





# NBS TECHNICAL NOTE 667

U.S. DEPARTMENT OF COMMERCE / National Bureau of Standards

## Upper-Bound Errors in Far-Field Antenna Parameters Determined From Planar Near-Field Measurements

**PART 1: Analysis** 

QC 100 . 45753 no. 667 pt. 1 1975

#### NATIONAL BUREAU OF STANDARDS

The National Bureau of Standards<sup>1</sup> was established by an act of Congress March 3, 1901. The Bureau's overall goal is to strengthen and advance the Nation's science and technology and facilitate their effective application for public benefit. To this end, the Bureau conducts research and provides: (1) a basis for the Nation's physical measurement system, (2) scientific and technological services for industry and government, (3) a technical basis for equity in trade, and (4) technical services to promote public safety. The Bureau consists of the Institute for Basic Standards, the Institute for Materials Research, the Institute for Applied Technology, the Institute for Computer Sciences and Technology, and the Office for Information Programs.

THE INSTITUTE FOR BASIC STANDARDS provides the central basis within the United States of a complete and consistent system of physical measurement; coordinates that system with measurement systems of other nations; and furnishes essential services leading to accurate and uniform physical measurements throughout the Nation's scientific community, industry, and commerce. The Institute consists of the Office of Measurement Services, the Office of Radiation Measurement and the following Center and divisions:

Applied Mathematics — Electricity — Mechanics — Heat — Optical Physics — Center for Radiation Research: Nuclear Sciences; Applied Radiation — Laboratory Astrophysics<sup>2</sup> — Cryogenics<sup>2</sup> — Electromagnetics<sup>2</sup> — Time and Frequency<sup>2</sup>.

THE INSTITUTE FOR MATERIALS RESEARCH conducts materials research leading to improved methods of measurement, standards, and data on the properties of well-characterized materials needed by industry, commerce, educational institutions, and Government; provides advisory and research services to other Government agencies; and develops, produces, and distributes standard reference materials. The Institute consists of the Office of Standard Reference Materials, the Office of Air and Water Measurement, and the following divisions:

Analytical Chemistry — Polymers — Metallurgy — Inorganic Materials — Reactor Radiation — Physical Chemistry.

THE INSTITUTE FOR APPLIED TECHNOLOGY provides technical services to promote the use of available technology and to facilitate technological innovation in industry and Government; cooperates with public and private organizations leading to the development of technological standards (including mandatory safety standards), codes and methods of test; and provides technical advice and services to Government agencies upon request. The Institute consists of the following divisions and Centers:

Standards Application and Analysis — Electronic Technology — Center for Consumer Product Technology: Product Systems Analysis; Product Engineering — Center for Building Technology: Structures, Materials, and Life Safety; Building Environment; Technical Evaluation and Application — Center for Fire Research: Fire Science; Fire Safety Engineering.

THE INSTITUTE FOR COMPUTER SCIENCES AND TECHNOLOGY conducts research and provides technical services designed to aid Government agencies in improving cost effectiveness in the conduct of their programs through the selection, acquisition, and effective utilization of automatic data processing equipment; and serves as the principal focus within the executive branch for the development of Federal standards for automatic data processing equipment, techniques, and computer languages. The Institute consists of the following divisions:

Computer Services — Systems and Software — Computer Systems Engineering — Information Technology.

THE OFFICE FOR INFORMATION PROGRAMS promotes optimum dissemination and accessibility of scientific information generated within NBS and other agencies of the Federal Government; promotes the development of the National Standard Reference Data System and a system of information analysis centers dealing with the broader aspects of the National Measurement System; provides appropriate services to ensure that the NBS staff has optimum accessibility to the scientific information of the world. The Office consists of the following organizational units:

Office of Standard Reference Data — Office of Information Activities — Office of Technical Publications — Library — Office of International Relations — Office of International Standards.

<sup>&</sup>lt;sup>1</sup> Headquarters and Laboratories at Gaithersburg, Maryland, unless otherwise noted; mailing address Washington, D.C. 20234.

<sup>&</sup>lt;sup>2</sup> Located at Boulder, Colorado 80302.

## Upper-Bound Errors in Far-Field Antenna Parameters Determined From Planar Near-Field Measurements

## OF STANDARDO LIBRARY DEC 3, 1 1975 20100 .015753 no.667 pt.1 1975 c.2

SATONAL BURMAN

## **PART 1: Analysis**

to Jecanica : 1 de, noi 661.

A.D. Yaghjian

Electromagnetics Division Institute for Basic Standards National Bureau of Standards Boulder, CO 80302

Sponsored by Air Force Avionics Laboratory Air Force Wright Aeronautical Laboratories Air Force Systems Command Wright-Patterson Air Force Base, Ohio 45433



U.S. DEPARTMENT OF COMMERCE, Rogers C. B. Morton, Secretary James A. Baker, III, Under Secretary Dr. Betsy Ancker-Johnson, Assistant Secretary for Science and Technology

US NATIONAL BUREAU OF STANDARDS, Ernest Ambler, Acting Director Issued October 1975

### NATIONAL BUREAU OF STANDARDS TECHNICAL NOTE 667 Nat. Bur. Stand. (U.S.), Tech Note 667, 120 pages (Oct. 1975)

CODEN: NBTNAE

For sale by the Superintendent of Documents, U.S. Government Printing Office, Washington, D.C. 20402 (Order by SD Catalog No. C13.46:667) \$1.85

### CONTENTS

Ι

		Page
	List of Figures and Tables	iv
I.	Introduction	1
τ <b>ι</b> .	Relationship of Errors in Gain Function, Sidelobe Level, Polarization Ratio, and Beamwidth to the Far-Field Error in Electric Field	4
II.	Error Analysis	8
	A. Finite Scan Errors	8
	1. Mathematical Formulation of the Problem	9
	2. The Fields of Electrically Large Aperture Antennas	13
	3. Evaluation of $\eta(\overline{r})$	18
	B. Position and Instrumentation Errors	30
	1. Position Errors	33
	2. Instrumentation Errors	48
	C. Multiple Reflections	58
τν.	Summary	69
	Appendix A Near-Fields of a Circular Antenna with Uniform Aperture Distribution	96
	Appendix B Position and Instrumentation Errors for the Null Depth of Difference Patterns	105
	References	111
	Acknowledgment	113

## LIST OF FIGURES AND TABLES

## Page

Figure	1.	Main beam of a hypothetical test antenna	82
Figure	2.	Schematic of scanning geometry	82
Figure	3.	Schematic of aperture antenna	83
Figure	4.	Definition of $a_m$ , $\theta_m$ , $D_m$	83
Figure	5.	Schematic of aperture and scan areas	84
Figure	6.	Circular reflector antenna	84
Figure	7a.	Near-field centerline data (constrained lens) (z = 25 cm)	85
Figure	7b.	Near-field centerline data (reflector antenna) (z = 43.18 cm)	85
Figure	8a.	Change in gain vs. decreasing scan length (constrained lens)	86
Figure	8b.	Change in gain vs. decreasing scan length (reflector antenna)	86
Figure	9a.	Constrained lens sum port near-field log ampli- tude, f = 9.2 GHz, z = 25.0 cm, no radome	87
Figure	9b.	Near-field phase, constrained lens sum port, f = 9.2 GHz, z = 25 cm	87
Figure	9c.	Constrained lens antenna and probe	87
Figure	9d.	Near-Field Centerline Data, z = 25 cm	88
Figure	10.	Position errors in on-axis gain	89
Figure	11.	Comparison with Rodrigue et al. for random phase errors	89
Figure	12.	Comparison with Newell for quadratic phase errors	90
Figure	13.	Amplitude errors in on-axis gain	90
Figure	14.	On-axis error in far-field from multiple reflections	91
Figure	15.	Far-field errors from multiple reflections $(a/\lambda = 12)$	91

## LIST OF FIGURES AND TABLES (continued)

Р	а	g	е
_	_	$\sim$	_

Figure Al.	Definition of $\overline{t}$ and $\alpha$	102
Figure A2.	Dotted line shows region in which eq. (A12a) holds	102
Figure A3.	Near-field amplitude of circular antenna	103
Figure A4.	Near-field phase of circular antenna $(a/\lambda = 12)$ -	104
Table l.	Finite Scan Errors from Centerline Data of a Typical X-Band Antenna	92
Table 2.	XY- and Z-Position Errors for a Typical X- and K-Band Antenna	93
Table 3.	Instrumentation Errors in Measuring Amplitude	94
Table 4.	Total Far-Field Errors for a Typical X- and K-Band Antenna	95

#### UPPER-BOUND ERRORS IN FAR-FIELD ANTENNA PARAMETERS DETERMINED FROM PLANAR NEAR-FIELD MEASUREMENTS

Part I: Analysis

A.D. Yaghjian

#### ABSTRACT

General expressions are derived for estimating the errors in the sum or difference far-field pattern of electrically large aperture antennas which are measured by the planar near-field scanning technique. Upper bounds are determined for the far-field errors produced by 1) the nonzero fields outside the finite scan area, 2) the inaccuracies in the positioning of the probe, 3) the distortion and nonlinearities of the instrumentation which measures the amplitude and phase of the probe output, and 4) the multiple reflections. Computational errors, uncertainties in the receiving characteristics of the probe, and errors involved with measuring the input power to the test antenna are briefly discussed.

Key words: Antennas; error analysis; far-field pattern; near-field measurements; planar scanning; planewave spectrum.

#### I. Introduction

The planar near-field scanning method has been used to measure with high accuracy the electromagnetic fields of microwave antennas. High accuracy is possible primarily because so few restrictive approximations are involved in the formulation and application of the near-field techniques. Moreover, the far-field errors associated with each approximation can be estimated because the approximations themselves can be expressed in convenient mathematical form. This report essentially derives and evaluates some of these mathematical expressions under the given laboratory conditions to determine quantitatively the accuracy with which the far-field of antennas can be measured by the planar near-field scanning method.

The error analysis was undertaken for two main reasons. One, it was desired to find general upper-bound expressions for the limits of accuracy in computing far-fields from planar near-field measurements without resorting to direct far-field comparisons. Ιt has long been the feeling of those involved with the near-field measurement techniques at the NBS that these techniques were often more accurate than measurements taken on conventional "far-field" ranges with a standard antenna. Thus comparisons with patterns measured on conventional far-field ranges would not give a reliable evaluation of the near-field techniques which do not have to cope with proximity corrections, ground reflections, or the calibration of standard far-field antennas. Two, the upper-bound expressions could be used to stipulate design criteria for the construction of new near-field scanning facilities. This meant that the upper-bounds for the accuracy in a given far-field parameter should be expressed in terms of measured near-field data and/or the computed far-field, the frequency and dimensions of the antenna-probe system, the variation in the positioning of the scanner, and the precision of the instrumentation which measures the probe output. The design engineer could then compute from the upper-bound expressions the near-field tolerances required to insure a given farfield accuracy for the range in size and frequency of the antennas he was considering.

There have been two major computer studies performed in the past to estimate the errors involved with planar near-field scanning measurements [11,16]. Rodrigue, Joy and Burns [16] have introduced position and instrumentation errors into a hypothetical near-field distribution in order to compute their effects on the far-field. Newell and Crawford [11,17] performed a similar analysis with measured near-field data which included an estimate of errors involved with truncating the scan plane. (Jensen [25] has also made a numerical investigation into the accuracy of near-field measurement techniques but for nonplanar scanning only.) A major drawback of the computer studies, as well as direct far-field comparisons, is that they apply to particular antennas and their results do not necessarily represent upper-bounds to errors which will hold for large general classes of antennas. It should be emphasized, however, that the computer studies are an extremely useful aid in giving direction to the general analysis and checking its results.

This report does not attempt to estimate the accuracy of the extrapolation technique for measuring the gain of antennas [22]. An error analysis involving the extrapolation technique has been performed recently by Kanda [23].

If we assume that the antennas under consideration are linear, of finite extent, and operating in a single mode at fixed frequency and amplitude, and that Maxwell's equations for free space describe the region in which the antenna is situated, the only approximations involved in formulating and applying the planar scanning method are:

- 1) The fields outside the finite scan area are zero.
- The scanner is aligned and positioned with infinite precision.
- 3) The instrumentation introduces no distortion and measures the amplitude and phase of the probe output with perfect accuracy.
- 4) Multiple reflections between the test antenna and "probe" antenna are zero.
- 5) Computation errors in "deconvoluting" the measured nearfield data to get the far-field are nil.

Errors caused by uncertainties in the receiving characteristics of the probe, and errors involved with measuring the input power to the test antenna are discussed in Section IV, which, incidently, contains a summary of the major results and conclusions of this report.

The far-field errors introduced by the computations (approximation 5) are so much smaller than the combined errors in the farfield caused by a finite scan area, positioning, instrumentation, and multiple reflections (approximations 1-4) that they are of little consequence. With the help of the sampling theorem, Fast Fourier Transform, and computers accurate to many places, the necessary deconvolution of the measured data can be performed with insignificant error.<sup>1</sup>

The amplitude of the near-field multiple reflections (approximation 4) can be estimated in practice by changing the distance between the probe and test antennas. Any periodic variations in the amplitude of the received signal repeating about every  $\lambda/2$  ( $\lambda$  = wavelength) would be caused primarily by the multiple reflections. In Section III.C the effects on the far-field of multiple reflections are discussed and estimated analytically. Although they cannot be eliminated completely, multiple reflections can be reduced by using efficient absorber material, by decreasing the size of the probe, or by increasing the distance between the probe and test antenna. Also, it is likely that the effect of multiple reflections on the far-field can be reduced by averaging the far-field patterns obtained by scanning on a number of near-field planes which are separated by a small fraction of a wavelength.

Far-field errors caused by the errors in the scanner positioning and instrumentation (approximations 2 and 3) are determined from a common set of equations. These equations are derived and evaluated in Section III.B for both systematic and random near-field

<sup>&</sup>lt;sup>1</sup>Without the advantage of the FFT, typically the computer would add 20,000 terms to calculate the variable which yields the far-field. Even if we make the absurd hypothesis that every round-off error adds in the same direction, a computer of 10-place accuracy adding 20,000 numbers would retain more than 5-place accuracy (.001%) for the sum. Of course, in practice the FFT algorithm vastly reduces the number of necessary computations.

There is also the approximation associated with applying the sampling theorem, which assumes that the output of the probe is the Fourier transform of a band-limited function. For a separation distance between test antenna and probe of more than a few wavelengths, this can be shown to be an extremely good approximation which introduces negligible errors into the far-field.

errors. "Position errors" may be reduced by scanning along both vertical and horizontal lines and appropriately averaging the two sets of measurements. "Instrumentation errors" can be reduced if the distortion and nonlinearities of the receivers can be determined and included as part of the computer program that deconvolutes the near-field data.

The first portion of the error analysis (Section III.A) is devoted to determining the maximum far-field errors introduced by neglecting the fields outside the scan area. As part of the analysis, asymptotic expressions are derived for the near-field in front of large aperture radiators.

All errors are assumed small enough so that the individual contribution to the far-field error from each source of near-field error can be estimated independently and then combined to give the total far-field error. We shall find that all the individual errors in the far-field combine linearly except for the on-axis sum pattern, position and instrumentation phase errors which combine quadratically (see footnote 12).

## II. <u>Relationship of Errors in Gain Function, Sidelobe Level,</u> <u>Polarization Ratio, and Beamwidth to the Far-Field Error in</u> <u>Electric Field</u>

Let  $\overline{E}(\overline{r})$  denote the electric field (to within the limits of error) of an antenna radiating into free-space and  $\pm \Delta \overline{E}(\overline{r})$  the limits of error involved with the measurement of  $\overline{E}(\overline{r})$  (e<sup>-iwt</sup> time dependence has been suppressed). The magnitude of the fractional error  $\eta(\overline{r})$  in the electric field amplitude can be defined for small errors as,

$$\eta(\overline{r}) = \left| \frac{|\overline{E} \pm \Delta \overline{E}| - |\overline{E}|}{|\overline{E}|} \right| \leq \frac{|\Delta \overline{E}(\overline{r})|}{|\overline{E}(\overline{r})|}.$$
(1)

(Henceforth, the < sign will be omitted when eq. (1) or similar expressions are used.) The Hermitian amplitude  $|\overline{E}| \equiv \sqrt{\overline{E} \cdot \overline{E}} *$  (the asterisk \* denotes the complex conjugate) is related to the power S radiated per unit area in the far-field or any other locally

plane-wave field in free-space by  $S = \sqrt{\varepsilon_0/\mu_0} |\overline{E}|^2$ . From the values of  $\eta(\overline{r})$  as r approaches infinity and the approximate amplitude of the far-field  $|\overline{E}(\overline{r})|_{r \to \infty}$ , all other errors in far-field quantities can be found. Four such quantities of interest are the gain function, the sidelobe level, the polarization ratio, and the half-power beamwidth. Of course, these four are not always the only far-field quantities of interest, but they will be used as typical examples to demonstrate how the error in any far-field quantity can be related easily to  $\eta(\overline{r})$  and  $|\overline{E}(\overline{r})|_{r \to \infty}$ . (In eqs. (2)-(5) below, where the error in these four quantities is derived, the subscript "r $\rightarrow\infty$ " is understood, but not shown explicitly.)

The error  $\eta_{G}$  in the gain function  $G(\overline{r})$ , which is proportional to the square of the far-field amplitude, may be written immediately as (for small  $|\Delta \overline{E}|/|\overline{E}|$ , so that  $|\Delta \overline{E}|^2$  terms can be neglected)

$$n_{G} = \left\{ \frac{|\overline{E} \pm \Delta \overline{E}|^{2} - |\overline{E}|^{2}}{|\overline{E}|^{2}} \right\} G = \pm 2 \frac{|\Delta \overline{E}|}{|\overline{E}|} G \qquad (2a)$$
$$= \pm 2\eta(\overline{r})G(\overline{r}),$$

or in decibels

$$\eta_{G}^{dB} \equiv 10 \log\left(\frac{|\overline{E} \pm \Delta \overline{E}|^{2}}{|\overline{E}|^{2}}\right) = 20 \log(1\pm\eta(\overline{r})).$$
(2b)

For small errors,  $\eta << 1$ , and

$$n_{G}^{dB} = \pm 8.7 n(\overline{r}).$$
 (2c)

The sidelobe level, when meaningful, is usually stated in decibels and is defined as the ratio of the maximum far-field intensity of the largest sidelobe to the maximum far-field intensity of the main beam [1]. The error  $\eta_c$  in sidelobe level SL is

$$n_{s} = \frac{|\overline{E}_{side} \pm \Delta \overline{E}_{side}|^{2}}{|\overline{E}_{max} \pm \Delta \overline{E}_{max}|^{2}} - \frac{|\overline{E}_{side}|^{2}}{|\overline{E}_{max}|^{2}}.$$

For SL =  $|\overline{E}_{side}|^2 / |\overline{E}_{max}|^2$ , and small  $\eta(\overline{r})$ ,

$$n_{s} = \pm 2 [\eta(\overline{r}_{s}) + \eta(\overline{r}_{o})] SL, \qquad (3a)$$

with  $\eta(\overline{r}_{s})$  and  $\eta(\overline{r}_{o})$  denoting the values of  $\eta$  at the sidelobe maximum and main beam maximum respectively. In most cases  $\eta(\overline{r}_{s})$  will be much larger than  $\eta(\overline{r}_{o})$  so that  $\eta_{s} = \pm 2\eta(\overline{r}_{s})$ SL. (3b)

In decibels

$$\eta_{s}^{dB} = 20 \left[ \log \frac{\left| \overline{E}_{side} \pm \Delta \overline{E}_{side} \right|}{\left| \overline{E}_{max} \pm \Delta \overline{E}_{max} \right|} - \log \frac{\left| \overline{E}_{side} \right|}{\left| \overline{E}_{max} \right|} \right],$$

or for small n, and  $\eta(\overline{r}_{s}) >> \eta(\overline{r}_{o})$ ,

$$\frac{\eta_{s}^{dB} = \pm 8.7 \eta(\overline{r}_{s}),}{(3c)}$$

i.e., as we might expect, simply the error in the gain of the sidelobe itself.

The polarization ratio (Pol) of the electric field is defined as the ratio of the minor to major axis of its polarization ellipse [1]. For a given amplitude of error field  $|\Delta \overline{E}|$  the maximum error in the polarization ratio at a point in the far-field occurs when the field  $\Delta \overline{E}$  has the same polarization ratio as  $\overline{E}$  but with major and minor axes interchanged and the direction of rotation of the electric-field vector reversed.\* (Also the electric field vectors of  $\Delta \overline{E}$  and  $\overline{E}$  must be colinear along the major-minor axes.)

Under these conditions, the maximum error ( $\Delta Pol$ ) in polarization ratio is realized and can be expressed for small errors in the form  $\Delta Pol = \pm [1 + (Pol)^2] \eta(\overline{r}).$ (4a) The upper-bound error in polarization is never greater than 2 $\eta$  (circularly polarized) and for antennas with small cross polarization the upper-bound error is approximately  $\eta$ .

It is an interesting result that if the maximum error in polarization ratio were realized, the rotational shift in the polarization ellipse caused by the error field would be a minimum, i.e., zero. Fortunately, as part of the derivation of eq. (4a) the maximum possible rotational shift  $\psi_{max}$  in the polarization ellipse for a given  $|\Delta \overline{E}|$  can also be determined. Specifically,

$$\psi_{\text{max}} = \pm \eta \left( \frac{1 + (\text{Pol})^2}{1 - (\text{Pol})^2} \right) \text{ radians.}$$
(4b)

For a far-field of approximately circular polarization (Pol  $\approx$  1) the shift in polarization ellipse introduced by the error field may \*This result, the proof of which is straightforward but rather lengthy, was obtained by Flemming Jensen and brought to my attention by Flemming Larsen both of the Technical University of Denmark, Lyngby, Denmark. become large -- as one might expect. Finally, it is mentioned that footnote 11 should be consulted when applying eqs. (4) to instrumentation amplitude errors.

The half-power beamwidth is defined for a plane containing the line along the maximum intensity of the beam. It is simply "the angle between the two directions in which the radiation intensity is one half the maximum value of the beam" [1]. If we know  $\overline{E}(\overline{r})$  and  $\Delta \overline{E}(\overline{r})$  in the far-field we can determine the maximum errors in measuring the beamwidth. In figure 1,  $|\overline{E}|^2$  and  $|\overline{E} \pm \Delta \overline{E}|^2 = |\overline{E}|^2 \pm 2|\overline{E}||\Delta \overline{E}|$  (neglecting  $|\Delta \overline{E}|^2$  terms, as usual) are plotted for the main beam of an arbitrary test antenna. The beamwidth is  $\theta_1 + \theta_2$ . From figure 1, we see that the error in  $\theta_1$  is

$$\Delta \theta_{1} = \pm \frac{2 |\Delta \overline{E}(\theta_{1})| |\overline{E}(\theta_{1})|}{\tan \alpha} = \frac{\pm |\Delta \overline{E}(\theta_{1})| |\overline{E}(\theta_{1})|}{|\overline{E}(\theta_{1})|} = \frac{\pm \eta(\theta_{1}) |\overline{E}(\theta_{1})|}{\frac{d|\overline{E}(\theta_{1})|}{d\theta}} radians.**$$

A corresponding expression holds for the error in  $\Delta \theta_2$ . The total fractional error  $\eta_R$  in beamwidth may be written

$$\eta_{\rm B} = \pm \frac{\Delta \theta_1 + \Delta \theta_2}{\theta_1 + \theta_2}, \qquad (5a)$$

or, for symmetrical beams ( $\theta = \theta_1 = \theta_2$ ), simply

$$\eta_{\rm B} = \frac{\pm \Delta \theta}{\theta} = \frac{\pm \eta(\theta) |\overline{\rm E}(\theta)|}{\theta \frac{d|\overline{\rm E}(\theta)|}{d\theta}} .$$
(5b)

For large circular or square apertures of uniform amplitude and phase distribution,  $|\overline{E}(\theta)| / \left| \theta \frac{d |\overline{E}(\theta)|}{d\theta} \right|$  can be shown to approximately equal 1, and  $\eta_B$  becomes simply,

$$\frac{\eta_{\rm B} = \pm \eta(\theta)}{(2) - (5)}$$
(5c)

As expected, eqs. (2)-(5) verify that a knowledge of |E(r)|and  $\eta(\overline{r})$  as  $r \neq \infty$  (as mentioned above, the " $r \neq \infty$ " is suppressed in eqs. (2)-(5)) is all that is required to determine the errors in the gain function, sidelobe level, polarization ratio, and beamwidth. If desired, errors in other far-field parameters can equally well be expressed in terms of  $|\overline{E}(\overline{r})|$  and  $\eta(\overline{r})$ . The far-field  $|\overline{E}|_{r \neq \infty}$  may be computed from the measured near-field data or estimated analytically. Thus, the problem of finding the far-field errors reduces to the problem of evaluating  $\eta(\overline{r})$  of eq. (1) in the far-field. \*\*Here we are neglecting the error caused by the change in the maximum value of the beam. If this error is significant compared to  $\Delta \overline{E}(\theta_1)$  it

should be added to it.

#### III. Error Analysis

#### A. Finite Scan Errors

The purpose of the present section is to estimate the maximum errors in the far-field introduced by scanning in the near-field over a plane of finite area. "Finite" is the key word. In principle, the planar scan method requires that the output of the probe be recorded over an infinite plane in front of the test antenna. In practice, of course, only a finite area of the plane is scanned and the fields outside that finite area are set equal to zero. The scan area is usually, but not necessarily, rectangular with the boundaries commonly chosen where the output of the probe antenna is down 30 or 40 dB or more from its maximum. For many microwave antennas such a scan area turns out to be about two or three times the aperture area of the antenna. The present analysis will be restricted to electrically large (average width/wavelength > 10 will do) aperture-type antennas, usually but not necessarily operating at microwave frequencies. The phase will be assumed fairly uniform across the aperture with the amplitude of the field either uniform or reaching a maximum near the center of the aperture and convexly tapered toward the edge to reduce the sidelobe radiation [2].<sup>2</sup> Near-field, centerline, amplitude and phase data for the sum pattern of a typical antenna measured at NBS can be seen in figure 9d. Reflectors, large horns, and broadside arrays are probably the most common examples of the test antennas under consideration. The results of this finite scan part of the error analysis apply to antennas with their boresight direction steered at an arbitrary angle with respect to the scan plane.

<sup>&</sup>lt;sup>2</sup>Initially we are assuming the antenna is operating in a sum mode or pattern. For finite scan errors it will be shown that difference patterns need not be considered separately since they are formed by the superposition of two sum patterns with wavefronts slightly skewed to create a "null" in the boresight direction. For position and instrumentation errors, however, Section III.B along with Appendix B shows that sum and difference patterns must be considered separately, at least when determining far-field errors near the boresight direction.

The approach which is used to estimate the finite scan errors involves finding an upper-bound to the appropriate integral of the fields outside the finite scan area. Physical optics and the geometrical theory of diffraction are used to show that the fields outside the scan area are determined chiefly by edge diffracted fields of the antenna. For each antenna these edge diffracted fields are different. However, they all can be expressed in a general form (eq. (19)) which allows upper-bound expressions (eqs. (32) and (36)) to be found by evaluating the integral outside the scan area in terms of the probe output on the edge of the scan area. Outside the "solid angle" formed by the edge of the aperture and edge of the scan area, the evaluation of the integral can be done by the method as stationary phase to show that in this region the far-fields computed from the near-field data cannot be relied upon with any confidence. Well within the solid angle the integral evaluation can be performed through integration by parts to yield an upper-bound expression for finite scan errors from both centerline data scans (eq. (32)) and full scans (eq. (36) or (32)).

#### 1. Mathematical Formulation of the Problem

Suppose we want to determine the radiation pattern of a given antenna of aperture area A bounded by the curve C, as in figure 2. The task is accomplished experimentally by recording the output of an arbitrary but known probe antenna (for two orientations, in general) as the probe scans in front of the radiating test antenna on a plane of area A' bounded by C'. The z-axis will always be chosen perpendicular to the scan plane with origin 0 in the antenna aperture. The scan plane, however, may not always be chosen parallel to the aperture plane. For beams steered off-axis, larger scan areas may be required if the scan plane does not lie perpendicular (approximately)to the boresight direction.

After taking a double Fourier transform of the probe output in each orientation, the radiating characteristics  $(\overline{S}_{10}(\overline{K}))$  of the test antenna are found simply by solving simultaneously the two resulting linear equations. In particular, if the probe were a perfect dipole,

the output of the probe would be proportional to the electric field at the dipole in the direction of the dipole moment. The expression for  $\overline{S}_{10}(\overline{K})$  (defined with respect to the reference plane z=0, and the transverse part of the propagation vector denoted by  $\overline{K}$ ) then becomes [3]

$$\overline{S}_{10}(\overline{K}) = \frac{1}{4\pi^2 a_0} e^{i\gamma d} \int_{A'} \overline{E}_t(\overline{P}, d) e^{-i\overline{K} \cdot \overline{P}} d\overline{P}, \qquad (6)$$

$$(e^{-i\omega t} \text{ time dependence})$$

where  $\overline{E}_{t}(\overline{P},d)$  is the electric field, i.e., the output of the dipole probe in two mutually perpendicular orientations, transverse to the z-axis at the point ( $\overline{P}$ ,d) in the scan plane A'. (The equation of the A' plane is z = d.) The amplitude of the input mode to the test antenna is designated by  $a_{0}$ , and the variable  $\gamma$  is defined by  $\gamma = (k^{2}-K^{2})^{\frac{1}{2}}(k = \omega/c = \frac{2\pi}{\lambda})$ , where the radical is chosen to keep  $\gamma$ positive real or imaginary.<sup>3a</sup>,b

For the sake of simplifying the theory we will assume a perfect electric dipole as the probe. The dipole gives information about the electric field only at a point. All physically realizable probes respond to a weighted average of the field near the probe. Thus it is expected that the errors in the computed far-field introduced by omitting a part of the infinite scan plane are as great or greater for a perfect dipole than for any other probe antenna, and that the following conclusions and resulting upper bound expressions (32) and (36) hold for arbitrary probes. Also, at this point in the error

<sup>3</sup>a The sampling theorem shows that to obtain the far-field pattern the double integral in eq. (6) can essentially be replaced by a double summation over points in A' separated by about  $\lambda/2$  or less. Thus, in practice, data need be taken only at a finite number of discrete points for eq. (6) to be evaluated. However, for most of the error analysis we prefer (somewhat arbitrarily) the integral representation of  $\overline{S}_{10}$  to the summation.

<sup>&</sup>lt;sup>3b</sup>Strictly speaking, the Fourier transform in eq. (6) and eqs. (7), (10), and (11) below may not converge to a unique value as the scan area approaches infinity because  $\overline{E}_{t}(\overline{P},d)$  has a 1/P dependence in a lossless medium as  $P \rightarrow \infty$ , and thus gives rise to a rapidly oscillating part in the transform as  $P \rightarrow \infty$ . Usually this oscillatory term can be ignored with impunity because it vanishes upon integration when taking the inverse transform. However, it does determine the limiting value of the finite scan errors (see footnote 9).

analysis any uncertainty in the receiving characteristics (S'ol) of the measuring probe are ignored.

For eq. (6) to represent  $\overline{S}_{10}(\overline{K})$  exactly, the probe scan and subsequent integration would have to be performed over the infinite plane. Thus the error  $(\Delta \overline{S}_{10})$  produced in  $\overline{S}_{10}$  by a scan of finite area may be written formally as

$$\Delta \overline{S}_{10} = \frac{1}{4\pi^2 a_0} e^{-i\gamma d} \int_{A'_c} \overline{E}_t(\overline{P}, d) e^{-i\overline{K} \cdot \overline{P}} d\overline{P}, \qquad (7)$$

where  $A_c^{\prime}$  is the infinite area outside or complementary to A'. The far-fields can be found from  $\overline{S}_{10}(\overline{K})$  by taking the inverse double Fourier transform of eq. (6) and evaluating the resulting expression by the method of stationary phase for double integrals. So doing yields [3]

$$\overline{E}_{t}(\overline{r}) = -2\pi a_{0} ik \cos\theta \overline{S}_{10}(k\overline{R}/r) \frac{e^{ikr}}{r}$$

$$r \to \infty$$
(8)

and from eq. (8)

$$\Delta \overline{E}_{t}(\overline{r}) = -2\pi a_{0} i k \cos \theta \Delta \overline{S}_{10}(k\overline{R}/r) \frac{e^{ikr}}{r}.$$
(9)  

$$r \rightarrow \infty \qquad (\cos \theta = z/r, z > 0)$$

Substitution of  $\overline{S}_{10}$  and  $\Delta \overline{S}_{10}$  from eqs. (6) and (7) into eqs. (8) and (9), respectively, produces expressions for the far-electric-field and its error in terms of the near-field data:

$$\overline{E}_{t}(\overline{r}) = -\frac{ik \cos\theta}{2\pi r} e^{ik(r-d \cos\theta)} \bigwedge_{A'} \overline{E}_{t}(\overline{P},d) e^{-i\frac{K}{r}\overline{R}\cdot\overline{P}} d\overline{P}$$
(10)  

$$r \neq \infty$$

$$\Delta \overline{E}_{t}(\overline{r}) = -\frac{ik \cos\theta}{2\pi r} e^{ik(r-d \cos\theta)} \bigwedge_{A'_{c}} \overline{E}_{t}(\overline{P},d) e^{-i\frac{K}{r}\overline{R}\cdot\overline{P}} d\overline{P}.$$
(11)  

$$r \neq \infty$$

(For a dipole probe,  $\overline{E}_{t}(\overline{P},d)$  and the output of the probe are identical.) Equations (10) and (11) express mathematically the well-known

"Fourier optics" result that the far-field amplitude is proportional to the spatial Fourier transform of the near-field times  $\cos\theta$ . Division of eq. (10) by eq. (11) results in the fractional error  $\eta_t$ in the transverse part of the far-electric-field

$$n_{t}(\overline{r}) = \frac{|\Delta \overline{E}_{t}(\overline{r})|}{|\overline{E}_{t}(\overline{r})|} = \frac{\left| \int_{A_{c}} \overline{E}_{t}(\overline{P}, d) e^{-i\frac{k}{r}\overline{R}\cdot\overline{P}} d\overline{P} \right|}{\left| \int_{A_{c}} \overline{E}_{t}(\overline{P}, d) e^{-i\frac{k}{r}\overline{R}\cdot\overline{P}} d\overline{P} \right|}, \quad (12a)$$

or simply

$$\eta_{t}(\overline{r}) = \frac{\cos\theta \left| \int_{A'_{c}} \overline{E}_{t}(\overline{P}, d) e^{-i\frac{k}{r}} \overline{R} \cdot \overline{P} \right|}{\lambda r \left| \overline{E}_{t}(\overline{r}) \right|_{r \to \infty}}.$$
(12b)

Of course, the fractional error  $\eta$  in the total far-electricfield is not necessarily  $\eta_t$  except on the z-axis. However we can find  $\eta$  in terms of  $\eta_t$  by a simple argument. In the far-field  $|\overline{E}_t(\overline{r})|$ differs from  $|\overline{E}(\overline{r})|$  at most by a factor  $\cos\theta$ , i.e.

$$\left|\overline{E}(\overline{r})\right|\cos\theta \leq \left|\overline{E}_{t}(\overline{r})\right| \leq \left|\overline{E}(\overline{r})\right|.$$
(12c)

Similarly,

$$|\Delta \overline{E}| \cos \theta \leq |\Delta \overline{E}_{t}| \leq |\Delta \overline{E}|.$$
 (12d)

Consequently  $\eta$  is greater than  $\eta_t$  by at most a factor  $\frac{1}{\cos\theta}$ , and from eqs. (12) we can express the maximum possible  $\eta$  in the far-field as

$$\eta(\overline{r}) = \frac{|\Delta\overline{E}|}{|\overline{E}|} = \frac{\begin{vmatrix} \int_{A_{c}} \overline{E}_{t}(\overline{P}, d) e^{-i\frac{k}{r}} & \overline{R} \cdot \overline{P} \\ A_{c}' & d\overline{P} \end{vmatrix}}{\lambda r |\overline{E}(\overline{r})|_{r \to \infty}}.$$
(13)

For the denominator of eq. (13) we can use the far-field estimated analytically or computed from the measured near-field data. Thus, the problem of finding  $\eta$  reduces to that of estimating  $\overline{E}_t(\overline{P},d)$  on  $A'_c$ , i.e., on the area outside the finite scan plane.

#### 2. The Fields of Electrically Large Aperture Antennas

If the behavior of the electric field  $\overline{E}_t(\overline{P},d)$  were known in the area A', the integral of eq. (13),

$$\overline{I} = \int_{A_{C}^{\prime}} \overline{E}_{t}(\overline{P}, \overline{d}) e^{-\frac{ik}{r}} \overline{R} \cdot \overline{P} d\overline{P}, \qquad (14)$$

could be evaluated and the far-field errors could be found immediately from eqs. (1)-(5). Even asymptotic methods cannot be applied to eq. (14) until the behavior of  $\overline{E}_t(\overline{P},d)$  is determined. Fortunately, the electric field outside the aperture of electrically large aperture antennas can be determined analytically from the electric field distribution across the aperture. In fact, it will be shown shortly that just the electric field at the edge of the aperture distribution is required.

As a first step in finding the electric field  $\overline{E}_t(\overline{P},d)$  to use in eq. (14), consider the aperture antenna drawn schematically in figure 3. (The boundary or rim of the antenna is assumed to lie in a plane with  $\hat{e}_z$  here chosen perpendicular to the plane. These restrictions are relaxed later.) It is well-known [4] that the electric field everywhere to the right of the infinite plane  $A_{\infty}$  can be expressed in terms of an integral of the electric field over  $A_{\infty}$ ,

$$\overline{E}(\overline{r}) = -\frac{1}{2\pi} \int_{A_{\infty}} \left[ \hat{e}_{z} \times \overline{E}_{t}(\overline{R}') \right] \times \nabla G(\overline{r}, \overline{R}') d\overline{R}', \qquad (15)$$

where

$$G = \frac{e^{1k|\overline{r} - \overline{R}'|}}{|\overline{r} - \overline{R}'|},$$

and  $\overline{E}_{t}(\overline{R}')$  is the transverse electric field on the plane  $A_{\infty}$  emanating from sources to the left of  $A_{\infty}$  (e.g., electric fields from a feed located to the right of  $A_{\infty}$  would not be included in  $\overline{E}_{t}(\overline{R}')$ , except, of course, indirectly as reflected fields from the antenna).

For an aperture antenna, whether it be a reflector, large horn, or broadside array, the components of the electric field  $\overline{E}_{t}(\overline{R}')$  are

slowly varying in phase<sup>4</sup> and amplitude across the aperture, except possibly right near the edge. The amplitude often tapers toward the edge of the aperture and drops abruptly (in a distance less than a wavelength) to zero or near zero beyond the edge. Thus the limits of integration in eq. (15) reduces to the aperture area A or at most a couple of wavelengths beyond A. Also, since eq. (14) requires only the transverse component of  $\overline{E}_t(\overline{r})$ , we can ignore the zcomponents of eq. (15) and write

$$\overline{E}_{t}(\overline{r}) = -\frac{1}{2\pi} \frac{\partial}{\partial z} \int_{A} \overline{E}_{t}(\overline{R}') G(\overline{r}, \overline{R}') d\overline{R}'.$$
(16)

For electrically large apertures, eq. (16) can be evaluated asymptotically. Before doing this a couple of remarks are in order.

The first has to do with neglecting the fields outside the aperture area A when in reality there may be scattering from the edge of the antenna aperture. In those cases it may seem unreasonable to neglect, initially, the fields beyond the aperture area A as part of the procedure to calculate the fields beyond the scan area A'. The "canonical" problems that can be solved exactly, such as scattering by an infinite wedge or elliptical disk, indicate, however, that at short wavelengths the scattered fields are caused predominantly by high intensity fields within a wavelength or so of the edge, and indeed the fields more than this distance beyond the edge may be neglected [5]. Of course, this assumption has been confirmed by experiment and constitutes the basic postulate of the geometrical theory of diffraction [6]. In terms of the radiation from large aperture antennas, it means simply that the fields everywhere to the right of the aperture plane depend solely upon the fields within and near the edge of the aperture, even when appreciable scattering from the edges is present.

The second remark concerns antennas that have part of their feeding mechanism mounted to the right of the aperture plane--as in the case of reflector antennas. As mentioned above, the direct radiation from the feed must not be included as part of  $\overline{E}_t(\overline{R}')$  for eq. (16) to be correct. However, scattering from feed mounts

<sup>&</sup>lt;sup>4</sup>For electrically steered arrays the planes of "uniform" phase may be skewed with respect to the aperture plane. This situation is considered at the end of the section.

(including the feed itself) of the fields reflected by the antenna are not taken into account by eq. (16). Although the mount scattered fields can be ignored if they are small compared to the fields scattered from the aperture edge, there is no reason to believe this will always be the case even in the region  $A_c^{\prime}$ . Fortunately, the results of the geometrical theory of diffraction (GTD) can also be used to determine the behavior of the fields diffracted from the mounting in front of the aperture as well as from any sharp edges at the boundary of the aperture [6]. Moreover, we shall find that the final expression (eqs. (32) and (36)) for the far-field error does not require an explicit estimation of either the mount or edge diffracted fields. Of course, for many antennas such as horns and arrays there are no obstructions in front of the aperture.

For the moment we shall ignore the problems of the exact nature of the edge diffraction and diffraction from feed mounts and return to evaluate eq. (16) for a smoothly tapered amplitude within A and zero outside A. For apertures which are many wavelengths across, the double integral (16) can be expanded in an asymptotic series. The first three terms in the series for integrals like eq. (16) have been derived by Van Kampen [7]. Keller, Lewis and Seckler [8] apply Van Kampen's results to eq. (16) specifically. The final expression has been confirmed by the present author using an approach different from Van Kampen's. In the shadow region, i.e., the entire half space z > 0 excluding the cylindrical volume formed by the projection of the aperture area A along the z-axis, the electric field in eq. (16) is approximated by

$$\overline{E}_{t}(\overline{r}) = \sum_{m} \frac{1}{2\pi} \sqrt{\frac{\lambda}{Dm}} \left( \frac{a_{m}}{a_{m}^{+}D_{m} \sin \theta_{m}} \right)^{\frac{1}{2}} \frac{\cos \theta_{m} \overline{E}_{tm}}{\sin \theta_{m}} e^{i \left( kD_{m}^{+} \frac{\pi}{4} \right)}.$$
 (17)

The variables in eq. (17) are defined with the help of figure 4. The distance from the point  $\overline{r}$  to the edge of an aperture with a smooth boundary has at least one relative maximum and one relative minimum. The subscript m simply refers to the mth relative extremum point on the edge of the aperture.  $D_m$  is the distance from  $\overline{r}$  to the mth relative extremum,  $a_m$  is the radius of curvature of the edge (in

the plane of the aperture) at the mth relative extremum,  $\theta_m$  is the angle between  $D_m$  and the z-direction, and  $\overline{E}_{tm}$  is the value of the transverse electric field at the edge of the aperture excluding the fields diffracted from the edge. The radius of curvature  $a_m$  is taken positive if the distance  $D_m$  is a relative minimum and negative if a relative maximum. The radical  $\begin{bmatrix} a_m \\ a_m + D_m \sin \theta_m \end{bmatrix}^{1/2}$  is taken positive if real and negative if imaginary. Of course, all subscripted quantities are, in general, functions of position  $\overline{r}$ .

Actually, in order for expression (17) to remain valid,  $\theta_m$  must be greater than a few  $\lambda/\ell^{ave}$  ( $\ell^{ave} \equiv \sqrt{A}$ ), and  $D_m$  no closer than a couple of wavelengths  $\lambda$  from the edge. This latter restriction says simply that eq. (17) does not describe the reactive fields. The former restriction can be understood physically by dividing the aperture into Fresnel zones for the direction  $\theta_m$ . For  $\theta_m$  greater than a few  $\lambda/\ell^{ave}$  there are enough Fresnel zones (even for the farfield) to assure that the main contribution to the fields in the shadow region are from the fields near the edge of the aperture rather than from the fields well within the aperture.<sup>5</sup>

The expression (17) does not necessarily account correctly for scattering from edges that may be present on the boundary or rim of the antenna. The necessary modification of eq. (17), for example, when scattering from sharp conducting edges occurs can be extracted from Kellers GTD [6]. Kouyoumjian [9a] has written Keller's results in a form similar to eq. (17). The GTD expression differs from eq. (17) only in that the factor  $\cos\theta_{\rm m}\overline{E}_{\rm tm}$  is replaced by

$$\overline{E}_{tm}^{||} g_{||} (\theta_{m}) + \overline{E}_{tm}^{\perp} g_{\perp}(\theta_{m}), \qquad (18)$$

where  $\overline{E}_{tm}^{\parallel}$  and  $\overline{E}_{tm}^{\perp}$  are the transverse components of the incident electric field parallel and perpendicular to the edge of the aperture. The factors  $g_{\parallel}$  and  $g_{\perp}$  can be found from either reference [6a] or [9a], but it is not necessary to know them explicitly for our purposes. Moreover, scattering from other than sharp conducting edges can also be handled by changing appropriately the factors  $g_{\parallel}$  and  $g_{\perp}$  in eq. (18).

<sup>5</sup>Note that in a similar manner it can be argued that the far-fields for  $\theta$  less than a couple  $\lambda/\ell^{\max}$  ( $\ell^{\max}$  = maximum width of aperture) are determined mainly by the near-fields well within the boundary of the aperture. Thus it is seen from eqs. (17) and (18) that regardless of the nature of the scattering from the edges, the fields in the shadow zone appear to emanate from points along the edge of the aperture. For our purposes it proves convenient to write simply the one equation valid for the scattered field in the shadow zone

$$\overline{E}_{t}(\overline{r}) = \sum_{m} \overline{F}_{tm}(\overline{r}) e^{ikD_{m}}.$$
(19)

 $\overline{F}_{tm}$  is defined by comparing eq. (19) with eqs. (17) and (18). The essential property of  $\overline{F}_{tm}(\overline{r})$ , which allows the asymptotic evaluation of eq. (14), is that unlike  $e^{ikD}m$  it varies slowly with  $\overline{r}$ . In fact, for the error analysis it turns out that this is the only property of  $\overline{F}_{tm}(\overline{r})$  that is required. Never is it necessary to evaluate  $\overline{F}_{tm}(\overline{r})$ explicitly, although for reasons of general interest it has been evaluated in Appendix A for the circular aperture of uniform distribution. Results from Appendix A are also used in Section III.B.1.

Also if the edge of the aperture has points where the radius of curvature is much smaller than a wavelength (e.g., the corners of a rectangular aperture), these corners and tips contribute to the field. For large apertures at least it can be shown [5-9] that their contribution is usually much smaller (higher order in  $\lambda/l^{ave}$ ) than the edge fields of eq. (19), and thus can usually be neglected for the purpose of evaluating eq. (14). However, even if they cannot be neglected, the fields from corners and tips can be expressed in the same form as eq. (19).

Electronically steered aperture antennas (broadside phased arrays) are also covered by eq. (19) with the appropriate modifications of  $\overline{F}_{tm}$  (see, for example, reference [8] which deals with an arbitrary phase of the field across the aperture). When the axis of the main beam is steered away from the perpendicular to the aper-

ture, the region of validity of eq. (19) changes to the entire half space in the direction of the new axis, excluding the projection of the aperture along that axis, i.e., eq. (19) is still valid in the shadow zone regardless of what direction the beam is steered.

Eq. (19) also applies to antennas operating in a difference pattern where the on-axis field drops to a sharp minimum. As in the case of the sum pattern, the fields in the shadow zone are determined by whatever value of electric field impinges upon the edge of the aperture. And again the variation in electric field separates into a rapidly oscillating part e and a slowly varying part  $\overline{F}_{tm}$ .

Eq. (17) (or (17) modified by (18)) represents the first term in an asymptotic expansion of the electric field. The higher order terms are assumed so much smaller than the first that they are neglected. However, if the electric field at the edge of the aperture becomes too small, the second term in the asymptotic expansion must be included.<sup>6</sup> Even then, for reasonably smooth aperture distributions, this second term also has the form of eq. (19) but with  $\overline{F}_{tm}$ depending on the derivative of the electric field at the edge rather than the field itself. This "slope diffraction coefficient" has been derived for the GTD by Hwang and Kouyoumjian [9b].

In brief, eq. (19) describes the electric field in the shadow zone of nearly all large aperture antennas including electronically steered arrays, antennas excited in a difference pattern, and antennas with aperture distributions that taper to zero at the edge.

#### 3. Evaluation of $\eta(\overline{r})$

The evaluation of the integral in eq. (14) and subsequently  $\eta(\overline{r})$  in eq. (13) is accomplished by first substituting the electric field from eq. (19) into eq. (14),

$$\overline{I} = \sum_{m \text{ o}} \int_{D'_{m}}^{2\pi \infty} \overline{F}_{tm}(\overline{P}, d) e^{ik[D_{m}-p \sin\theta\cos(\phi - \phi_{p})]} p dp d\phi_{p}.$$
(20)

The vectors  $\overline{P}$  and  $\overline{r}$  have been written in cylindrical  $(p, \phi_p)$  and spherical coordinates  $(r, \theta, \phi)$ , respectively, defined explicitly in

<sup>&</sup>lt;sup>6</sup>The fields at the edge of the aperture would have to be quite small for the second term to be significant. For example, an expansion of eq. (16) for a cosine distribution on a circular aperture of radius "a" shows that the second term would be required only after the edge taper became less than about 20 log  $\lambda/4a$  (e.g., if  $a/\lambda = 10$ , 20 log  $\lambda/4a \simeq -32$  dB).

figure 5. (The z-axis is chosen to intersect the scan area perpendicularly at a point somewhat centrally located.)  $D_m^{\prime}$  denotes the distance  $D_m$  when  $\overline{P}$  is on the boundary C' of the scan area, which is always assumed to be outside the aperture boundary C.

Eq. (20) is amenable to the method of stationary phase for double integrals. The critical points of the first kind of  $[D_m - p \sin\theta \cos(\phi - \phi_p)]$  occur at

$$\frac{\partial D_{m}}{\partial \phi_{p}} = p \sin \theta \sin(\phi - \phi_{p})$$
(21a)

$$\frac{\partial D_{m}}{\partial p} = \sin\theta \, \cos(\phi - \phi_{p}) \,. \tag{21b}$$

Consider the derivative  $\frac{\partial D_m}{\partial p}$ , which can be interpreted physically by referring to figure 5. Let the vector  $\overline{P}_m$  be the perpendicular projection of the line  $D_m$  such that

 $\mathbf{p}_{\mathrm{m}} = \sqrt{\mathbf{p}^2 - \boldsymbol{\ell}_{\mathrm{m}}^2}.$ 

Then

$$\frac{\partial D_m}{\partial p} = \frac{\partial D_m}{\partial p_m} \frac{\partial p_m}{\partial p} = \frac{p - \ell_m}{p_m} \frac{\partial \ell_m}{\partial p} \cos\gamma_m$$

where  $\gamma_m$  is the angle between  $\overline{P}_m$  and  $D_m$ . Ordinarily, the scan areas are appreciably larger than the aperture area so that

$$\frac{p - \ell_m}{p_m} \stackrel{\frac{\partial \ell_m}{\partial p}}{=} \simeq 1$$

and (21b) may be written

$$\cos\gamma_{\rm m} = \sin\theta \cos(\phi - \phi_{\rm p}). \tag{22}$$

Similarly, it can be argued that  $\frac{\partial D_m}{\partial \phi_p}$  is much less than p for scan areas appreciably larger than the aperture area. Thus for  $\theta$  not too small eq. (21a) implies the critical point must be near  $\phi_p = \phi$ . Now  $\cos \gamma_m$  has a minimum value greater than zero because  $\gamma_m$  never reaches 90°. The minimum value of  $\cos \gamma_m$  occurs at the maximum value of  $\gamma_m = \gamma_{max}$  or on the boundary of the scan area near  $\phi$ . This maximum value is important because eq. (22) reveals that there are no critical points near the angle  $\phi$  for  $\theta < 90 - \gamma_{max}(\phi)$ .

For  $\theta > 90 - \gamma_{max}$  critical points exist at

$$\begin{split} \varphi &\simeq \varphi_{\rm p} \\ \theta &\simeq 90 - \gamma_{\rm m} = \theta_{\rm m} \end{split} ,$$

and eq. (20) can be evaluated immediately by the method of stationary phase for double integrals [10]. Such a procedure yields after some rearrangement

$$\overline{I} = \sum_{m} \frac{\overline{F}_{tm} \lambda D_{m}}{\cos \theta} e^{ik(d \cos \theta + x_{m} \sin \theta)}.$$
(23)

Actually, eq. (23) was derived using the approximation  $D_m \simeq \sqrt{(p \pm x_m)^2 + d^2}$ and  $\frac{1}{p} \frac{\partial x_m}{\partial \phi_p} << 1$ , where  $x_m$  and d are defined in figure 5. The above approximations simplify the mathematics but do not alter by a great amount the amplitude of the final expression (nor the following conclusions).

The implications of eq. (23) prove to be quite significant because it shows that for  $\theta > 90 - \gamma_{max}(\phi)$  the magnitude of the integral  $\overline{I}$  is of the same order as the amplitude of the electric field itself with each term multiplied by  $\lambda D_m$  cos $\theta$ . By referring back to eqs. (12) and (13) we see that this result implies the following:

In the region outside of the envelope, which is formed by the rays running from the edge of the aperture through the boundary of the scan area, the fractional error  $\eta(\overline{r})$  is on the order of unity. Thus, outside the envelope the farfields computed from a planar scan in the near-field cannot be relied upon with any confidence.

Moreover, diffraction from feed mounts, if present, does not affect the above conclusion, because the radiation scattered by the feed mounts grazes the boundary of the scan area at a wider angle than the radiation from the edge of the aperture.

The conclusion says, essentially, that the planar scan technique does not give information about the fields outside the solid angle formed by the edge of the aperture antenna and the boundary of the scan area. (We use the term "solid angle" loosely since it will not be a solid angle in the strict mathematical sense unless the extension of its sides meet at a single point.) As an example consider a circular reflector antenna of radius "a" scanned in the near-field on a larger concentric circular area of radius  $a\sqrt{2}$ . Suppose the scan area were a distance d = a in front of the aperture. Then, as shown in figure 6, the above results reveal immediately that the data from the near-field scan would not contain reliable information about the fields outside the angle  $\theta_m = 22.5^\circ$ .

Newell and Crawford [11] reached the same conclusion from experimental data taken on scan planes at different distances in front of the same microwave antenna. It appears from the above analysis that their conclusion is a general result which holds for all electrically large aperture radiators.

It should be emphasized that the above results were derived for the sum and difference pattern of electrically large aperture antennas and for a scan area that extends well beyond the main nearfield beam region. Also the main near-field beam has been assumed to be characterized by planes of fairly uniform phase. The above conclusion would not necessarily apply, for instance, to broadbeam horns with dimensions on the order of a wavelength or less, to beams steered nearly to the edge of the scan area and scan areas just covering the main near-field beam, to apertures on a finite ground plane, to defocussed antennas, or to electrically large aperture antennas with a diverging or converging lens placed within or directly in front of the aperture. Fortunately, special situations and classes of antennas such as these can often be analyzed separately within the framework of the preceding analysis and results. The special cases mentioned above are discussed in the following paragraph.

Specifically, an analysis similar to the preceding shows that the encircled conclusion applies to the latter three classes of antennas (the defocussed antennas and antennas with a ground plane or lens), provided the scan area extends well beyond the edge of the antenna, the ground plane or lens, and provided the edge of the ground

plane or lens is used as the base perimeter for the solid angle when the edge of the ground plane or lens extends appreciably beyond the edge of the aperture and significant scattering occurs at these edges. Also, it can be shown [20] that the encircled conclusion applies to broadbeam horns if the center of the horn is taken as the base of the solid angle instead of the perimeter of the horn. (For scan areas much larger than the aperture of the horn, there is little difference in size between these two solid angles.) Similarly, for antennas with their mainbeam steered close to the edge of the scan area it may be more accurate to choose a point nearer the center of the aperture rather than the edge to determine the side of the solid angle near the direction of the main beam. Again it makes little difference for large scan areas. In general, when the scan area is close to the boundary of the main beam, the base of the solid angle outside of which the computed far-field pattern is unreliable tends to shift from the perimeter of the aperture (ground plane or lens) toward the center. Often the increase in solid angle is slight, however.

In brief, the above encircled conclusion (in its stated or slightly modified forms just explained) applies to a very large variety of antennas, including electrically large aperture antennas operating in a sum or difference pattern (with or without beam steering, defocussing, a finite ground plane, or modifying lens) and broadbeam horns.

Next we want to evaluate  $\overline{I}$  of eq. (20) for points within the solid angle formed by the edges of the antenna and scan area. Within this solid angle the integrand contains no critical points of the first kind. Consequently, the p integration can be done by parts to yield

$$\overline{I} = \frac{\lambda}{2\pi i_{m}^{2}} \int_{0}^{2\pi} \frac{\overline{F}_{tm}(p',\phi_{p})p' e}{\left[\cos\gamma_{m}'-\sin\theta\cos(\phi-\phi_{p})\right]} d\phi_{p}, \quad (24)$$

where again  $\cos\gamma'_{m}$  has replaced  $\frac{\partial D'_{m}}{\partial p'}$ , and the primes refer to points on the boundary of the scan area. It should be noted that eq. (24) represents the first term in an asymptotic expansion of eq. (20), and when  $\cos\gamma_{\rm m}^{\prime}$  gets too small eq. (24) no longer represents a good approximation to eq. (20). We can get an idea of the largest permissible  $\gamma_{\rm m}^{\prime}$  by realizing that the result (24), if valid, must be much smaller in amplitude than the amplitude of the integrand of eq. (20) multiplied by the change in distance p as D<sub>m</sub> changes from D'<sub>m</sub> to D'<sub>m</sub> +  $\lambda/2$ . A little mathematics shows that this condition is always satisfied if  $\cos\gamma_{\rm m}^{\prime}$  is greater than about  $\sqrt{\frac{\lambda}{d^{\prime}}}$ , where d' is the perpendicular distance from the edge of the aperture to the scan plane. However, when used to find an upper bound expression for  $|\overline{1}|$  (see eq. (28) below), eq. (24) remains valid for  $\gamma_{\rm m}^{\prime}$  right up to 90°.

Eq. (24) has been derived under the condition that the fields emanate or at least appear to emanate from points on the edge of the antenna aperture. If the fields are also scattered from the feed mounts, eq. (24) must include these fields as well. The  $\cos\gamma'_m$ associated with these mount scattered fields will always be equal to or greater than that of the edge diffracted fields--since the fields scattered by feed mounts make larger angles with the plane of the scan area at its boundary than the edge diffracted fields. Thus, the integration by parts remains valid (as an upper bound expression within the solid angle formed by the edges of the aperture and scan area), and eq. (24) holds even when there exists appreciable radiation scattered from feed mounts in front of the antenna.

For angles near the z-axis ( $\sin\theta < \cos\gamma_m$ ) eq. (24) becomes

$$\overline{\mathbf{I}} = \frac{\lambda}{2\pi i} \int_{0}^{2\pi} \left( \sum_{m} \frac{\overline{\mathbf{F}}_{tm} \mathbf{e}^{m}}{\cos \gamma_{m}^{*}} \right) \mathbf{p}^{*} \mathbf{e}^{-ikp^{*}} \sin \theta \cos (\phi - \phi_{p}) d\phi_{p}.$$
(25)

Upon taking the amplitude of eq. (25) we find

$$\overline{I} \mid \leq \frac{\lambda}{2\pi} \int_{0}^{2\pi} \left| \sum_{m} \frac{\overline{F}_{tm} e}{\cos \gamma_{m}'} \right| p' d\phi_{p}.$$
(26)

For scan areas whose boundary is well outside the edge of the aperture,  $\cos \gamma_m^* \approx 1$ . For scan areas with boundaries somewhat close to the edge of the aperture, the term (in the summation over m) which corresponds to the minimum  $D_m^*$  (maximum  $\gamma_m^*$ ) predominates (assuming fairly uniform illumination around the edge of the aperture), so that

$$\sum_{m} \frac{\overline{F}_{tm} e}{\cos \gamma_{m}'} \simeq \frac{1}{\cos \gamma_{max}} \sum_{m} \overline{F}_{tm} e^{ikD_{m}'}.$$

In either case, we see from eq. (19) that

$$\left|\sum_{m}^{\mathbf{F}_{tm}e} \frac{|\mathbf{E}_{t}(\mathbf{p}', \phi_{p})|}{\cos\gamma_{m}'}\right| \simeq \frac{|\overline{\mathbf{E}}_{t}(\mathbf{p}', \phi_{p})|}{\cos\gamma_{max}},$$

where  $E_t(p',\phi_p)$  is the electric field at the boundary of the scan area. Eq. (26) can now be written

$$|\overline{I}| \leq \frac{\lambda}{2\pi \cos \gamma_{\max}} \int_{0}^{2\pi} |\overline{E}_{t}(p',\phi_{p})| p' d\phi_{p}, \qquad (27)$$

or

$$\left|\overline{\mathbf{I}}\right| \leq \frac{\lambda \, \mathrm{L}_{\mathrm{max}}}{2 \, \mathrm{cos} \, \gamma_{\mathrm{max}}} \left|\overline{\mathbf{E}}_{\mathrm{t}}^{'\,\mathrm{max}}\right|, \qquad (28)$$

with  $|\overline{E}_t^{'max}|$  denoting the maximum amplitude of the transverse electric field found on the boundary C' of the scan area, and  $L^{max}$  is the maximum width of the scan area. If the output of the measuring probe at the limits of the scan area is down at least X dB from its maximum output, then eq. (28) may be rewritten

$$|\overline{\mathbf{T}}| \leq \frac{\lambda \ \mathbf{L}^{\max} \ \mathbf{10}^{-\frac{\lambda}{20}}}{2 \ \cos\gamma_{\max}} \mathbf{E}_{to}, \tag{29}$$

where  $E_{to}$  represents the highest amplitude of the transverse electric field found on the scan area.<sup>7,8</sup> Equation (29) combines with eqs. (13) and (14) to yield an upper bound expression for the error  $\eta$  in

<sup>7</sup>For an arbitrary probe (i.e., not necessarily a dipole probe)  $E_{to}$  represents the highest output amplitude of the probe on the scan area and X the largest output amplitude of the probe at the edge of the scan area measured in dB down.

<sup>8</sup>The maximum electric field on the scan area in the near-field  $(z << A/\lambda)$  of an electrically large aperture is very nearly equal to the maximum electric field on the aperture itself.

the far-field produced by neglecting the fields outside the finite scan area:

$$\eta(\overline{r}) \leq \frac{\lambda L^{\max} 10^{-\frac{X}{20}} g(\overline{r})}{2 \cos \gamma_{\max} |\int_{A_0} \frac{\overline{E}_t}{E_{to}} da|}, \qquad (30a)$$

where  $g(\overline{r})$  is the ratio of the amplitude of the maximum far-electricfield to the far-electric-field in the given direction  $\overline{r}$ . In other words, itisthe inverse of the normalized far-field pattern. Use has been made of eq. (10) which shows that for sum patterns

$$\lambda r |\overline{E}_{0}|_{r \to \infty} \simeq |\int_{A_{0}} \overline{E}_{t} da|,$$
 (30b)

where  $|\overline{E}_0|_{r\to\infty}$  is the amplitude of the maximum far-field, and the integration is performed in the near-field over the area  $A_0$ , that part of the beam which has nearly uniform phase. Since we are in the near-field,  $A_0 \simeq A \cos\theta_0$ , where A is the aperture area. (The factor  $\cos\theta_0$  accounts for the reduction in effective aperture area for beams which are steered off-axis electronically through an angle  $\theta_0$ .)

Because  $|\overline{E}_t|/E_0 \le 1$ , where  $E_0$  is the highest amplitude of electric field on the scan area, and  $E_{t0} \simeq E_0 \cos\theta_0$ , we can write

$$\frac{1}{\left|\int_{A_{o}} \frac{\overline{E}_{t}}{E_{to}} da\right|} = \alpha \cos\theta_{o}/A_{o} = \alpha/A, \quad (31)$$

where the factor  $\alpha$  is greater than its minimum value of 1.0 (for apertures of uniform amplitude and phase) but less than 5 for most tapered aperture distributions found in practice. For example, the tapered distributions found in Table IX of [13] have a maximum  $\alpha$  of 4.0. Newell [17] has found that the factor we have called  $\alpha$  has not been greater than about 2 A/A<sub>e</sub> for any microwave antenna he has measured. Since the effective area A<sub>e</sub> (see [12] for a definition of effective area) is less than the aperture area A and greater than .5A for most aperture antennas [13], the experience of Newell

also indicates that  $\alpha$  is less than 4 or 5 for nearly all electrically large aperture antennas found in practice.

Equation (31) combines with eq. (30a) to give the final expression for  $\eta(\overline{r})$ 

$$n(\overline{r}) \leq \frac{\alpha \lambda L^{\max} 10^{-\frac{X}{20}} g(\overline{r})}{2 A \cos \gamma_{\max}},$$
 (32)

where

A = area of the antenna aperture.

- $\lambda$  = wavelength.
- $L^{max}$  = maximum width of the scan area.
- $\gamma_{max}$  = maximum acute angle between the plane of the scan area and any line connecting the edges of the aperture and scan area.
- X = the largest amplitude of the probe output at the edge of the scan area, measured in dB down from the maximum amplitude of probe output in the scan plane.
- α = a "taper" factor--equal to a minimum of 1.0 (for apertures of uniform amplitude and phase) and less than 5 for most tapered distributions found in practice. (See eq. (31) for the precise definition of α.)
- $g(\overline{r})$  = ratio of the amplitude of the maximum far-electric-field to the far-electric-field at the given direction  $\overline{r}$ , i.e., the inverse of the normalized far-field pattern. ( $g(\overline{r})$  = 1 for the center of the main beam, or beams if a difference pattern.) (If desired the errors in the gain function sidelobe level, polarization ratio, and beamwidth may be calculated from eqs. (2)-(5) once  $\eta$ and the far-field pattern is known.)

Equation (32) has been derived for antennas operating in a sum pattern. But since a difference pattern can be divided into two, approximately equal, sum patterns with wavefronts slightly skewed, eq. (32) holds for difference patterns as well. (For a difference pattern one should still use the taper factor  $\alpha$  of the constituent sum patterns.)

In summary, eq. (32) applies to either sum or difference patterns of all electrically large aperture antennas (including antennas
with their boresight direction steered away from the axis perpendicular to the scan area) within a solid angle  $(\sin\theta < \cos\gamma_{max})$  about the axis perpendicular to the scan area. Again, it has been assumed that the scan area extends well beyond a main near-field beam which is characterized by planes of fairly uniform phase. It can be shown that eq. (32) and eq. (36) below apply even to defocussed antennas, apertures in a finite ground plane, and to antennas with a diverging or converging lens, provided the angle  $\gamma_{max}$  is chosen in accord with the second paragraph preceding that of eq. (24). The condition ( $\sin\theta < \cos\gamma_{max}$ ) can be made more specific by returning to eqs. (24) and (25). For all practical purposes, eq. (25) follows from eq. (24) if

$$\sin\theta < \frac{1}{2} \cos\gamma_{\text{max}} = \frac{1}{2} \sin\theta_{\text{max}}$$

$$(\theta_{\text{max}} = 90 - \gamma_{\text{max}}).$$
(33)

For example, if  $\gamma_{max}$  were 45°, condition (33) becomes  $\theta < 20^{\circ}$ , which is a large enough angle to include many side lobes of most microwave antennas (assuming their boresight direction at  $\theta = 0$ ). Roughly speaking, eq. (32) represents a valid upper bound within the region  $\theta < \frac{1}{2} \theta_{max}$ .

As an upper bound, eq. (32) remains valid for  $\gamma_{max}$  right up to 90°. However, from the discussion immediately following eq. (24), it is unlikely that eq. (32) would remain small enough to be very useful when

$$\cos\gamma_{\max} < \sqrt{\frac{\lambda}{d_{\min}}},$$
 (34)

where d<sub>min</sub> refers to the minimum perpendicular distance from the edge of the aperture to the scan plane.

The error  $\eta$  given by eq. (32) can be compared with the results of the empirical error analysis performed by Newell and Crawford [11]. They took "centerline" data on a near-field scan plane 25 cm in front of a circular, fixed-beam "constrained lens" array, which was 80 cm in diameter (see figure 9). The centerline was 213 cm long.

Assuming a rectangularly separable field pattern, they first used the 213 cm centerline data to compute the far-field pattern. Successively, more and more of the 213 cm distance was deleted and

the corresponding far-field pattern computed. In that way they could get an idea of the errors involved in scanning on a near-field plane of finite area.

The envelope of their near-field centerline amplitude is reproduced in figure 7a. The on-axis gain change computed by Newell and Crawford by deleting distances from the scan line is reproduced by the dashed line in figure 8a. The solid lines in figure 8a represent the maximum envelope of on-axis gain change calculated from eqs. (32) and (2c) of the present report. The values of X and  $L^{max}$  (see eq. (32)) were taken from figure 7a. The value of  $\alpha$  was estimated from eq. (31) and figure 7a to be about 3. The remaining parameters needed to calculate  $\eta$  from eq. (32) are contained in reference [11]:

$$\gamma_{max} = \tan^{-1} \left( \frac{d}{\left( \frac{L^{max}}{2} - a \right)} \right)$$
$$\lambda = 3.26 \text{ cm}$$
$$A = \pi a^{2}$$
$$a = 40 \text{ cm}$$
$$d = 25 \text{ cm}$$
$$g(\overline{r}) = 1.$$

Figure 8a confirms the result that the fractional error  $\eta$  of eq. (32) represents a reasonable upper bound. In the region  $L^{max}/2a > 1.7 (\gamma_{max} < 42^{\circ})$  the upper-bound error from eq. (32) is no more than double the error estimated by computer "deconvolution" of the near-field data. The upper bound error grows inordinately large, however, for  $L^{max}/2a$  much less than about 1.2 ( $\gamma_{max} > 75^{\circ}$ ), as eq. (34) predicts.

Figure 8b shows the same comparison as that made in figure 8a but for a 46 cm (18 in) reflector antenna operating at 60 GHz ( $\lambda$  = .5 cm). (The envelope of the amplitude for a centerline scan of this antenna is shown in figure 7b. The value of  $\alpha$  is about 2.) The dashed line in figure 8b represents the on-axis gain change which Newell [17] computed by deleting distances from the centerline scan length taken 43.18 cm in front of the aperture. The agreement between his computations and the upper bound solid curve calculated from eq. (32) is even closer than for that of the constrained lens

antenna (figure 8a). The upper bound error is no more than double the computed error for  $L^{max}/2a > 1.05$  ( $\gamma_{max} < 88^{\circ}$ ) which is very close to the value of  $\gamma_{max} < 84^{\circ}$  predicted for the range of usefulness by eq. (34).

It appears from this somewhat limited experimental evidence with centerline data that the simple formula (32) provides a useful upper bound error at least for scan areas with  $\cos\gamma_{max} > \sqrt{\frac{\lambda}{d_{min}}}$ . It should be noted, however, that centerline data do not account for changes in phase of the field around the perimeter of the scan area, and thus would predict larger finite scan errors in most cases than the complete 2-dimensional scan data. An upper bound expression of smaller magnitude generally than eq. (32) that takes the phase changes into account can be derived by returning to eq. (24). Under the condition of eq. (33), eq. (24) becomes

$$\left|\overline{I}\right| \leq \frac{\lambda}{2\pi \cos\gamma_{\max}} \left| \int_{0}^{2\pi} \overline{E}_{t}(p',\phi_{p}) e^{-ikp'\sin\theta} \cos(\phi - \phi_{p}) p' d\phi_{p} \right|.$$
(35)

Again  $\overline{E}_{t}(p',\phi_{p})$  refers to the transverse electric field, i.e., output of the dipole probe, at the boundary of the scan area. Substitution of eq. (35) into eq. (13) yields the fractional error  $\eta(\overline{r})$  in the far-field for  $\theta \leq \frac{1}{2} \theta_{max} = \frac{1}{2}(90 - \gamma_{max})$ ,

$$\eta(\overline{\mathbf{r}}) \leq \frac{\left| \int_{0}^{2\pi} \overline{\mathbf{E}}_{t}(\mathbf{p}', \phi_{p}) e^{-ikp' \sin\theta} \cos(\phi - \phi_{p}) \mathbf{p}' d\phi_{p} \right|}{2\pi \mathbf{r} |\overline{\mathbf{E}}(\overline{\mathbf{r}})|_{\mathbf{r} \to \infty} \cos\gamma_{\max}}.$$
(36)

The far-field pattern  $r|\overline{E}(\overline{r})|_{r \to \infty}$  in eq. (36) can be approximated analytically by  $\frac{AE_{to}}{\alpha\lambda g(\overline{r})}$  or found by deconvoluting the measured nearfield data. The field  $\overline{E}_t(p',\phi_p)$  at the boundary of the scan area can be taken from the measured near-field data. Thus, in practice both the numerator and denominator of eq. (36) can be determined straightforwardly. Although eq. (36) involves more computations than eq. (32) even for the on-axis value for which  $\theta=0$ , it could be computed by a simple routine added to the program which deconvolutes the near-field data, since for arbitrary probes  $\overline{E}_t(p',\phi_p)$  can be replaced by the output of the probe (for two orientations, in general) on the perimeter of the scan area. In cases where the antenna pattern is assumed separable in xy coordinates and only centerline data is taken, eq. (36) cannot be applied but eq. (32) still can.<sup>9</sup>

In Table 1 are listed the errors calculated from eq. (32) for some of the far-field parameters of a typical X-band antenna operating in a sum and difference pattern. The finite scan errors are proportional to wavelength, so changing the wavelength while holding the other antenna dimension the same merely changes the values in Table 2 proportionately. Of course, such an isolated change is rather unrealistic.

## B. Position and Instrumentation Errors

To determine the radiating fields of an unknown antenna by scanning on a near-field plane with a given probe, the output  $b'_{0}(\overline{P})$  of the probe must be recorded throughout the scan area A' (see footnote 3a). In principle, the data points should lie in a plane and the position of the probe should be recorded exactly as it scans from point to point. And, ideally, the instrumentation used to measure the phase and amplitude of  $b'_{0}$  should do so with perfect accuracy.

Obviously, in practice, neither the position of the probe nor the phase and amplitude of the probe output  $b'_{O}$  can be measured exactly. Regardless of how small the uncertainties in the measurement of  $b'_{O}(\overline{P})$  they will introduce errors into the calculated farfield. It is the purpose of this section to derive general expressions which estimate the magnitude of the errors in the far-field produced by the inaccuracies in measuring the position and output of the probe in the near-field.

Specifically, we want to evaluate  $\Delta \overline{E}$  in the far-field so that the fractional error  $\eta(\overline{r})$  of eq. (1) can be determined. (In Section

<sup>9</sup>It is interesting to note that  $\eta$  in both eqs. (32) and (36) does not approach zero but simply an insignificantly small number as the scan boundary approaches infinity. This limiting value of  $\eta$  represents the contribution of the oscillatory part of the Fourier transform mentioned in footnote 3b. Consequently, once the edges of the scan area reach the region where the fields behave as 1/p', there may be no advantage to scanning on a larger area at least if only the pattern near the boresight direction is required.

It is shown in reference [20] that eqs. (32) and (36) slightly modified apply to broadbeam horn antennas as well as electrically large aperture antennas. For these broadbeam antennas the limiting value of  $\eta$  can be significant.

II the errors in gain function, sidelobe level, polarization ratic and beamwidth are derived in terms of  $n(\bar{r})$  and the far-field pattern.) In order to simplify the theoretical analysis, the errors will be evaluated as if the probe were a perfect electric dipole. The justification for choosing a perfect dipole in the analysis is similar to that stated in Section III.A. The dipole measures the electric field components at a point. All physically realizable probes respond to a weighted average of the fields near the probe. Thus any small error in position would be expected to change the output of a perfect dipole by as much or more than any other probe. As for instrumentation errors, they remain essentially independent of the particular measurement probe. Also, as in the previous sections, any uncertainty in probe receiving characteristics (S'01) will be ignored for this part of the error analysis.

Under the above conditions the far-field error in  $\Delta \overline{E}_t$  may be found with the help of eq. (10):

$$\Delta \overline{E}_{t}(\overline{r}) = -\frac{ik \cos\theta}{2\pi r} e^{ik(r-d \cos\theta)} \int_{A'} \Delta \overline{E}_{t}(\overline{P},d) e^{-i\frac{k}{r}\overline{R}\cdot\overline{P}} d\overline{P}. \quad (37)$$

$$r \to \infty$$

 $\Delta \overline{E}_{t}(\overline{P},d)$  is the difference between the actual electric field at the point  $(\overline{P},d)$  and the measured output of the hypothetical dipole probe (for two orientations in general) at the point  $(\overline{P},d)$ . For errors near the z-axis ( $\theta < 2\lambda/L_{0}^{\max}$ , see footnote 5) eq. (37) becomes

$$\Delta \overline{E}(\overline{r}) = -\frac{ik}{2\pi r} e^{ik(r-d)} \int_{A_0} \Delta \overline{E}_t(\overline{P}, d) e^{-i\frac{k}{r}\overline{R}\cdot\overline{P}} d\overline{P}, \qquad (38)$$

where  $A_0$  designates that part of the scan area over which the major variations in phase are relatively small. (For the position and instrumentation error analysis the scan plane is assumed to lie nearly parallel to the near-field planes of "uniform" phase, i.e., perpendicular to the center of the main beam of sum patterns or to the null axis of difference patterns.) For scan planes in the very near-field,  $A_0$  is approximately equal to A  $\cos\theta_0$ , i.e., the projected area of the antenna aperture. (Only electrically large aperture

antennas are being considered.)  $\theta_0$  is the angle between the perpendicular to the aperture and the perpendicular ( $\hat{e}_z$ ) to the scan plane.  $\theta_0 = 0$  for beams which are not steered off-axis electronically.

The scan area outside  $A_0$  can be neglected for this part of the error analysis because the rapidly changing phase in the region outside  $A_0$  contributes little when integrated to find the far-field and the errors in the far-field near the z-axis. It follows from footnote 5, or more rigorously from an asymptotic analysis like the one performed in Appendix A for a circular aperture of uniform distribution, that eq. (38) can be used as an upper bound expression for  $\Delta \overline{E}$  in the region given approximately by  $\theta < 2\lambda/L_0^{max}$  where  $L_0^{max}$  is the maximum breadth of the partial scan area  $A_0$ . This region is large enough to include the first sidelobe maximum of many electrically large aperture radiators. For example, a circular aperture of uniform distribution and radius a  $\approx L_0^{max}/2$  has its first sidelobe maximum at an angle  $\theta \approx 1.7\lambda/L_0^{max}$  radians.

Physically this  $2\lambda/L_0^{max}$  condition says that for most electrically large aperture antennas, the part of the near-field  $(A_0)$  over which the phase is fairly uniform strongly influences the far-field within the angle  $2\lambda/L_0^{max}$ . Beyond this angle the edge diffracted fields dominate the far-fields to a greater and greater extent until in the far sidelobes the fields are determined essentially by the edge diffracted fields alone.

To find either the position or instrumentation errors, the integral

$$\overline{I}_{o} = \int_{A_{o}} \Delta \overline{E}_{t}(\overline{P}, d) e^{-i\frac{k}{r}\overline{R} \cdot \overline{P}} d\overline{P}$$
(39)

in eq. (38) must be evaluated. Of course, the integration can be performed only after  $\Delta \overline{E}_{t}(\overline{P},d)$  is found. In Section 1 below,  $\Delta \overline{E}_{t}$ ,  $\overline{I}_{o}$ , and thus  $\eta(\overline{r})$  are evaluated for position errors, and in Section 2 for instrumentation errors.

The approach that is taken is quite straightforward. For position errors  $\Delta \overline{E}_t$  is expanded in a Taylor series about (P,d) assuming the deviation in the position of the scanner is small compared to a wavelength. The Taylor series and the integral (39) into which it

is substituted divides naturally into a longitudinal or z-position part and a transverse or xy-position part. The upper-bound for each integral and thus for the z- and xy-position errors are then determined as a function of the measured near-field data and the computed far-field pattern.

For instrumentation errors,  $\Delta \overline{E}_t$  is expressed in terms of the amplitude and phase errors introduced by the nonlinearities in the receivers which measure these quantities as the probe traverses the scan area. Mathematically, the integrals involving the receiver phase errors are handled in the same way as z-position errors, and thus the final upper-bound expressions have the same form. The integrals involving the amplitude errors have their upper-bound determined by characterizing the receiver nonlinearity in measuring amplitude in dB of error per dB down from the maximum amplitude of the probe output on the scan area.

## 1. Position Errors

Consider the scanner which moves the probe throughout the nearfield scan area. Typically the scanner covers the area by traversing a grid or raster of lines while the probe output is recorded at given points along each line. Ideally, all the scan lines lie perfectly straight and parallel in a single plane, and the position of the data points along each line is recorded exactly. In reality, of course, none of these idealizations hold, basically because the scan lines will never be perfectly straight and the data must always be recorded over an interval rather than at a point.

Regardless of the reason for the position errors, they all effect the near-field data simply by positioning the probe at points  $(\overline{P}+\Delta\overline{P}, d+\Delta z)$  rather than (P,d). In other words, the difference  $\Delta\overline{E}_{+}(\overline{P},d)$  in eq. (39) can be written for position errors as

$$\Delta \overline{E}_{t}(\overline{P},d) = \overline{E}_{t}(\overline{P}+\Delta \overline{P},d+\Delta z) - \overline{E}_{t}(\overline{P},d), \qquad (40)$$

where, as usual,  $\overline{E}_t(\overline{P},z)$  is the electric field at the point  $(\overline{P},z)$  in the near-field. In general,  $\Delta \overline{P}$  and  $\Delta z$ , which will be referred to as displacement errors, are functions of the transverse position  $\overline{P}$ .

Before continuing with the analysis it should be pointed out that displacement errors caused by a small initial translation of the entire scanner with respect to the test antenna will not cause a change in the computed far-field amplitude, as eqs. (6) and (8) indicate. Also, an initial rotation of the entire scanner through a small angle will have no effect on the far-field pattern other than to rotate the entire pattern through that same angle.

Since the displacement errors must be much smaller in magnitude than a wavelength, the right hand side of eq. (40) can be expanded in a three dimensional Taylor series. By letting  $\Delta \overline{r} = \Delta \overline{P} + \Delta z \hat{e}_z$  and keeping only the first two terms in the series, eq. (40) becomes

$$\Delta \overline{E}_{t}(\overline{P},d) = \Delta \overline{r} \cdot \nabla \overline{E}_{t}(\overline{P},d) + \frac{1}{2} \Delta \overline{r} \cdot [\Delta \overline{r} \cdot \nabla \nabla \overline{E}_{t}(\overline{P},d)], \quad (41)$$
where  $\nabla \nabla \overline{E}_{t} \equiv (\nabla \nabla E_{x})\hat{e}_{x} + (\nabla \nabla E_{y})\hat{e}_{y}$ 
and  $\nabla \overline{E}_{t} \equiv (\nabla E_{x})\hat{e}_{x} + (\nabla E_{y})\hat{e}_{y}.$ 

Substitution of eq. (41) into eq. (39) yields a useful expression for  $\overline{I}_{0}$ ,

$$\overline{I}_{o} = \int_{A_{o}} \Delta \overline{r} \cdot \left[ \nabla \overline{E}_{t} + \frac{1}{2} \Delta r \cdot \nabla \nabla \overline{E}_{t} \right] e^{-i\frac{k}{r}\overline{R} \cdot \overline{P}} d\overline{P}.$$
(42)

Again it is emphasized that  $\Delta \overline{r}$  is, in general, a function of  $\overline{P}$ , the transverse coordinates over which eq. (42) is integrated. Also, as we shall see shortly, it is necessary to retain the second term in the integrand of eq. (42) when on-axis errors for sum patterns are considered. As a check on eq. (42) let  $\overline{R} = 0$  (on-axis) and  $\Delta \overline{r}$  be constant over  $A_0$  so that  $\Delta \overline{r}$  can be taken outside the integral. The terms containing the transverse part of the gradient operator convert to line integrals around the boundary of  $A_0$ . These line integrals must equal zero because in effect eq. (42) assumes negligible fields outside the integral, are left, and eq. (42) may be written

$$\overline{I}_{0} = \Delta z \left( \frac{\partial}{\partial z} + \Delta z^{2} \frac{\partial^{2}}{\partial z^{2}} \right) \int_{A_{0}} \overline{E}_{t} d\overline{P}.$$
(43)

With the aid of eq. (10), eq. (43) converts to

$$\overline{I}_{o} = -(\Delta z + ik\Delta z^{2}) 2\pi r e^{-ik(r-d)} \overline{E}_{t}(\overline{r}).$$

$$r \to \infty$$
(44)

Equations (38), (39), (42) and (44) combine to show that

$$\left|\overline{E}(\overline{r})+\Delta\overline{E}(\overline{r})\right|_{r\to\infty} \simeq \left(1 + \frac{(k\Delta z)^{4}}{8}\right) \left|\overline{E}(\overline{r})\right|_{r\to\infty},$$

i.e., the error in the far field amplitude calculated from eq. (42) is of higher order than  $(\frac{|\Delta \overline{r}|}{\lambda})^2$ , i.e., it is negligible when  $\Delta \overline{r}$  is constant -- a result which must hold if eq. (42) is a valid expression for  $\overline{\Gamma}_0$ , because, as mentioned above, a translation of the entire scanner has a negligible effect on the far-field pattern. Equation (42) also checks in a similar way for  $R \neq 0$ , but the proof is more involved.

In order to evaluate  $\overline{T}_0$  of eq. (42) exactly, both  $\Delta \overline{r}$  and  $\overline{E}_t(\overline{r})$  in the near-field would have to be known. Fortunately, an upper bound approximation can be found for  $\overline{T}_0$  without detailed information about  $\Delta \overline{r}$  or  $\overline{E}_+(\overline{r})$ .

Consider one component, say  $E_x$ , of the integrand of eq. (42). For an electrically large aperture antenna, we can express  $E_x$  within the area  $A_0$  as

$$E_{x}(\overline{P},z) \simeq (1+\Delta A_{x}(\overline{P},z))E_{ox}(\overline{P}) e^{i(kz+\phi_{ox}+\Delta\phi_{x}(\overline{P},z))}, \quad (45)$$

where  $\phi_{OX}$  is a real arbitrary phase constant, and  $\Delta A_X$ ,  $\Delta \phi_X$  and  $E_{OX}$ are real functions of the indicated near-field coordinates. The functions  $\Delta A_X(\overline{P},z)$  and  $\Delta \phi_X(\overline{P})$  typically oscillate over a distance equal to or greater than a wavelength, each with a magnitude usually much less than one.  $E_{OX}(\overline{P})$  is the smoothly tapered amplitude function. In other words, eq. (45) simply states that the near-field across the area  $A_O$  of an electrically large aperture antenna has a phase equal essentially to kz and a smoothly tapered amplitude except for small variations which oscillate over distances equal to or greater than a wavelength. (Recall that for the position and instrumentation error analysis we are assuming that the perpendicular to the scan area is approximately aligned with the boresight direction of the antenna.)

In Appendix A eq. (45) is verified for a circular aperture of radius "a" and uniform aperture distribution ( $E_{ox} = E_o$ ). In that case  $\Delta A_x$  and  $\Delta \phi_x$  are on the order of  $\frac{1}{\pi} \sqrt{\lambda/a}$  or less. Rusch and Potter report similar results for the circular aperture [14]. Equation (45) has been verified experimentally by the substantial near-field scan and extrapolation data taken at the NBS. The measured amplitude and phase on a near-field plane of a typical microwave antenna are plotted in figures 9a,b,d. This particular scan was taken 25 cm in front of the circular "constrained lens array" (see figure 9c) of radius 40 cm operating at 9.2 GHz ( $\lambda = 3.26$  cm). This antenna is the same one described in the paragraph following eq. (34) and whose centerline amplitude envelope is plotted in figure 7a.

When eq. (45) is substituted into the integrand of eq. (42) and all terms higher than either second order in  $|\Delta \overline{r}|/\lambda$  or first order in  $|\Delta \overline{r}|/\sqrt{A_0}$  are discarded, the following expression for the x component of  $\overline{I}_0$  remains:

$$I_{OX} \approx \int_{A_{O}} \left[ [\Delta \overline{r} \cdot \nabla | E_{X}] - \frac{1}{2} \left( \frac{2\pi\Delta z}{\lambda} \right)^{2} E_{OX} + i \left( \frac{2\pi\Delta z}{\lambda} \right) E_{OX} \right] e^{i\phi_{X}} e^{-i\frac{K}{T}\overline{R} \cdot \overline{P}} d\overline{P},$$
(46)
where  $E_{X} = |E_{X}| e^{i\phi_{X}}$ , or from eq. (45)
$$|E_{X}| = (1 + \Delta A_{X}) E_{OX}$$

$$\phi_{X} = kd + \phi_{OX} + \Delta \phi_{X}.$$

It has been assumed that the transverse  $(\overline{P})$  and longitudinal (z) displacement errors are of the same order of magnitude. Eq. (46) can  $i\phi_x \qquad i(kd+\phi_{ox})$ be simplified further by writing e as e  $(\cos\Delta\phi_x+i\sin\Delta\phi_x)$ , to put I<sub>ox</sub> in the form

$$I_{ox} \approx e^{i(kd+\phi_{ox})} \int_{A_{o}} (\Delta \overline{r} \cdot \nabla |E_{x}| - \frac{1}{2} \delta^{2} E_{ox} + i \delta E_{ox})$$
  

$$\cdot (\cos \Delta \phi_{x} + i \sin \Delta \phi_{x}) e^{-i\frac{k}{r}\overline{R} \cdot \overline{P}} d\overline{P}. \qquad (47)$$
  

$$(\delta = 2\pi\Delta z/\lambda)$$

First consider on-axis errors for antennas operating in a sum mode, that is  $\frac{k\overline{R}\cdot\overline{P}}{r} << 1$  or  $\theta$  less than about  $\lambda/(10 L_0^{max})$ . Then the exponential in eq. (47) can be approximated by unity. The arbitrary phase constant  $\phi_{0x}$  can be chosen so that  $\Delta\phi_x$  varies about zero throughout the area  $A_0$ . Furthermore, since the variations in  $\Delta\phi_x$  are small, oscillate many times across the area  $A_0$ , and remain completely independent of the variations in the displacement errors  $\Delta\overline{r}$  of the scanner, to a high probability,  $\phi_{0x}$  can be chosen such that the integration in eq. (47) which is multiplied by  $\sin\Delta\phi_x$  can be neglected compared to the maximum possible value of the  $\cos\Delta\phi_x$  integration. In addition, since  $E_{0x} \cos\Delta\phi_x$  remains positive throughout  $A_0$  for a sum pattern, the reference plane (z=d) for  $\delta$  can be chosen to make

$$\int_{A_{O}} \delta E_{OX} \cos \Delta \phi_{X} d\overline{P} = 0.$$
(48)

Thus, under the above conditions the  $i\delta$  term of eq. (47) is eliminated entirely and eq. (47) simplifies to

$$I_{ox} \approx e^{i(kd+\phi_{ox})} \int_{A_{o}} (\Delta \overline{P} \cdot \nabla_{t} E_{ox} - \frac{1}{2} \delta^{2} E_{ox}) \cos \Delta \phi_{x} d\overline{P}.$$

$$(\Delta = \Delta_{t} + \hat{e}_{z} \frac{\partial}{\partial z})$$
(49)

 $E_{ox}$  in the first term of eq. (49) has replaced  $|E_{x}| = (1+\Delta A_{x}) E_{ox}$  of eq. (47) because the many oscillations of  $\Delta A_{x}$  would also (to a high probability) eliminate upon integration all but higher order contributions from the  $\nabla(\Delta A_{x})$  term.

It is interesting that eq. (48) expresses the same condition chosen by Ruze [15] in his well-known work on "antenna tolerance theory," and under the above assumptions the z-position errors always lower the on-axis gain value of the sum pattern. Of course, in his work  $\delta$  represented a small "arbitrary

phase error or aberration" (what we call  $\Delta \phi_{\rm X}$ ) rather than the displacement errors of a near-field scanner. It would be desirable that the reference planes of  $\Delta x$  and  $\Delta y$  ( $\Delta \overline{P} = \Delta x \hat{e}_{\rm X} + \Delta y \hat{e}_{\rm Y}$ ) be chosen such that  $\int \Delta \overline{P} \cdot \nabla_{\rm t} E_{\rm ox} \cos \Delta \phi_{\rm X} d\overline{P}$  became zero also. Unfortunately, such a  $A_{\rm o}$  choice is impossible (in general) because neither derivative,  $\frac{\partial E_{\rm ox}}{\partial x}$  or  $\frac{\partial E_{\rm ox}}{\partial y}$ , stay the same sign throughout  $A_{\rm o}$ .

From eqs. (38) and (39) it is seen that the fractional error  $\eta$  of eq. (1) can be written as

$$\eta(\overline{r}) = \frac{1}{\lambda r |\overline{E}(\overline{r})|_{r \to \infty}} \sqrt{|I_{ox}|^2 + |I_{oy}|^2}.$$
 (50)

The amplitude of  $I_{ox}$  is found from eq. (49) to be

$$|I_{ox}| = |\int_{A_{o}} (\Delta \overline{P} \cdot \nabla_{t} E_{ox} - \frac{1}{2} \delta^{2} E_{ox}) \cos \Delta \phi_{x} d\overline{P}|$$

$$\leq \Delta P_{max} \int_{A_{o}} |\nabla_{t} E_{ox}| d\overline{P} + \frac{1}{2} \delta^{2}_{max} \int_{A_{o}} E_{ox} d\overline{P},$$
(51)

where  $\Delta P_{\max}$  and  $\frac{\lambda O_{\max}}{2\pi}$  are the maximum magnitudes of the transverse  $(\overline{P})$  and longitudinal (z) displacement errors, respectively, introduced by the near-field scanner.

The last integral in eq. (51) can be related to the maximum far-field  $|E_{x0}|_{r \to \infty}$ , i.e. from eq. (10) or (30b)

$$\int_{A_{o}} E_{ox} d\overline{P} \simeq \lambda r |E_{xo}|_{r \to \infty} .$$
(52)

The remaining integral,

$$\int_{A_{o}} |\nabla_{t} E_{ox}| \, d\overline{P},$$
(53)

is a bit more troublesome. However, it can also be estimated by expressing the integral in polar coordinates  $(p,\phi)$  as follows:

$$\int_{A_{o}} |\nabla_{t} E_{ox}| dP = \int_{A_{o}} \sqrt{\left(\frac{\partial E_{ox}}{\partial p}\right)^{2}} + \left(\frac{1}{p} \frac{\partial E_{ox}}{\partial \phi}\right)^{2} pdpd\phi.$$
(54)

If we assume that the amplitude of the aperture distribution tapers with much greater slope in the radial direction (p) than in the azimuthal direction ( $\phi$ ), the second term under the radical sign of eq. (54) can be neglected, leaving

$$-\int_{A_{o}} \frac{\partial E_{ox}}{\partial p} p dp d\phi.$$
 (55a)

The negative sign is present in eq. (55a) because  $\frac{\partial E_{ox}}{\partial p}$  is negative for amplitude distributions which taper toward the boundary of A<sub>o</sub>. (We are assuming p = 0 at the maximum of E<sub>ox</sub>.) Integration of eq. (55a) by parts with respect to p yields

$$-\int_{A_{o}} \frac{\partial E_{ox}}{\partial p} p dp d\phi = \int_{A_{o}} E_{ox} dp d\phi \simeq \frac{\pi}{2} E_{xo} L_{o}^{max}, \qquad (55b)$$

where  $E_{xo}$  and  $L_o^{max}$  denote the maximum amplitude of  $E_{ox}$  and the maximum breadth of the partial scan area  $A_o$ , respectively. With the aid of eq. (55b), eq. (54) becomes

$$\int_{A_{o}} |\nabla_{t} E_{ox}| \ d\overline{P} \leq \frac{\pi}{2} L_{o}^{\max} E_{xo}.$$
(56)

Since the area  $A_0$  is in the very near-field of the aperture antenna, the maximum amplitude  $E_{XO}$  on  $A_0$  is approximately equal to the maximum amplitude on the aperture itself. Thus  $E_{XO}$  is related to the maximum far-field by (see eqs. (30b) and (31))

$$E_{XO} = \frac{\alpha \lambda r |E_{XO}|_{r \to \infty}}{A},$$
 (57)

and eq. (56) becomes

$$\int_{A_{o}} |\nabla_{t} E_{ox}| d\overline{P} \leq \frac{\pi \alpha \lambda r L_{o}^{\max} |E_{xo}|_{r \to \infty}}{2 A}.$$
(58)

Substitution of eqs. (52) and (58) into eq. (51) yields

$$|I_{OX}| \leq \lambda r |E_{XO}|_{r \to \infty} \left( \frac{\pi \alpha \Delta P_{max} L_{O}^{max}}{2 A} + \frac{1}{2} \delta_{max}^{2} \right).$$
(59)

A corresponding inequality holds for  $|I_{0Y}|$  with  $|E_{Y0}|_{r \to \infty}$  replacing  $|E_{X0}|_{r \to \infty}$ . At first sight, one may raise the objection that the reference plane for  $\delta$  cannot necessarily be chosen so that both eq. (48) and the corresponding equation with  $E_{0Y}$  are satisfied simultaneously. It should be noted, however, that the two equations need not be satisfied simultaneously. It is only necessary that one reference plane <u>can</u> be found that allows eq. (48) to hold, and that a second reference plane <u>can</u> be found that allows the corresponding equation with  $E_{0Y}$  to hold. If the two reference planes are a slight distance apart, the relative phase of the x and y components of the far-electric-field will be in slight error but not the Hermitian amplitude of the far-electric-field, i.e., the far-field pattern will remain unchanged even though the far-field polarization ratio will be shifted slightly.

Eq. (59) and the corresponding equation for  $|I_{oy}|$  combine with eq. (50) to give an expression for the maximum position error n in the far-field:

$$\eta(\overline{r}) \leq \left(\frac{\pi \alpha \Delta P_{\max} L_{O}^{\max}}{2 A} + \frac{1}{2} \delta_{\max}^{2}\right) \qquad \theta < \frac{\lambda}{10 L_{O}^{\max}} \quad (\text{sum patterns}).$$
(60a)

Equation (60a) was derived assuming the antenna was operating in a sum pattern and does not apply to difference patterns since eq. (48) may not be satisfiable for difference patterns. However, in Appendix B it is shown that an error expression similar to eq. (60a) may be derived near the boresight direction (null axis) of difference patterns as well. Specifically,

$$m(\overline{r}) \leq \left(\frac{\pi \alpha \Delta P_{\max} L_{o}^{\max}}{2 A} + 4 \Delta F \delta_{\max}\right) g(\overline{r}), \ \theta < \frac{\lambda}{10 L_{o}^{\max}} \begin{array}{c} \text{(difference)} \\ \text{pattern)} \end{array}$$
(60b)

where  $\Delta F$  and  $g(\overline{r})$  are defined below after eq. (61).

Finally for the angular region  $\theta > \lambda/10 L_0^{max}$ , but still less than  $2\lambda/L_0^{max}$  (see eqs. (37) and (38)), we can derive an upper bound expression similar to eq. (60a). Specifically, the magnitude of  $I_{ox}$ in eq. (47) may be written

$$|I_{ox}| \leq \int_{A_o} |\Delta \overline{r} \cdot \nabla |E_x| | d\overline{P} + \frac{1}{2} \int_{A_o} |\delta E_{ox}| d\overline{P}.$$

The term second order in  $\delta$  has been ignored since now the first order term in  $\delta$  is the major contributor to the z-displacement error. When we carry the analysis through in a way similar to that described between eqs. (51) to (59), the following expression for the fractional error for both sum and difference patterns results:

$$n(\overline{r}) \leq \left(\frac{\pi \alpha \Delta P_{\max} L_{o}^{\max}}{A} + \delta_{\max}\right) \frac{g(\overline{r})}{2} \quad \frac{\lambda}{10 L_{o}^{\max}} < \theta < \frac{2\lambda}{L_{o}^{\max}} \quad (60c)$$

Although eq. (60c) was derived for  $\theta < 2\lambda/L_0^{max}$ , it remains valid as an upper-bound expression all the way to  $\theta = \pi/2$ . This result follows from the fact, which will not be proven here, that the contribution from the integration in eq. (37) outside the area  $A_0$  is negligible compared to the upper-bound contribution obtained from inside  $A_0$  and expressed by eq. (60c). (It is interesting to note that the maximum possible errors in even the far sidelobes are determined by the displacement errors across  $A_0$ , whereas the field itself in the far sidelobe region is determined by the near-field outside  $A_0$ .)

Thus, if we combine eqs. (60a), (60b), and (60c); insert the approximations,  $L_{o}^{\max} \approx \ell^{\max}$ ,  $A \approx (\ell^{\max})^2$  into eqs. (60); and let  $\Delta_{\max} = \frac{2\pi\Delta P_{\max}}{\lambda}$ ; an upper-bound expression for  $\eta$  valid over the entire far-field hemisphere emerges

$$\eta(\bar{\mathbf{r}}) \leq \left\{ \frac{\alpha\lambda}{2\lambda^{\max}} \Delta_{\max} + \eta_z \right\} \frac{g(\bar{\mathbf{r}})}{2}$$

$$\eta_z = \begin{cases} \delta_{\max}^2 & (\text{sum patterns}) \\ 8\Delta F \delta_{\max} & (\text{difference patterns}) \end{cases} \frac{\theta < \frac{\lambda}{10\lambda^{\max}}}{10\lambda^{\max}} \\ \delta_{\max} & (\text{sum and difference } \frac{\lambda}{10\lambda^{\max}} < \theta < \frac{\pi}{2} \end{cases}$$

$$(61)$$

where

 $\lambda$  = wavelength.

 $l^{max}$  = maximum width of the antenna aperture.

- $\Delta_{\max} = 2\pi\Delta P_{\max}/\lambda, \text{ where } \Delta P_{\max} \text{ is the maximum amplitude of the trans$ verse displacement errors within the partial scan area A<sub>0</sub>.(A<sub>0</sub> is that part of the scan area over which the phase isfairly uniform. For near-field scans parallel to the aper $ture A<sub>0</sub> <math>\approx$  A, the aperture area.)
- $\delta_{\max} = 2\pi\Delta z_{\max}/\lambda$ , where  $\Delta z_{\max}$  is the maximum amplitude of the longitudinal displacement errors within the partial scan area A<sub>0</sub>.
- $\alpha$  = a "taper" factor -- equal to a minimum of 1.0 (for apertures of uniform amplitude and phase) and less than 5 for most tapered distributions found in practice. (See eq. (31) for the precise definition of  $\alpha$ ; for a difference pattern one should still use the taper factor of the constituent sum patterns.)
- $g(\overline{r})$  = ratio of the amplitude of the maximum far-electric-field to the far-electric-field at the given direction  $\overline{r}$ , i.e., the inverse of the normalized far-field pattern.  $(g(\overline{r}) = 1$  for

the center of the main beam, or beams if a difference pattern.) (If desired, the errors in the gain function, sidelobe level, polarization ratio, and beamwidth may be calculated from eqs. (2)-(5) once  $\eta$  and the far-field pattern are known.)

The expression (61) represents an upper bound to the far-field error n caused by inaccuracies in the position of the near-field scanner. It applies to both sum and difference patterns in the entire forward hemisphere of all electrically large aperture antennas. Equation (61) was derived under the assumption that the scan plane is parallel or nearly parallel to the near-field planes of "uniform" phase, i.e., the plane perpendicular to the electrical boresight direction.

In addition, eq. (61) holds for arbitrary (random as well as systematic) errors in the positioning of the scanner, since only the

maximum magnitude of displacement errors  $\Delta_{\max}$  and  $\delta_{\max}$  are required to evaluate eq. (61). However, it proves useful to derive an expression similar to eq. (61) which separates the effects of the systematic and random errors in position.

To do this and also clarify what is meant by systematic and random errors, consider the motion of the scanner as it takes measurements along lines in the near-field plane. As the scanner moves along each line it will deviate from a perfectly straight-line by a gently varying curve that will contain at most a few oscillations from one end of the scan line to the other. These curves, which may also change gently from scan line to scan line, represent the systematic errors in position of the scanner. For example, a slight warp or deformation of the scanner frame would create a systematic error.

Superimposed upon the systematic deviations from the straightline would be position errors which changed randomly (within limits) from measurement point to measurement point. These random errors in position have zero or nearly zero mean and could result, for example, from vibrations of the entire scanner or from a slight play in the drive mechanisms. The maximum magnitude of the random errors are often smaller than that of the systematic errors. However, it is possible that the scanner is aligned so precisely, that essentially all but the random errors are eliminated.

Return to eq. (47) and separate  $\Delta \overline{P}$  and  $\delta$  into systematic and random displacement errors, i.e.,

$$\Delta \overline{P} = \Delta \overline{P}^{S} + \Delta \overline{P}^{rn}$$
(63a)  

$$\delta = \delta^{S} + \delta^{rn}.$$
(63b)

All the integrals in eq. (47) which contain linear terms in  $\Delta \overline{P}^{rn}$  or  $\delta^{rn}$  can be dropped. Since  $\Delta \overline{P}^{rn}$  and  $\delta^{rn}$  change randomly from measurement point to measurement point (over distances less than  $\lambda/2$ ), the integrals actually summations -- see footnote 3a) containing these linear terms will be extremely small compared to the largest possible errors produced by the remaining integrals (summations). Thus, substituting eqs. (63) into eq. (47) and proceeding as we did before with eq. (47), yields the desired expression for  $\eta$  separated into

systematic and random errors,

$$n(\bar{r}) \leq \left(\frac{\alpha\lambda}{2\lambda^{\max}} \Delta_{\max}^{S} + \eta_{z}^{S}, rn\right) \frac{g(\bar{r})}{2}$$

$$n_{z}^{S}, rn_{z}^{S} = \begin{cases} (\delta_{\max}^{S})^{2} + (\delta_{\max}^{rn})^{2} \text{ (sum patterns)} \\ 8\Delta F \delta_{\max}^{S} \text{ (difference patterns)} \end{cases} \quad \theta < \frac{\lambda}{10\lambda^{\max}} \\ \delta_{\max}^{S} \text{ (sum and difference } \frac{\lambda}{10\lambda^{\max}} < \theta < \frac{\pi}{2} \end{cases}$$

$$(64)$$

All symbols have the same definitions found after eq. (61). The superscripts "s" and "rn" refer to "systematic" and "random" errors respectively.

Note from eq. (64) that to the given order of approximation the longitudinal random errors ( $\delta^{rn}$ ), but not the transverse random errors ( $\Delta^{rn}$ ), cause an error in the on-axis far-field of sum patterns (provided, of course, that  $\Delta^{rn}$  is of the same order of magnitude or less than  $\delta^{rn}$ ). In addition, eqs. (64) and (61) above show that the maximum possible transverse (xy) position errors do not depend upon wavelength for a given  $g(\bar{r})$  since  $\Delta_{max}$  behaves as  $1/\lambda$ . Also note that in expressions (64) and (61) above, the z-position error is not continuous across the angle  $\theta = \lambda/10\ell^{max}$ . There lies no contradiction in this fact since the expressions remain valid as inequalities. The jump between the two regions merely indicates that the upper-bound was determined by a different method in each region. Obviously expressions (61) and (64) do not represent a least upper-bound throughout the region  $\theta > \lambda/10\ell^{max}$ . This region will be discussed further at the end of the section.

One can get an idea of the magnitude of the position errors by plotting the on-axis gain from eqs. (64) and (2c) for the fixed-beam constrained lens array described in the paragraph following eq. (34) and shown in figure 9. In that case,

 $\lambda/\ell^{\max} = .04$  $g(\overline{r}) = 1,$ 

and with  $\alpha$  equal to 3, eq. (64) combines with eq. (2c) to give

$$\eta_{G}^{dB} \leq \pm 8.7 \left( .03 \ \Delta_{max}^{S} + \frac{1}{2} (\delta_{max}^{S})^{2} + \frac{1}{2} (\delta_{max}^{rn})^{2} \right).$$
(65)

If we assume  $\delta_{\max}^{rn} = 0$  and let  $\delta_0 = \delta_{\max}^{S} = \Delta_{\max}^{S}$ , eq. (65) may be written

$$n_{\rm G}^{\rm dB} \le \pm 8.7 \, \delta_{\rm o} (.03 + \frac{1}{2} \, \delta_{\rm o}) \, .*$$
 (66)

The solid curve in figure 10 depicts the maximum value of  $\eta_G^{dB}$  in eq. (66) versus  $\delta_0$ , i.e. when the random errors are negligible. The dashed line represents the maximum error  $\eta_G^{dB}$  when the  $\Delta_{\max}^{S} = \delta_{\max}^{S} = 0$ and  $\delta_0 = \delta_{\max}^{rn}$ , i.e., when the systematic errors are negligible.

To insure that the on-axis gain is less than .01 dB for this particular antenna,  $\delta_0$  must be less than about .027. That is, each component of systematic displacement error of the scanner must be less than .027  $\lambda/2\pi$ , or less than about .004 $\lambda$ . For this constrained lens antenna  $\lambda = 3.26$  cm, so the errors in each component of displacement must be less than about .14 mm for better than .01 dB accuracy in the on-axis far-field.

For random errors only (the dashed line) the z-displacement errors must be less than about .26 mm for .01 dB accuracy in the on-axis far-field for this particular wavelength. As a matter of fact, when the systematic errors are negligible, eq. (64) shows that the "random" error in gain  $\eta_{G,rn}^{dB}$  for the sum-pattern main-beam of an arbitrary (electrically large aperture) antenna can be written simply as

$$\eta_{G,rn}^{dB} \leq \pm \frac{8.7}{2} (\delta_{max}^{rn})^{2} \star (\delta_{max}^{rn} = 2\pi\Delta z_{max}^{rn}/\lambda)$$
(67)

For  $\eta_{G,rn}^{dB} \leq \pm .01$ ,  $\delta_{max}^{rn}$  must be less than about .05 radians or  $\Delta z_{max}^{rn}$ less than .008 of a wavelength (3 degrees). That is, the random errors in z-position should be no greater than about  $\pm .01\lambda$  to insure a .01 dB accuracy in the gain of the main beam. Equation (67) reveals that the random error in the on-axis far-field gain of sum patterns increases as the square of the random error in the

<sup>\*</sup>Actually, as mentioned above, the z-position or phase errors always lower (under the stated assumptions) the on-axis gain of sum patterns, but the + sign will be included throughout to keep the same form to all the error expressions.

z-position of the near-field scanner. For example, a position error of  $\pm .025\lambda \simeq 10^{\circ}$  (@ 3.125 x .008 $\lambda$ ) leads to a maximum  $\eta_{G,rn}^{dB}$  of about  $\pm .1 \ dB$  (@(3.125)<sup>2</sup> x .01) for the center of the main beam.

To date, little experimental data are available with which to compare the results of eqs. (61), (64) or (67). However, a comparison can be made between eq. (67) and the computations performed by Rodgrigue, Joy, and Burns [16]. They introduced errors into a hypothetical near-field distribution in order to compute the effects of the errors on the far-field. The results of their computations for the effect of random phase errors (or equivalently z-position errors) on on-axis gain are plotted in figure 3-14 or A-21 of [16], and are reproduced here by the dashed line in figure 11 below. The solid line is  $\eta_{G,rn}^{dB}$  plotted from eq. (67). One can see from figure 11 that the two curves are in close agreement. The solid line lies slightly above the computed dashed line as indeed it should if eq. (67) represents an upper bound.

Figure 12, which will be explained in greater detail below under instrumentation errors, shows a comparison between the effects on the on-axis gain of a sum pattern from systematic (quadratic in this case) phase errors introduced into actual near-field data by Newell [17,21] and the corresponding upper-bound results calculated from eq. (64). Again agreement is close, with the upper-bound curve lying just above the actual curve for small deviations in phase.

Next, let's calculate the effect of systematic z-displacement errors on the depth of the null for an antenna operaing in a difference pattern. From eq. (64)

$$\eta_{G,s}^{dB} \leq \pm 35 \Delta F \delta_{max}^{s} g(\overline{r}),$$

where  $g(\overline{r})$  is no longer equal to unity because  $\overline{r}$  is in the direction of the boresight null. Typically,  $\Delta F$  is about .01 and the depth of the null is 25 dB down from the main beams of the difference pattern. Thus

> $g(\overline{r}) \simeq 10^{5/4} \simeq 18,$  $\eta_{G,s}^{dB} \leq \pm 6.3 \delta_{max}^{s}$

and

for the null depth. For example, if  $\Delta z_{max}^{rn} = .01\lambda$  (which would correspond to an accuracy of about .27 dB for the main beams) eq. (68) insures that the null depth would be accurate to within .40 dB. This surprisingly high insensitivity of the null depth to z-displacement errors (or, equivalently, phase errors) has been observed by Newell [21] upon introducing phase errors into the measured near-field data of a number of antennas operating in the difference mode. To understand the reasons for this high accuracy in null depth, one must refer to the derivation in Appendix B. There appears to be no simple way to explain this result heuristically.

It is also found in Appendix B that the maximum shift  $\theta_{shift}$  in the direction of the far-field null of a difference pattern caused by z-position errors is given by the simple expression which is not a function of wavelength:

$$\theta_{\text{shift}} \leq \frac{4\Delta z_{\text{max}}^{S}}{\ell^{\text{max}}} = \frac{2\lambda}{\pi \ell^{\text{max}}} \delta_{\text{max}}^{S} \text{ radians.}$$
(68)

In general, the shift in the null caused by all other sources of error are negligible compared to this shift caused by the z-position error or, equivalently, the phase errors.

Table 2 lists the upper-bound position errors in a number of far-field parameters for a typical X-band and K-band antenna. The values in the table were calculated from expressions (61) and (68). As eqs. (61) and (64) show, the maximum possible transverse (xy) position errors do not depend upon frequency for a given  $g(\overline{r})$ . Table 2 also shows quite dramatically that the z-position or phase errors everywhere except in the boresight direction can be extremely large compared to all other representative sources of error -- compare Tables 1-4. (This is also true of the shift in the difference pattern null.) Especially note that the error in a -25 dB sidelobe can be several dB for phase errors  $(2\pi\Delta z_{max}/\lambda)$  of just a few degrees. Whether or not these maximum possible far-field errors are actually experienced in practice depend strongly upon the shape of the nearfield z-position or phase error throughout the scan area. For example, we shall find in the next section that receiver phase distortion usually has a functional dependence which introduces

negligible errors into the sidelobe fields. It is important to know exactly what effect various distributions of near-field phase errors have on the far-field in order to avoid experimentally, if possible, the distributions which produce large far-field errors in the directions of interest. Such a detailed study of the dependence of the far-field errors on the functional form of the nearfield z-position or phase errors will not be included as part of this report but will be contained in a forthcoming report by Newell [21].

## 2. Instrumentation Errors

The amplitude and phase of the probe output are measured at discrete points as the probe moves back and forth across the nearfield scan area. The receivers are capable of sampling and recording the amplitude and phase to within a certain accuracy only. The errors in the near-field data, caused by the inaccuracies in the receivers or instrumentation used to measure the probe output, produce errors in the computed far-field. This section estimates the far-field errors under given limits of accuracy of the instrumentation which measures the amplitude and phase of the probe output. It is emphasized that the errors produced by the imperfect positioning of the scanner were determined in the previous section and are not considered as part of the instrumentation error analysis of this section. Also the instrumentation errors associated with converting analogue to digital information is assumed negligible.

Under the conditions explained in Section III.B, the far-field errors can be found in the region

$$\theta < \lambda / (10 \ell^{\text{max}})$$

by evaluating the integral (39)

$$\overline{I}_{o} = \int_{A_{o}} \Delta \overline{E}_{t}(\overline{P}, d) d\overline{P}.$$

Here,  $\Delta \overline{E}_t(\overline{P},d)$  represents the difference between the measured  $(\overline{E}_t^{meas})$  and "actual"  $(\overline{E}_t)$  output of the probe at the point  $(\overline{P},d)$ , i.e.

$$\Delta \overline{E}_{t}(\overline{P},d) = \overline{E}_{t}^{\text{meas}}(\overline{P},d) - \overline{E}_{t}(\overline{P},d).$$
(69)

If we look at just the x-component first, the integral  $\overline{I}_0$  and eq. (69) combine to give

$$I_{ox} = \int_{A_o} (E_x^{\text{meas}} - E_x) d\overline{P}.$$
 (70)

By writing

$$E_{x} = |E_{x}|e^{i\phi_{x}}$$
(71a)

and

$$E_{x}^{\text{meas}} = [|E_{x}| + \Delta A_{x}^{I}]e^{i(\phi_{x} + \Delta \phi_{x}^{I})}, \qquad (71b)$$

where  $\Delta A_x^I$  and  $\Delta \phi_x^I$  are the errors in amplitude and phase respectively introduced by the measuring instrumentation, eq. (70) becomes

$$I_{ox} = \int_{A_o} [(|E_x| + \Delta A_x^{I}) e^{i\Delta \phi_x^{I}} - |E_x|] e^{i\phi_x} d\overline{P}.$$
(72)

In general, both  $\Delta A_x^I$  and  $\Delta \phi_x^I$  are functions of the transverse coordinates  $\overline{P}$ . For small errors  $\Delta \phi_x^I << 1$ , so that

$$e^{i\Delta\phi_X^{I}} \approx 1 + i\Delta\phi_X^{I} - \frac{(\Delta\phi_X^{I})^2}{2} + \cdots$$

and

$$F_{\text{ox}} = \int_{A_0} [\Delta A_x^{\text{I}} + i(|E_x| + \Delta A_x^{\text{I}}) \Delta \phi_x^{\text{I}} - \frac{|E_x|}{2} (\Delta \phi_x^{\text{I}})^2] e^{i\phi_x} d\overline{P}.$$
(73)

All terms higher than second order have been neglected in eq. (73). If a sum pattern is assumed and the exponential  $e^{i\phi_X}$  is written as in eq. (47),

$$e^{i\phi_{x}} = e^{i(kd+\phi_{ox})}(\cos\Delta\phi_{x} + i\sin\Delta\phi_{x}),$$

with the arbitrary phase constant  $\phi_{\text{ox}}$  chosen as in eq. (47), then to a high probability, the integration in eq. (73) which is multiplied by the oscillating quantity  $\sin \Delta \phi_x$  can be neglected compared to the maximum possible value of the  $\cos\Delta\phi_{\rm X}$  integration. (Note the distinction between  $\Delta\phi_{\rm X}$  and  $\Delta\phi_{\rm X}^{\rm I}$ .  $\Delta\phi_{\rm X}$  is the actual variation in phase of the x-component of electric field within  $A_{\rm o}$ , whereas  $\Delta\phi_{\rm X}^{\rm I}$  is the error in phase introduced by the phase measuring instruments.) In addition, since  $(|E_{\rm X}| + \Delta A_{\rm X}^{\rm I})\cos\Delta\phi_{\rm X}$  is always greater than zero for sum patterns, the reference phase for the instrumentation phase error  $\Delta\phi_{\rm Y}^{\rm I}$  can be chosen to make

$$\int_{A_{O}} (|E_{X}| + \Delta A_{X}^{I}) \Delta \phi_{X}^{I} \cos \Delta \phi_{X} = 0, \qquad (74)$$

which again expresses essentially the same condition as that chosen by Ruze [15] in his work on antenna tolerance theory. Under the above conditions, the imaginary term within the brackets of eq. (73) is eliminated and the magnitude of I<sub>ox</sub> reduces to

$$|I_{0X}| = |\int_{A_0} [\Delta A_X^{I} - \frac{|E_X|}{2} (\Delta \phi_X^{I})^2] \cos \Delta \phi_X d\overline{P}|$$

$$\leq \int_{A_0} |\Delta A_X^{I}| d\overline{P} + \frac{1}{2} (\Delta \phi_{xmax}^{I})^2 \int_{A_0} |E_X| d\overline{P}.$$
(75)

 $\Delta \phi_{\text{xmax}}^{1}$  is the maximum value (in absolute value) of the instrumentation phase error within the partial scan area  $A_{0}^{1,10}$ .

Since it can be shown that (see eq. (10), (30b) or (52))

$$\int_{A_{o}} |E_{x}| d\overline{P} \simeq \lambda r |E_{xo}|_{r \to \infty}$$
(76)

where  $|E_{x0}|_{r\to\infty}$  is the magnitude of the maximum x-component of farfield,  $|I_{0x}|$  may be rewritten

<sup>&</sup>lt;sup>10</sup>Because the errors in measuring phase are usually greatest at points in the scan area where the amplitude is least, it is desirable to choose the partial scan area  $A_0$  as small as possible when estimating  $\Delta \phi_{\rm Xmax}^{\rm I}$ . The far-field within  $\theta < 2\lambda/\ell^{\rm max}$  is hardly effected by the near-field outside that part of the scan area where the amplitude of electric field is equal to the edge taper down from the maximum amplitude. Thus for the sake of designating maximum errors in phase measurement on a near-field scan plane, the area  $A_0$  need be chosen no larger than this effective "edge taper" scan area.

$$|I_{ox}| \leq \int_{A_o} |\Delta A_x^{I}| d\overline{P} + \frac{1}{2} (\Delta \phi_{xmax}^{I})^2 \lambda r |E_{xo}|_{r \to \infty}.$$
 (77)

It is usually possible to express the errors in amplitude in dB per dB change of amplitude. That is, the receivers are assumed to read the correct (zero error) amplitude of the probe output at its maximum value point on the area  $A_0$ . At all other points the amplitude lies a certain number of dB down from its maximum value. Typically the dB errors in measuring the amplitude are linearly related to this number of dB down from the maximum amplitude, and thus the errors can be expressed in dB per dB down. Even if the actual amplitude error curve is not linear, for the sake of the upper bound expression (77), it can be replaced by a straight line (linear curve) which is equal to or greater than the actual error curve.

Specifically, if  $N_{dB}^{I}$  designates the amplitude error in the number of dB per dB down, and  $A_{dB}$  the amplitude in dB down from the maximum amplitude,  $\Delta A_{x}^{I}$  can be expressed as (for small errors)

$$|\Delta A_{x}^{I}| = |E_{x}| N_{dB}^{I} A_{dB}/8.7$$
 (78)

By definition

$$A_{dB} = 20 \log \frac{E_{x0}}{|E_x|} \le 8.7 \left(\frac{E_{x0}}{|E_x|} - 1\right),$$
 (79)

where  $E_{x0}$  denotes the maximum of  $|E_x|$  on the scan area. Substitution of eq. (79) into eq. (78) and the result into eq. (77) yields

$$|I_{ox}| \leq N_{dB}^{I} \int_{A_{o}} (E_{xo} - |E_{x}|) d\overline{P} + \frac{1}{2} (\Delta \phi_{xmax}^{I})^{2} \lambda r |E_{xo}|_{r \to \infty}.$$
(80a)

With the help of eqs. (57) and (76), eq. (80a) becomes

$$|I_{ox}| \leq \left[N_{dB}^{I}\left(\frac{\alpha A_{o}}{A} - 1\right) + \frac{1}{2}(\Delta \phi_{xmax}^{I})^{2}\right]\lambda r |E_{xo}|_{r \to \infty}.$$
 (80b)

By combining eq. (80b) and the corresponding equation for  $|I_{oy}|$  with eq. (50), assuming  $E_{yo} \approx E_{xo}$ , and approximating  $\frac{A_o}{A}$  by 1, the upper-bound expression for the fractional far-field error n caused by the

instrumentation is obtained:<sup>11</sup>

$$\eta(\overline{r}) \leq [N_{dB}^{I}(\alpha-1) + \frac{1}{2}(\Delta \phi_{max}^{I})^{2}] \quad \theta < \frac{\lambda}{10\ell^{max}} \text{ (sum patterns). (81)}$$

Equation (81), which is analagous to the position error equation (60a), holds only for sum patterns within an angle  $\lambda/(10l^{max})$  of the boresight direction. For difference patterns as well, and for  $\theta > \lambda/(10l^{max})$ , the following upper bound expression analagous to the position error equation (61) applies:



where

λ

= wavelength.

N<sup>I</sup><sub>dB</sub> = the maximum instrumentation errors involved in measuring the amplitude of the probe output -- N<sup>I</sup><sub>dB</sub> is expressed in dB error per dB amplitude down from the maximum amplitude on the scan area. (For the present purposes, the amplitude error is designated as zero at the maximum amplitude.)

11When the maximum value of the probe output on the scan area for the x-orientation is very different from that of the y-orientation  $(E_{yo} \neq E_{xo})$ , it can be shown that eq. (81) remains valid as an upper bound for the errors in magnitude of the far-field. But for errors in polarization ratio an extra term,  $N_{dB}^{I}|x_{p}|/8.7$ , must be added to eq. (81), where  $x_{p}$  is the difference between the maximum probe outputs measured in dB for the two orientations.

 $\Delta \phi_{\text{max}}^{1}$  = the maximum instrumentation errors (expressed in radians) involved in measuring the phase of the probe output on the effective scan area A<sub>0</sub> (see footnotes 10 and 13).

 $\Delta F$ 

α

 = fractional difference between the amplitude of the two main far-field lobes of the difference pattern (see Appendix B).
 = a "taper" factor -- equal to a minimum of 1.0 (for apertures

- of uniform amplitude and phase) and less than 5 for most tapered distributions found in practice. (See eq. (31) for the precise definition of  $\alpha$ ; for a difference pattern one should still use the taper factor of the constituent sum patterns.)
- g(r) = ratio of the amplitude of the maximum far-electric-field to
   the far-electric-field at the given direction r, i.e., the
   inverse of the normalized far-field pattern. (g(r) = 1 for
   the center of the main beam, or beams if a difference pattern.)

  &max = maximum width of the antenna aperture.

A = area of antenna aperture.

The derivation of  $\eta_z^{I}$  is identical to that done for z-position errors in Section III.B.1. The derivation of  $\beta^{I}$  for  $\frac{\lambda}{10\ell^{max}} < \theta < \frac{2\lambda}{\ell^{max}}$  is accomplished by the same procedure used above for  $\theta < \lambda/(10\ell^{max})$ . In the far sidelobe region,  $\theta > 10\lambda/\ell^{max}$ , the far-field errors become approximately equal to the corresponding errors in the nearfield amplitude, and after using eqs. (30b), (31), and (79)  $\beta^{I}$  in this region can be written as shown in eq. (82). Between  $\theta$  equal to  $2\lambda/l^{\max}$  and  $10\lambda/l^{\max}$  the value of  $\beta^{I}$  can be estimated by connecting a straight line from its value at  $2\lambda/\ell^{max}$  to its value at  $10\lambda/\ell^{max}$ .  $\beta^{1}$  near the boresight direction  $\theta < \lambda/(10\ell^{max})$  of difference patterns is derived in Appendix B. (Note that the error factor  $\beta^{I}$  is generally much smaller near the boresight direction or null axis of difference patterns than near the center of the main beam of sum patterns. This result occurs, as Appendix B shows, because the instrumentation distorts the amplitude on the "positive" and "negative" sides of a difference pattern by approximately the same amount.) Appendix B also shows that we can write an upper-bound expression for the null shift of difference patterns caused by the instrumentation errors:

 $\theta_{\text{shift}} \leq \frac{2\Delta \phi_{\max}^{\mathrm{I}} \lambda}{\pi \ell^{\max}} \text{ radians.}$ 

(83)

Equation (83) is identical to eq. (68) with the instrumentation phase error replacing the z-position error.

Equation (82) represents an upper bound to the far-field errors produced by the instrumentation which measures the amplitude and phase of the probe output. It applies to either sum or difference patterns in the forward hemisphere of all electrically large aperture antennas. As with eq. (61), eq. (82) was derived for scan planes which are parallel or nearly parallel to the plane perpendicular to the electrical boresight direction. (If desired, the errors in the gain function, sidelobe level, polarization ratio, and beamwidth may be calculated from eqs. (2)-(5) once  $\eta$  and the far-field pattern are known.)

A comparison of eq. (82) with eq. (61) shows that the instrumentation phase error  $\Delta \phi_{max}^{I}$  in eq. (82) has taken the place of  $\delta_{max}$  in eq. (61). This result acts as a check on eqs. (61) and (82) because  $\delta_{max}$  simply represents a phase error caused by a z-displacement error in the position of the scanner.<sup>12</sup> Also,  $\Delta \phi_{max}^{I}$  can be separated into a random and systematic part to get a result analagous to eq. (64). However, the random phase errors introduced by the instrumentation are usually much smaller than the systematic phase errors, and thus can usually be neglected.

Figure 11 reveals that the phase  $(\Delta \phi_{max}^{I})$  part of eq. (82) for the on-axis gain of a sum pattern is in good agreement (as an upper bound) with the computer error analysis performed by Rodrigue, Joy and Burns [16] on a hypothetical near-field distribution with random phase errors. Newell [17,21] has introduced phase errors which are quadratic with respect to the xy coordinates, into the actual nearfield data of the 60 GHz, 46 cm (18 inch) reflector antenna whose

12<sub>Note</sub> that the "phase error terms" in eqs. (61) and (82) for sum patterns and  $\theta < \lambda/(10 \ell^{max})$  depend on the square of  $\delta_{max}$  and  $\Delta \phi_{max}$ respectively. Thus, these two squared terms should not be added directly when estimating the total error in the far-field. Instead,  $\delta_{max}$  should be added to  $\Delta \phi_{max}^{I}$  before the square is taken. near-field amplitude envelope is shown in figure 7b. The resulting errors in  $n_G^{dB}$  for on-axis gain computed by Newell are shown with the dashed line in figure 12. The solid line represents the maximum phase error plotted from eqs. (82) and (2c). Again it appears that the expression (82) represents a useful upper bound estimate for the instrumentation phase errors in on-axis gain, especially when the measured phase is accurate to within a few degrees across the effective scan area  $A_0$  (as is usually the case in practice).

The accuracy with which the receiver can measure the phase of the probe output is related to the amplitude of the probe output. Specifically, the smaller the amplitude the larger the phase errors usually become (see footnote 10). For example, a typical receiver used at the NBS near-field range measures phase to within ± .001 radians (± .05°) at the maximum amplitude on the near-field scan plane, and ± .01 radians (.5°) at an amplitude 20 dB down from the maximum. Thus, for an edge taper 20 dB down,  $\Delta \phi_{max}^{I} = .01$ , and eq. (82) shows that the error in the main beam of a sum pattern caused by the errors in measuring the phase of the probe output are negligible  $(n_G^{dB} = \frac{\pm 8.7}{2} (.01)^2 < \pm .001 \text{ dB}).^{13}$  The same is true for the null depth and shift of difference patterns. Of course, the errors in sidelobe level could be affected to a greater extent by the phase errors, depending on the shape and distribution of the phase errors across the scan area. However, since receiver phase errors usually increase monotonically with decreasing amplitude, it can be shown as a consequence [21] that the upper-bound off-axis or sidelobe phase errors  $(\Delta \phi_{max}^{1}/2 g(\overline{r}))$  given in eq. (82) represents a much larger error in far-field than would usually occur in practice. Thus, in general, receiver phase errors have a relatively small effect over the entire far-field of sum or difference patterns. In fact, compared to the maximum possible effect that typical z-position errors can have on the off-axis far-fields, instrumentation phase errors can be ignored completely in the off-axis region.

<sup>&</sup>lt;sup>13</sup>Even for aperture antennas with edge tapers greater than 20 dB down, it is unlikely that the near-fields outside these -20 dB points (or even the -15 dB points) have a significant effect on the maximum possible far-field errors. In other words, regardless of how large the edge taper, the effective scan area  $A_0$  need not extend beyond about the -15 or -20 dB points.

For receivers which measure phase with high accuracy, the phase part of the instrumentation error can be neglected and only the amplitude error remains in eq. (82), i.e.

$$\eta(\overline{r}) \leq N_{dB}^{I}(\beta^{I}) g(\overline{r}).$$

Amplitude errors for  $\theta < 2\lambda/\ell^{max}$  do not depend directly on frequency or the size of the antenna, only on the taper factor  $\alpha$  of the nearfield beam, the receiver inaccuracy  $N_{dB}^{I}$ , and the inverse of the normalized far-field pattern  $g(\bar{r})$ . (For null depth of a difference pattern the amplitude errors are extremely small and do not even involve  $g(\bar{r})$ . These results are proven in Appendix B.) Also, in the far sidelobe region,  $\theta > 10\lambda/\ell^{max}$ , the instrumentation amplitude errors are relatively small, usually less than a few tenths of a dB for  $N_{dB}^{I}$  less than a few thousands of a dB per dB. The far-field error in the on-axis  $(g(\bar{r}) = 1)$  gain for sum patterns is found from the above equation and (2c) to be

$$\eta_{\rm G}^{\rm dB} \le \pm 8.7 \, N_{\rm dB}^{\rm I}(\alpha-1).$$
 (84)

Note that for  $\alpha$ =1 (uniform amplitude distribution) the far-field error, caused by the instrumentation errors in measuring near-field amplitude, equals zero--as it should since the receivers measure essentially at a constant amplitude across the effective scan area.

The maximum error in on-axis gain (eq. (84)), which is linear with respect to  $N_{dB}^{I}$ , is plotted with the solid lines in figure 13 for different values of  $\alpha$ . Rodrigue et al. [16] have also computed linear amplitude errors for their hypothetical near-field distribution, which has an  $\alpha$  exactly equal to 3.0. Their results (see figures 3-5 or A-5 of [16]) are reproduced by the dotted line in figure 13. The errors computed by Rodrigue et al. and the maximum errors predicted by the analytically derived expression (84) are in good agreement. The solid line for  $\alpha$ =3 lies above the dotted line -as it must if eq. (84) represents a valid upper bound expression for the errors.

To insure an on-axis gain error less than ± .01 dB, the error in measuring the near-field amplitude should be kept less than about ± .001 dB per dB down. Unfortunately, the accuracy of most receiver systems is of the order of  $\pm$  .01 dB per dB down (rather than  $\pm$  .001) which, according to figure 13, can lead to errors in the on-axis gain of about  $\pm$  .1 dB. This value of far-field error can be larger than the errors from all other sources combined. Thus, if high accuracy is desired, special effort should be devoted to designing a receiver system which can measure the amplitude of the probe output to better than  $\pm$  .001 dB per dB down. Alternatively, the amplitude calibration curve for the receivers could be determined to within  $\pm$  .001 dB per dB down and the errors in amplitude compensated for by including the calibration curve as part of the computer program that deconvolutes the near-field data.

This latter correction procedure has been adopted by A.C. Newell et al. at the National Bureau of Standards. The difference between the on-axis gain computed by Newell [17,21] with and without the amplitude calibration curve is shown by the dashed line in figure 13 for the 46 cm (18 in) reflector antenna operating at 60 GHz. (Actually, Newell found a .112 dB on-axis gain difference for an amplitude calibration curve that deviated by at most .02 dB per dB down over the effective scan area. The dashed line in figure 13 assumes linearity and simply connects the origin to the point .112 dB at .02 dB per dB.) The value of  $\alpha$  for this antenna was estimated at 2 from the measured near-field data shown in figure 7b. Again it is seen from figure 13 that the computed errors for this particular antenna correspond quite well with the maximum possible errors predicted by the general expression (84) for  $\alpha = 2$ .

In brief, the computations of both Rodrigue et al. and Newell indicate that eq. (82) yields reasonable values for the maximum farfield errors expected from instrumentation errors in measuring the amplitude and phase of the probe output.

Table 3 lists some representative far-field amplitude errors calculated from eq. (82) for an antenna with taper factor  $\alpha$  equal to 3, and a receiver nonlinearity in measuring amplitude  $(N_{dB}^{I})$  equal to .002 dB per dB. Note the extremely small effect that amplitude errors have on the null depth of difference patterns. As Appendix B shows, this small effect on the null depth is due to the fact that the receiver which measures the amplitude of the probe output distorts the opposite sides of the near-field difference pattern by approximately the same amount.

## C. Multiple Reflections

Consider a probe which scans on a plane in the near-field of a radiating test antenna. The radiation that the probe receives can be described by an infinite series of rapidly decreasing terms, with the first term equal to the unperturbed field of the test antenna. This unperturbed field scatters from the probe, reflects from the test antenna and other nearby objects, and returns to the probe to give the second term in the series. The return radiation again scatters from the probe, reflects, and returns to the probe to yield the third term. The process repeats ad infinitum.

In order to determine the far-field of the test antenna by "deconvoluting" the measured near-field data (without knowing the detailed scattering properties of the probe or test antenna), the multiple reflections must be neglected. That is, the second and higher order terms in the infinite series just described are assumed negligible when applying the planar near-field scanning techniques [3].

Multiple reflections can be reduced by decreasing the size of the probe antenna, by increasing the distance between the probe and test antenna, and by appropriately covering the scanning range with efficient absorber material. These measures will not, however, eliminate the multiple reflections entirely.<sup>14</sup> It is the purpose of this section to estimate the effects of the multiple reflections on the far-field which is computed from the near-field scan data under the assumption of zero multiple reflections.

As we shall see shortly, it is a fairly simple matter to estimate maximum and minimum values expected for the far-field errors produced by the multiple reflections. However, it is impossible to derive an accurate estimate of the far-field errors analytically without knowing the phase of the multiply reflected fields throughout the scan area. Thus, the only reliable way to get an accurate estimate of the far-field errors caused by multiple reflections is through measurement. Specifically, a number of near-field scans could be

14In principle, the effect of multiple reflections could be eliminated at microwave frequencies by the use of gated sinewaves instead of CW. Unfortunately, the speed of electromagnetic propagation (c) is so great that the necessary gating times are too short for the present-day electronics to handle. It is possible, however, in the analagous measurement of electroacoustic transducers to eliminate the problem of multiple reflections by the use of gated sinewaves because the speed of sound is much smaller than that of light [18].

taken on parallel planes separated by about 1/4 wavelength and the far-field computed from each scan. Any differences observed in the far-fields computed from the separate near-field scans would indicate the extent of the effect of multiple reflections (assuming the scan area is large enough so that changes in finite scan errors are negligible). In this way the far-field errors can be determined straightforwardly and accurately. Of course, the main disadvantage of this "straightforward method" of determining errors lies in the time and effort it takes to record data and compute far-fields from several near-field scan planes for every antenna that has to be measured. Because of this disadvantage it may prove worthwhile, particularly when the multiple reflections are very small, to derive the following very approximate, yet general, upper and lower bound expressions for the far-field errors caused by the multiple reflections. In addition to the upper and lower limits of errors, the farfield errors will be derived for multiply reflected fields which satisfy a certain class of hypothetical near-field distributions.

Consider a probe antenna scanning on a plane in the near-field of an electrically large, aperture antenna. Assume once again, for the sake of simplifying the mathematics, that the probe behaves as an electric dipole, i.e. its output in one orientation is proportional to  $E_x$  and in a second orientation proportional to  $E_y$ . Then the error  $(\Delta \overline{E})_{r \to \infty}$  in the computed far-electric-field can be expressed with the aid of eqs. (37) and (12d),

$$\Delta \overline{E} \leq \frac{-ik}{2\pi r} e^{ik(r-d\cos\theta)} \int_{A'} \Delta \overline{E}_{t}^{mr}(\overline{P},d) e^{-i\frac{k}{r}\overline{R}\cdot\overline{P}} d\overline{P}.$$
(85a)

The superscript "mr" on  $\Delta \overline{E}_t^{mr}$  denotes that part of the transverse near-electric-field caused by multiple reflections, and A' refers to the scan area.

The determination of  $(\Delta \overline{E})_{r \to \infty}$  requires the evaluation of the integral

$$\overline{I} = \int_{A'} \Delta \overline{E}_{t}^{mr} (\overline{P}, d) e^{-i\frac{k}{r}\overline{R} \cdot \overline{P}} d\overline{P}, \qquad (85b)$$

or if the x-component is concentrated on first

$$E_{x} = \int_{A} \Delta E_{x}^{mr} (\overline{P}, d) e^{-i\frac{k}{r}\overline{R} \cdot \overline{P}} d\overline{P}.$$
(85c)

The amplitude and phase of  $\Delta E_x^{mr}$  can be written explicitly as

 $\Delta E_{x}^{mr} = \Delta A_{x}^{mr} e^{i\phi_{x}^{mr}}$ 

to recast eq. (85c) in the form

$$I_{X} = \int_{A} \Delta A_{X}^{mr} e^{i(\phi_{X}^{mr} - \frac{k}{r}\overline{R} \cdot \overline{P})} d\overline{P}.$$
 (86)

The maximum value of the integral in eq. (86) occurs when  $\phi_X^{mr} = \frac{k}{r} \overline{R} \cdot \overline{P}$ , i.e.

$$I_{x} \leq \int_{A} \Delta A_{x}^{mr} d\overline{P}.$$
 (87)

If polarization is not changed drastically upon reflection from the probe and test antenna,  $\Delta A_{\chi}^{mr}$  will be roughly proportional to the magnitude of the x-component of electric field at the probe. That is,

$$\Delta A_{\rm X}^{\rm mr} \simeq \varepsilon_{\rm X}^{\rm mr} |E_{\rm X}|, \qquad (88)$$

where  $\varepsilon_{\rm X}^{\rm mr}$  is an average proportionality constant between the amplitude of the multiply reflected x-component of electric field and the amplitude of the total x-component of electric field as the probe traverses the scan area. Substitution of eqs. (88) and (52) into eq. (87) yields

$$I_{X} \leq \varepsilon_{X}^{mr} \lambda r |E_{XO}|_{r \to \infty}.$$
 (89a)

In the same manner, the expression for  $I_v$  is found to be

$$I_{y} \leq \varepsilon_{y}^{mr} \lambda r |E_{yo}|_{r \to \infty}.$$
 (89b)

An upper bound expression for the fractional error  $\eta$  emerges when eqs. (89) and (85) are combined with eq. (1):

$$n(\overline{r}) \leq \varepsilon^{mr} g(\overline{r}), \qquad (90)$$

where  $\varepsilon^{mr}$  is the average proportionality constant between the amplitude of the multiply reflected electric field (probe output) and the amplitude of the total electric field (probe output) as the probe traverses the scan area. The value of  $\varepsilon^{mr}$  can be estimated experimentally by changing the distance between the probe and test antenna by a few wavelengths at various locations within the scan area. Periodic variations in the amplitude of the probe output which repeated about every  $\lambda/2$  would be caused primarily by the multiple reflections. As usual,  $g(\bar{r})$  is the ratio of the amplitude of the maximum far-electric-field to the far-electric-field at the given direction  $\bar{r}$ .

Equation (90) represents an upper bound expression for the errors in the far-field caused by multiple reflections. It applies to the entire far-field of electrically large aperture antennas. However, for nearly all antenna-probe interactions it will give much too large an estimate of the far-field errors because it was derived under the unrealistic assumption that the multiply reflected fields possessed just the right phase across the scan area to maximize the far-field errors. In reality, as the probe traverses the scan area it will usually experience large variations in the phase of the multiply reflected fields throughout the scan area that will greatly reduce their effect on the far field. We emphasize the word "usually" because there exist some antennas (like the constrained lens, fixedbeam array shown in figure 9) which present a rather flat reflective surface to the radiation scattered from the probe, and thus a rather constant effective path length and phase for the multiply reflected fields as the probe scans on a plane parallel to the aperture. In that case the maximum error could be experienced at the center of the main beam.

The multiple reflections would have a minimum effect on the far-field when their phase varied radically over the scan area, or more precisely, when  $\phi_X^{mr} - \frac{k}{r} \overline{R} \cdot \overline{P}$  in eq. (86) has no critical points and varies rapidly with position  $\overline{P}$  on the scan area. Then eq. (86) written in polar coordinates (p,  $\phi_p$ ) can be integrated by parts with respect to p to give

$$I_{x} \simeq \frac{\lambda}{2\pi i} \int_{0}^{2\pi} \frac{\Delta A_{x}^{mr}(p',\phi_{p})}{\partial f/dp'} e^{ikf(p',\phi_{p})} p'd\phi_{p}, \qquad (91)$$

where p' refers to the distance from the origin within the scan area to the point on the boundary of the scan area at the angle  $\phi_p$ . The function f(p', $\phi_p$ ), which is assumed to possess no stationary points with respect to p, is defined by

$$kf = \phi_X^{mr} - \frac{k}{r} \overline{R} \cdot \overline{P}.$$
 (92)

As mentioned above, the smallest values of  $I_x$  occur, in general, when the phase function f varies rapidly with p and  $\phi_p$ . Experience at the NBS [17] indicates that it is unlikely that the average phase variations in multiple reflections which occur in practice ever exceed 360° per wavelength across the scan area. Thus it is also unlikely that  $|I_x|$  will be smaller than its value when f is chosen as a function which changes an average of about 360° per wavelength of motion in any direction across the scan area. For example, one such function is

$$f = p(1+\cos^2\theta_p).$$
(93)

Substitution of the function (93) into eq. (91) shows that the magnitude of  $\rm I_x$  may be expressed as

$$|I_{X}| \geq \frac{\lambda}{2\pi} \left| \int_{0}^{2\pi} \frac{\Delta A_{X}^{mr}(p',\phi_{p})}{1 + \cos^{2}\theta_{p}} p' e^{ikp'(1 + \cos^{2}\theta_{p})} d\phi_{p} \right|.$$
(94)

Equation (94) is written as an inequality to emphasize that for nearly all antennas  $|I_{X}|$  would be larger than the right side of eq. (94).

In order to get an idea of the value of eq. (94), assume that  $\frac{\partial p'}{\partial \phi_p} << p'$  so that the points of stationary phase of  $p'(1+\cos^2\phi_p)$  with respect to  $\phi_p$  occur near  $\phi_p = 0$ ,  $\pi/2$ ,  $\pi$  and  $3\pi/2$ . Then integration by the method of stationary phase shows that eq. (94) may be written approximately as

$$|I_{x}| \ge \frac{\lambda}{2\pi} \sqrt{\lambda} L^{ave} \Delta A_{x}^{ave},$$
 (95a)

with  $L^{ave}$  equal to the average of the width of the scan area, and  $\Delta A_x^{ave}$  equal to the average amplitude of the x-component of the multiply reflected electric field at the four points  $\phi_p = 0$ ,  $\pi/2$ ,  $\pi$  and  $3\pi/2$
on the boundary of the scan area. If we approximate  $\Delta A_x^{ave}$  by  $\varepsilon_x^{mr} |E_x|^{ave}$ , where  $|E_x|^{ave}$  refers to the average amplitude of the x-component of electric field on the boundary of the scan area, eq. (95a) becomes

$$|I_{x}| \ge \frac{\lambda}{2\pi} \sqrt{\lambda} L^{ave} \varepsilon_{x}^{mr} |E_{x}|^{ave}.$$
 (95b)

Since  $|\overline{I}| = \sqrt{|I_x|^2 + |I_y|^2}$ , eq. (95b) combines with the corresponding equation for  $|I_y|$  to give

 $|\overline{\mathbf{I}}| \geq \frac{\lambda}{2\pi} \sqrt{\lambda} \ \mathbf{L}^{\text{ave}} \ \varepsilon^{\text{mr}} |\overline{\mathbf{E}}_{t}|^{\text{ave}}.$  (96)

The average amplitude  $|\overline{E}_t|^{ave}$  of the transverse electric field may be expressed in terms of the maximum transverse electric field ( $E_{to}$ ) on the scan plane,

$$|\overline{E}_{t}|^{\text{ave}} = 10^{\frac{-\chi^{\text{ave}}}{20}} E_{\text{to}}, \qquad (97)$$

with X<sup>ave</sup> denoting the number of dB down from that maximum (see footnote 7).

Equations (30b) and (31) can be utilized in conjunction with eqs. (97) and (96) to give the final expression for the minimum value of  $|\overline{I}|$ ,

$$|\overline{\mathbf{I}}| \geq \sqrt{\lambda \ \mathbf{L}^{ave}} \frac{10^{\frac{-\chi^{ave}}{20}} \varepsilon^{\mathrm{mr}} \alpha \lambda^{2} r |\overline{\mathbf{E}}_{0}|_{r \to \infty}}{2\pi \mathrm{A}}.$$
 (98)

From eqs. (98), (85) and (1) we find the minimum value expected for the fractional error  $\eta$  in the far-field caused by multiple reflections:

$$\eta(\overline{r}) \geq \left(\frac{\lambda}{L^{\text{ave}}}\right)^{3/2} \frac{10^{\frac{-\chi^{\text{ave}}}{20}} \alpha \varepsilon^{\text{mr}} g(\overline{r})}{\pi}.$$
(99)

(The aperture area A has been taken as  $.5(L^{ave})^2$ .) The inequality (99) represents a lower bound expression for  $\eta$  in the sense that the actual far-field errors caused by multiple reflections would, to a high probability, be greater than but could lie reasonably close to the value of the right side of eq. (99). Of course, there remains the possibility that for some points in the far-field the effects of the multiple reflections will cancel to such a degree that  $\eta$  would actually be less than the right side of eq. (99). These exceptional points must be ignored if eq. (99) is accepted as a valid lower bound.

Between eqs. (90) and (99) we have approximate upper and lower limits to the value of  $\eta$ ,

$$\left(\frac{\lambda}{L^{ave}}\right)^{3/2} \frac{\alpha \ 10^{\frac{-\chi^{ave}}{20}}}{\pi} \epsilon^{mr} g(\overline{r}) \le \eta(\overline{r}) \le \epsilon^{mr} g(\overline{r}),$$

(100)

where

- $\lambda$  = wavelength.
- $\varepsilon^{mr}$  = the average ratio of the amplitude of the multiply reflected probe output to the amplitude of the total probe output as the probe traverses the scan area. (Its value can be estimated experimentally by changing the distance between the probe and test antenna at various locations within the scan area, and calculating one-half the fractional peak to peak height of the variations in amplitude that repeat about every  $\lambda/2$ .)
- $L^{ave}$  = average width of the scan area.
- X<sup>ave</sup> = the average amplitude of the probe output at the boundary of the scan area measured in dB down from the maximum amplitude of probe output in the scan plane.
- α = a "taper" factor -- equal to a minimum of 1.0 (for apertures of uniform amplitude and phase) and less than 5 for most tapered distributions found in practice (see eq. (31) for the precise definition of α; for a difference pattern one should still use the taper factor of the constituent sum patterns).
- $g(\overline{r})$  = ratio of the amplitude of the maximum far-electric-field to the far-electric-field at the given direction  $\overline{r}$ , i.e., the inverse of the normalized far-field pattern.  $(g(\overline{r}) = 1$  for the center of the main beam, or beams if a difference pattern.)

(If desired, upper and lower limits for the errors in the gain function, sidelobe level, polarization ratio, and beamwidth may be found by combining eq. (100) with eqs. (2)-(5) and the far-field pattern.)

The value of the factor

$$\left(\frac{\lambda}{L^{\text{ave}}}\right)^{3/2} \quad \frac{\alpha \quad 10^{\frac{-\chi^{\text{ave}}}{20}}}{\pi}$$

for a typical microwave antenna and scan area is on the order of .001; in which case eq. (100) becomes

$$001 \ \varepsilon^{mr}g(\overline{r}) \leq \eta(\overline{r}) \leq \varepsilon^{mr}g(\overline{r}).$$
(101)

It is clear from eq. (101) that the errors in the far-field produced by multiply reflected fields of a given relative amplitude, i.e. a given  $\epsilon^{mr}$ , can span an extremely wide range of values depending on the variation in phase of the multiply reflected fields across the scan area. (For example, if the multiple reflections are down 40 dB ( $\epsilon^{mr}$  = .01), eqs. (101) and (2c) show that the multiple reflection error in the on-axis gain of the main beam lies between about  $\pm$  .0001 and  $\pm$  .1 dB.) Essentially, the right side of eq. (101) gives the far-field errors when the effective phase of the multiply reflected fields is uniform, and the left side when the phase varies an average of 360° every wavelength across the scan area. Because of the extremely large range in the possible value of  $\eta$ , it appears unlikely that a precise value of the far-field errors produced by the multiple reflections can be obtained by any method other than direct measurement. As was mentioned at the beginning of this section, data could be taken on a number of parallel scan planes separated by about  $\lambda/4$ , and the far-fields computed for each plane. Any differences noted in the computed far-fields for the separate scan planes would be caused primarily by the multiple reflections. In addition, it appears likely that the effect of multiple reflections could be reduced appreciably by averaging the far-fields obtained from a number of different scan planes separated by a small fraction of a wavelength over a distance of one wavelength.

Finally, we shall evaluate the far-field errors for multiply reflected fields which are described by a class of hypothetical

near-field distributions. In particular, assume that the fields are linearly polarized and that  $\phi_X^{mr}$  in eq. (86) has the functional dependence,

$$\phi_{\rm X}^{\rm mr} = 2\pi \left( \frac{{\rm x}}{\lambda_1} + \frac{{\rm y}}{\lambda_2} \right), \qquad (102)$$

where  $\lambda_1$  and  $\lambda_2$  are arbitrary real constants. Also, assume that the test antenna has a circular aperture of radius "a" and uniform amplitude distribution. Then for scans in the very near-field,  $\Delta A_x^{mr}$  in eq. (86) can be approximated by a constant ( $\Delta E_o^{mr}$ ) inside the aperture area and zero outside. Under these conditions, the integral (85b) may be written in polar coordinates as

$$I = \Delta E_{o}^{mr} \int_{o}^{2\pi} \int_{o}^{a} \int_{o}^{\frac{i2\pi p}{\lambda}} \left[\frac{\lambda}{\lambda_{1}} \cos \theta_{p} + \frac{\lambda}{\lambda_{2}} \sin \phi_{p} - \sin \theta \cos (\phi_{p} - \phi)\right] p dp d\phi_{p}.$$
(103)

The  $\phi_p$  integration can be performed after writing the bracketed expression in the exponential of eq. (103) in the form

$$\frac{\lambda}{\lambda_1} \cos\phi_p + \frac{\lambda}{\lambda_2} \sin\phi_p - \sin\theta\cos(\phi_p - \phi) = B \cos(\phi_p - b).$$
(104)

where

$$B = \sqrt{(\lambda/\lambda_1 - \sin\theta\cos\phi)^2 + (\lambda/\lambda_2 - \sin\theta\sin\phi)^2}$$
(105a)

and

$$b = \tan^{-1} \left( \frac{\frac{\lambda}{\lambda_2}}{\frac{\lambda}{\lambda_1}} - \sin\theta \sin\phi}{\frac{\lambda}{\lambda_1}} \right).$$
(105b)

Using the integral representation of the Bessel function,

$$J_{o}(z) = \frac{1}{2\pi} \int_{0}^{2\pi} e^{iz \cos \psi} d\psi,$$

eq. (103) reduces to

$$I = 2\pi\Delta E_{o}^{mr} \int_{o}^{a} J_{o}\left(\frac{2\pi pB}{\lambda}\right) p dp, \qquad (106)$$

and eq. (106) becomes

$$I = \lambda a \Delta E_{o}^{mr} \frac{J_{1}\left(\frac{2\pi a B}{\lambda}\right)}{B}.$$
 (107)

By combining eqs. (107), (85), and (1), the fractional error  $\eta$  in the far-field takes the form

$$\eta(\overline{r}) = \frac{a\Delta E_{o}^{mr} \left| J_{1}\left(\frac{2\pi aB}{\lambda}\right) \right|}{Br \left| E(\overline{r}) \right|_{r \to \infty}}.$$
(108)

For a circular aperture with uniform amplitude distribution  $E_0$ , eq. (10) can be integrated to yield the far-field,

$$E(\overline{r})|_{r \to \infty} = E_0 \frac{a}{r} \left(\cos^2\theta + \sin^2\theta \cos^2\phi\right) \frac{\left|J_1\left(\frac{2\pi a}{\lambda} \sin\theta\right)\right|}{\cos\theta}.$$
 (109)

The definition of  $\eta(\overline{r})$  loses significance when its value becomes larger than 1, i.e. when the far-field amplitude  $|E(\overline{r})|_{r\to\infty}$  becomes less than the amplitude of the far-field error. To avoid this situation,  $J_1(\frac{2\pi a}{\lambda} \sin \theta)$  in eq. (109) can be approximated by its envelope,

$$|J_{1}(z)| \simeq J_{1}^{e}(z) \equiv \begin{cases} (\frac{1}{2} z - \frac{1}{8} z^{2}) & z < 2 \\ \sqrt{\frac{2}{\pi z}} & z > 2. \end{cases}$$
(110)

Substitution of eq. (110) into eq. (109) and the result into eq. (108) transforms the expression for  $\eta$  into

$$\eta(\overline{\mathbf{r}}) = \frac{\varepsilon^{mr} \sin\theta \left| J_1 \left( \frac{2\pi aB}{\lambda} \right) \right|}{B(\cos^2\theta + \sin^2\theta \cos^2\phi) \left| J_1^e \left( \frac{2\pi a}{\lambda} \sin\theta \right) \right|}.$$

$$(\varepsilon^{mr} = \Delta E_0^{mr} / E_0)$$
(111)

If  $\lambda_1$  and  $\lambda_2$  (see eq. (102)) are chosen such that  $\lambda_1 = \lambda_2 = \lambda_0$ , and  $\phi$  is set equal to zero, B can be written from eq. (105a) as

$$B = \sqrt{2} \frac{\lambda}{\lambda_0} \left( \frac{\lambda}{\lambda_0} - \sin \theta \right) + \sin^2 \theta,$$

and  $\eta$  becomes

$$\eta(\theta) = \frac{\varepsilon^{mr} \sin\theta \left| J_1 \left( \frac{2\pi a}{\lambda} \sqrt{2\frac{\lambda}{\lambda_0} \left( \frac{\lambda}{\lambda_0} - \sin\theta \right) + \sin^2 \theta} \right) \right|}{\sqrt{2\frac{\lambda}{\lambda_0} \left( \frac{\lambda}{\lambda_0} - \sin\theta \right) + \sin^2 \theta} J_1^e \left( \frac{2\pi a}{\lambda} \sin\theta \right)}.$$
 (112)

We can compare this result with the previous maximum and "minimum" values estimated for n in eq. (100) when  $g(\overline{r}) = \alpha = 1$ , and  $\chi^{ave} = 0$ . For  $\lambda_0 = \infty$  (uniform phase for the multiply reflected fields) eq. (112) should equal the right side of eq. (100). For  $\lambda_0 = \lambda$  eq. (112) should be of the same order of magnitude as the left side of eq. (100). Indeed, when  $\lambda_0 = \infty$ , eq. (112) becomes  $\varepsilon^{mr}$ (the right side of eq. (100)), and when  $\lambda_0 = \lambda$  it reduces to approximately .06 ( $\lambda/a$ )<sup>3/2</sup>, which is nearly equal to the left side of eq. (100) since  $A = \pi a^2$  was taken as  $.5(L^{ave})^2$  in eq. (100). This agreement between eqs. (112) and (110) supports the validity of both expressions.

Equation (112) reveals that the on-axis far-field error  $\eta(0)$  can be expressed in the especially simple form,

$$n(o) = \varepsilon^{mr} \left| J_1 \left( \frac{2\sqrt{2}\pi a}{\lambda_0} \right) \right| \frac{\sqrt{2}\pi a}{\lambda_0}.$$
(113)

Figure 14 shows the on-axis error  $\eta(o)$  plotted against the variable  $\sqrt{2\pi a}/\lambda_0$ . Note that for  $\lambda_0 < 2a$ ,  $\eta(o)$  is given approximately by

$$.06\left(\frac{\lambda_{o}}{a}\right)^{3/2}\left|\cos\left(8.9\ \frac{a}{\lambda_{o}}-\frac{3}{4}\ \pi\right)\right|\epsilon^{mr},$$

and never gets larger than about .1  $\varepsilon^{mr}$ . That is, if the phase of the multiply reflected fields changes 360° or more across the diameter of the aperture area, the error in the on-axis far-electric-field is less than one-tenth  $\varepsilon^{mr}$ , where  $\varepsilon^{mr}$  is the ratio of the amplitude of the multiply reflected electric field (probe output) to the total electric field (probe output) as the probe traverses the effective scan area. Only when the phase of the multiply reflected fields is uniform ( $\lambda_0 = \infty$ ) across the scan area does the on-axis far-field error equal  $\varepsilon^{mr}$ .

In figure 15,  $\eta(\theta)$  is plotted for different values of  $a/\lambda_0$  from eq. (112) for  $a/\lambda = 12$ . When  $\lambda_0$  is greater than a couple of aperture

diameters, the envelope of the errors from multiple reflections are on the order of  $\varepsilon^{mr}$  throughout the far-field. As  $\lambda_0$  becomes less than a couple of diameters, the near-axis errors grow much smaller than  $\varepsilon^{mr}$  but the envelope of errors in the far sidelobes remains at about  $\varepsilon^{mr}$ . Finally, when  $\lambda_0$  gets as small as the free-space wavelength  $\lambda$ , the far-field errors are much smaller than  $\varepsilon^{mr}$  all the way to  $\theta = 30^\circ$  in the far-field.

## IV. Summary

The far-field characteristics of a radiating test antenna can be determined throughout the forward hemisphere by scanning on a near-field plane of the test antenna with a probe antenna of arbitrary but known receiving characteristics. The amplitude and phase of the probe output are recorded on the near-field scan plane and the far-field pattern is computed by "deconvolving" the near-field The accuracy of the computed far-field depends upon the size data. of the scan area, the accuracy with which the scanner positions the probe, the accuracy with which the instrumentation measures the amplitude and phase of the probe output, the extent of the multiple reflections, the computation errors involved with deconvoluting the near-field data, and, of course, the accuracy with which the probe is calibrated and the input power to the test antenna is measured. Essentially, this report derives upper bound expressions for the errors in the far-field pattern produced by these sources of error in the near-field measurements. The upper-bound expressions are written in a form that can be used to stipulate design criteria for the construction of near-field scanning facilities. In particular, the limits of accuracy in a given far-field parameter are expressed in terms of the measured near-field data and/or the computed farfield, the frequency and dimensions of the antenna-probe system, the systematic and random variation in the positioning of the scanner, and the precision of the instrumentation which measures the probe output. In order to simplify the mathematics, the probe was usually assumed to be an electric dipole, although the resulting upper bound expressions hold for arbitrary probes.

The analysis and resulting upper-bound expressions are not restricted to a particular antenna as previous computer studies [11,16] and direct far-field comparisons have been, but apply generally to electrically large aperture antennas which can be operating in either a sum or difference pattern. The results for position and instrumentation errors apply only to nonscanning antennas in the sense that the analysis for these two sources of error assumed that the scan plane lay perpendicular or nearly perpendicular to the boresight direction of the antenna pattern. Position and instrumentation errors for beams which are steered away from the perpendicular to the scan plane will be included in a subsequent report by Newell [21]. Except for the position and instrumentation errors, however, the results of the present report, and in particular the error expressions pertaining to the truncation of the scan plane, apply to arbitrarily steered antennas.

Broadbeam antennas where the wavelength is on the same order of magnitude as the dimensions of the aperture are not examined in this report. But it is shown in a report by Crawford et al. [20] that many of the conclusions and upper bound expressions derived here apply directly or in slightly modified form to broadbeam antennas.

It is emphasized that the upper-bound expressions derived in this report determine the limits of accuracy of the far-field computed from the planar near-field scanning technique without resorting to comparisons with direct far-field measurements. This is probably the foremost purpose of the report along with the report acting as an aid in deciding design criteria and tolerances for the construction of new near-field scanning facilities. It has been the feeling of those involved with near-field measurement techniques at the NBS that often the near-field techniques determine the far-field more accurately than conventional far-field measurements with a standard antenna. Thus comparison with measurements made on conventional 'far-field" ranges would not be a reliable method, even if it were feasible, for estimating the accuracy of the near-field techniques, which do not have the problems of proximity corrections, ground reflections, or the need of a standard far-field antenna. A brief summary of the major conclusions and results of the report follows:

Errors in computation can be ignored immediately. A simple exercise in Section I showed that their effect on the far-field is extremely small compared to the effects of the other sources of error. Far-field errors from the approximation involved in applying the sampling theorem are also negligible (see footnote 1).

In Section II it was demonstrated that errors in various farfield parameters could be expressed conveniently in terms of the fractional far-electric-field error  $(\eta = |\Delta \overline{E}|/|\overline{E}|_{r\to\infty})$  and the approximate far-field pattern. In particular, the errors in gain function, sidelobe level, polarization ratio, and beamwidth were expressed in terms of  $\eta$  (see eqs. (1)-(5)).

In Section III.A the far-field errors associated with neglecting the near-fields outside the finite scan area were investigated. First it was shown analytically that no reliable information about the far-field pattern could be obtained by the planar near-field scan method outside the "solid angle" formed by the edge of the antenna aperture and the boundary of the scan area. Well within this solid angle ( $\theta \lesssim \frac{1}{2} \theta_{max}$ , see eq. (33) and following), reasonable upper bound expressions for the finite scan errors were found that could be applied to center-line data (eq. (32)) as well as full-scan data (eq. (36) or (32)). As part of the finite scan analysis, asymptotic expressions for the near-fields in front of a circular antenna of uniform aperture distribution were derived in Appendix A and plotted in figures A3 and A4. A comparison was made between the empirical analysis of finite scan errors performed by Newell and Crawford [11] with centerline data and the maximum errors calculated from the upper bound expression (32). Agreement is quite reasonable, as figures 8a and 8b indicate. Table 1 shows the finite scan error for various far-field parameters of a typical X-band antenna. The finite scan errors are proportional to wavelength, so changing the wavelength while holding the other antenna dimensions the same merely changes the values in Table 1 proportionately. Of course, such an isolated change is rather unrealistic.

Deviations in the position of the probe from its assumed position in the scan area will produce errors in the near-field data which show up as errors in the computed far-field pattern. Section

III.B.1 derives an upper bound expression throughout the forward hemisphere for the far-field errors produced by both systematic and random errors in the positioning of the probe (see eqs. (61), (64), (68) and figures 10, 11, and 12). (Of course, a uniform displacement of the scanner does not alter the far-field pattern, and a uniform rotation of the scanner simply rotates the entire far-field pattern through the same angle.) The contribution from the inaccuracies in the position of the scanner divides naturally into a transverse or xy (parallel to the scan area) and longitudinal or z (perpendicular to the scan area) part.

For sum patterns, the on-axis far-field errors were found proportional to the xy-displacement errors of the scanner but proportional to the square of the z-displacement errors (normalized to wavelength). This latter result is analogous to that obtained by Ruze [15] in his classical work on "antenna tolerance theory" for a small arbitrary phase error or aberration in the surface of an antenna. This result does not imply that the z-displacement errors generally have a much smaller effect on the main beam than the xy errors, because the multiplying factor is, in general, much larger for the z term. It does imply, however, that random and systematic displacement errors in the longitudinal or z direction weigh equally in their contribution to errors near the center of the main beam of sum far-field patterns. Unlike the z errors, random errors in the transverse or xy-displacement of the scanner have a negligible effect throughout the far-field compared to systematic transverse errors of the same order of magnitude, and the xy-position errors do not depend on wavelength. The xy-position errors also differ from the z-position errors in that the same xy error expression applies throughout the far-field hemisphere whereas the z errors are given by one expression close to the main beam, i.e., near the boresight direction, and another expression for the errors off-axis. Specifically, the maximum possible off-axis (or sidelobe) z-position errors depend linearly upon the systematic z-displacement errors of the scanner and are much larger than the on-axis errors, which are proportional to the square of the z-displacement errors. In fact, as Tables 2 and 4 indicate, these off-axis errors caused by displacements in the

z-position of the scanner can be much larger than the total off-axis errors from all other sources combined. The present report does not examine in detail the relationship between the distribution of zdisplacement errors and the off-axis or sidelobe errors, but such an analysis will be included as part of the subsequent report by Newell [21].

For difference patterns, the effect of the near-field displacement errors on the far-field were given by the same upper-bound expressions derived for sum patterns, except for the effect of zdisplacement errors on the null depth. This error in null depth for difference patterns was shown in Appendix B to be independent of the value of the null depth itself and proportional to the z-displacement errors, but, in general, proportional by a very small proportionality constant. In fact, for most antennas and reasonably accurate scanning systems, the z-displacement errors do not affect the null depth by more than a few tenths of a dB. This rather surprising result, which is rather difficult to explain without going through the mathematics of Appendix B, has been confirmed by an empirical error analysis performed by Newell [21] on the measured near-field data of a number of antennas operating in the difference mode. Although the z-displacement errors do not have a strong influence on the depth of the null of difference patterns, eq. (68), which was also derived in Appendix B, shows that they do have a strong influence on the direction of this null. In fact, the effect of all other sources of errors combined on the null direction of difference patterns is generally negligible compared to the effect of z-position errors, although instrumentation phase errors can sometimes shift the null an appreciable amount as well.

Table 2 shows the xy- and z-position error in various far-field parameters for a typical X-band and K-band antenna. Again, note the strong influence that z-position or phase errors can have on the off-axis far-field parameters (sidelobe level, beamwidth, mainlobes of difference patterns) and on the null shift of the difference pattern. Note also that the maximum possible null shift caused by z-position errors is independent of frequency.

The far-field errors caused by the inaccuracies of the receivers in measuring the phase and amplitude of the probe output are estimated in Section III.B.2 (see eqs. (82), (83) and figures 11-13). (It should be mentioned that instrumentation errors associated with converting analog to digital information is assumed negligible.) As would be expected, the instrumentation errors in measuring phase contribute to the far-field errors in exactly the same way as longitudinal or z-position errors of the scanner. However, since the errors which a typical receiver introduces into the phase are small and increase monotonically with decreasing amplitude of the probe output, calculations show that their effect is often negligible throughout the far-field.

Although typical instrumentation errors in measuring phase are small and often introduce insignificant errors into the far-field, typical instrumentation errors in measuring amplitude can have a pronounced effect on the far-field (see figure 13), except for the far sidelobe region and in the null depth of difference patterns. In general, if high accuracy is desired, the receiving system which measures the amplitude of the probe output should be calibrated and the calibration curves included as part of the computer program which deconvolutes the near-field data to get the far-field. It is significant, however, that the instrumentation errors in measuring near-field amplitude have a relatively small affect on the null depth of difference patterns, as eq. (82) and Table 3 demonstrate. The reason for this is that the receiver distorts the opposite lobes of the near-field amplitude by approximately the same amount (see Appendix B). Table 3 also displays the amplitude error in various other far-field parameters for a typical microwave antenna. The instrumentation amplitude errors for  $\theta < 2\lambda/\ell^{max}$  do not depend directly upon frequency or the size of the test antenna, only upon the taper factor  $\alpha$  of the near-field amplitude, the receiver inaccuracy  $N_{dB}^{I}$ , and, except for the null depth of difference patterns, the inverse of the normalized far-field pattern  $g(\overline{r})$ . It should also be pointed out that the instrumentation amplitude errors in the far sidelobe region,  $\theta > 10\lambda/l^{max}$ , are relatively small, usually less than a few tenths of a dB for  $N_{dB}^{I}$  less than a few thousands of a dB per dB.

Whenever comparisons were possible, the expressions for both position and instrumentation errors (eqs. (61), (64), (68), (82), and (83)) agreed well as an upper-bound with the results of the empirical error analysis of Newell et al. [11,17,21] at the National Bureau of Standards, and with the error analysis performed by Rodrigue et al. [16] at the Georgia Institute of Technology with a hypothetical near-field distribution (see figures 11-13).

In Section III.C upper and "lower" bound expressions were derived for the far-field errors caused by multiple reflections (see eq. (100)). The upper and lower bounds were extremely far apart because the phase of the multiply reflected fields has a strong influence on the far-field errors. Since the phase of the multiply reflected fields for a given test and probe antenna interaction would, in general, be difficult to measure or estimate, it was concluded that the only reliable way to get an accurate estimate of the far-field errors from multiple reflections would be to use the following straightforward but tedious procedure. Take several nearfield scans on parallel planes separated by about 1/4 wavelength or less. Any deviations in the far-field patterns computed from the data on the separate scan planes would be caused primarily by the multiple reflections (assuming the scan area is large enough so that changes in finite scan errors are negligible). If necessary, the effect of multiple reflections could probably be reduced appreciably by averaging the amplitude of the far-fields obtained from these different scan planes separated by a small fraction of a wavelength and covering a total change in separation distance of one wavelength. In addition to the upper and lower limits of error, the far-field errors were derived for multiply reflected fields which satisfy a certain class of hypothetical near-field distributions (see eq. (112) and figures 14 and 15).

The major analytical results of this error analysis study can be combined into one long upper-bound expression for the fractional far-electric-field error  $\eta(\theta, \phi)$ . ( $\theta$  and  $\phi$  specify the angular spherical coordinates of the far-field pattern.)

$$\begin{split} & n(\theta,\phi) \leq \left(\frac{\alpha\lambda L^{\max}_{10} \frac{-\chi}{20}}{A \sin\theta_{\max}} + \frac{\alpha\lambda \Delta_{\max}^{S}}{2x^{\max}} + n'_{z} + 2N_{dB}^{I}(\beta^{I}) + 2\left[\epsilon^{mT}\right]\right) \frac{g(\theta,\phi)}{2} \\ & + n_{\text{probe}}(\theta,\phi) + n_{\text{input}} \\ & \theta_{\text{shift}} = \frac{\text{null shift of}}{\text{difference pattern}} \leq \frac{2\lambda}{\pi x^{\max}} \left(\delta_{\max}^{S} + \Delta \phi_{\max}^{I}\right)_{\text{radians}} \quad (114a) \\ & \theta_{\text{shift}} = \frac{\text{null shift of}}{\text{difference pattern}} \leq \frac{2\lambda}{\pi x^{\max}} \left(\delta_{\max}^{S} + \Delta \phi_{\max}^{I}\right)_{\text{radians}} \quad (114b) \\ & n'_{z} = \begin{cases} (\delta_{\max}^{S} + \Delta \phi_{\max}^{I})^{2} + (\delta_{\max}^{rn})^{2} \quad (\text{sum patterns}) \\ 8\Delta F(\delta_{\max}^{S} + \Delta \phi_{\max}^{I}) \quad \text{patterns}) \\ \delta_{\max}^{S} \quad (\text{sum and difference } \frac{\lambda}{10x^{\max}} < \theta < \frac{\pi}{2} \\ \delta_{\max}^{S} \quad (\alpha-1) \quad (\text{sum patterns}) \quad \theta < \frac{\lambda}{10x^{\max}} \\ (\alpha-1)/2 \quad (\text{sum patterns}) \quad \theta < \frac{\lambda}{10x^{\max}} \\ (\alpha-1)/2 \quad (\text{sum and difference } \frac{\lambda}{10x^{\max}} < \theta < \frac{2\lambda}{x^{\max}} \\ \frac{\alpha\lambda L^{\max}_{3A}}{3A} \quad \frac{10\lambda}{x^{\max}} < \theta < \frac{\pi}{2} \\ \end{cases} \end{split}$$

Equations (114) represent essentially an amalgamation of eqs. (32), (64), (68), (82), (83) and (100), under the extreme condition that the various near-field errors combine in such a way as to create the maximum possible far-field errors. If desired, the tighter upperbound, eq. (36), for the finite scan error could be used for the first term in eq. (114a) instead of eq. (32). Recall from Section III.A.3 that the finite scan error term represents a valid upper-bound halfway or more within the "solid angle" formed by the edges of the aperture and the boundary of the scan area  $(\theta \leq \frac{1}{2} \theta_{max} = \frac{1}{2}(90 - \gamma_{max});$  and outside this solid angle region the planar near-field scanning technique cannot be relied upon with any confidence to yield accurate far-fields. The instrumentation amplitude factor  $\beta^1$  is not given explicitly by eqs. (114) in the region between  $\theta$  equal to  $2\lambda/2^{\max}$ and  $10\lambda/l^{max}$ . However  $\beta^{I}$  can be estimated in this region by connecting a straight line from its value at  $2\lambda/l^{max}$  to its value at  $10\lambda/l^{max}$ The detailed derivation of each of the terms in eq. (114), except

 $\eta_{\text{probe}}$  and  $\eta_{\text{input}}$ , can be found in the part of the main text from which each particular term came. The extra terms  $\eta_{\text{probe}}$  and  $\eta_{\text{input}}$ will be explained below. The definition of the various parameters in eqs. (114) can also be found from the preceeding main text:

- $\lambda$  = wavelength.
- A = area of the antenna aperture.
- $l^{\max}$  = maximum width of the antenna aperture.

 $L^{max}$  = maximum width of the scan area.

- $\gamma_{max}$  = maximum acute angle between the plane of the scan area and any line connecting the edges of the aperture and scan area ( $\theta_{max}$  = 90- $\gamma_{max}$ ).
- X = the largest amplitude of the probe output at the edge of the scan area, measured in dB down from the maximum amplitude of probe output in the scan plane.
- α = a "taper" factor--equal to a minimum of 1.0 (for apertures of uniform amplitude and phase) and less than 5 for most tapered distributions found in practice. (See eq. (31) for the precise definition of α; for a difference pattern one should still use the taper factor of the constituent sum patterns.)
- $\Delta_{\max} = 2\pi\Delta P_{\max}/\lambda, \text{ where } \Delta P_{\max} \text{ is the maximum amplitude of the} \\ \text{transverse (xy) displacement errors within the effective} \\ \text{scan area } A_0. \quad (A_0 \text{ is that part of the scan area over} \\ \text{which the phase is fairly uniform. For near-field scans} \\ \text{parallel to the aperture } A_0 \simeq A.)$
- $\delta_{\max} = 2\pi\Delta z_{\max}/\lambda$ , where  $\Delta z_{\max}$  is the maximum amplitude of the longitudinal (z) displacement errors within the effective scan area  $A_0$ .
- $\Delta \phi_{\text{max}}^{I} = \text{the maximum instrumentation errors (expressed in radians)} \\ \text{involved in measuring the phase of the probe output on} \\ \text{the effective scan area } A_{o} \text{ (see footnotes 10 and 13).}$
- △F = fractional difference between the amplitude of the two main far-field lobes of the difference pattern (see Appendix B).
- $N_{dB}^{I}$  = the maximum instrumentation errors involved in measuring the amplitude of the probe output- $N_{dB}^{I}$  is expressed in dB error per dB amplitude down from the maximum amplitude

on the scan area. (The amplitude error is designated as zero at the maximum amplitude; see footnote 11.)

- $\epsilon^{mr}$  = the average ratio of the amplitude; see footnote II.) flected probe output to the amplitude of the multiply reflected probe output to the amplitude of the total probe output as the probe traverses the scan area. (Its value can be estimated experimentally by changing the distance between the probe and test antenna at various locations within the scan area, and calculating one-half the fractional peak to peak height of the variations in amplitude which repeat about every  $\lambda/2$ .)
- $g(\theta,\phi)$  = the ratio of the amplitude of the maximum far-electric field to the far-electric-field at the given direction  $(\theta,\phi)$ , i.e., the inverse of the normalized far-field pattern.  $(g(\theta,\phi) = 1$  for the center of the main beam, or beams if a difference pattern.)

The superscripts "s" and "rn" refer to the "systematic" and "random" parts of the displacement errors respectively. The instrumentation phase and amplitude errors  $(\Delta \phi_{max}^{I}, N_{dB}^{I})$  are assumed systematic in nature. The phase error  $\Delta \phi_{max}^{I}$  does not show up in  $n'_{z}$  for  $\theta > \lambda/(10 \lambda^{max})$ because, as explained in Section III.B.2, the shape of the near-field instrumentation phase error is such that it has negligible effect in this off-axis region compared to the maximum effect of typical systematic z-position errors  $\delta_{max}^{S}$ . Random position errors have nonnegligible effect only near the boresight direction of sum patterns.

The multiple reflection ratio  $\varepsilon^{mr}$  is enclosed in a box in eq. (114a) to emphasize that for most antennas it represents an unrealistically large upper bound.

The error  $\eta_{\text{probe}}(\theta,\phi)$  simply represents the uncertainty in the receiving characteristics of the probe in the direction corresponding to  $(\theta,\phi)$ . For example, if the receiving characteristic S'\_01 of the

probe (see reference [3]) was known to an accuracy of 1% for the direction  $(\theta, \phi)$ , then  $\eta_{\text{probe}}$  would be .01 for that direction.

The error  $\eta_{input}$  arises in normalizing the amplitude of the probe output to the input power or amplitude  $|a_0|$  of the input mode to the test antenna. Such a measurement is necessary whenever absolute values of the gain function are required. Probably the simplest and most accurate method of performing this normalization is to connect the input waveguide of the test antenna directly to the output waveguide of the probe through a variable attenuator. If, as explained in Section III.B.2, the receiver which measures the amplitude of the probe output is specified arbitrarily to have zero error when the probe output is at its maximum amplitude on the scan area, then the normalization can be accomplished by measuring the attenuation needed to reduce the amplitude of the direct input from the transmitter to the level of the maximum amplitude of the probe output on the scan area. Of course, "mismatch factors" of any consequence must also be measured. The quantity ninput merely denotes the combined fractional error of the variable attenuator and of the devices used to measure the necessary mismatch factors. By using a high precision attenuator, the fractional error ninput can usually be kept below a few thousandths.

Table 4 shows the total maximum possible error in a number of far-field parameters for a typical X-band and K-band antenna and a reasonably accurate scanning facility. The table was computed from eqs. (114) for the representative values of the near- and far-field parameters listed above the table. It is emphasized that the values shown in Table 4 are the maximum possible upper-bounds to the farfield errors computed under the extreme condition that each of the sources of near-field error produce its maximum possible change in the far-field and then all these maximum changes in the far-field add in phase. The z-position errors have been separated and underlined when they represent the dominant contribution to the upperbound errors, because whether or not these maximum possible z-position errors actually occur depends strongly on the far-field direction of interest and on the shape of the deviation in z-position throughout the scan area. As mentioned above, a detailed analysis of this dependence will be included as part of a subsequent report by Newell [21].

The error  $(\eta_{\text{probe}}^{dB} + \eta_{\text{input}}^{dB})$  in the receiving characteristic of the probe and in normalizing to the input power of the test antenna was chosen as .1 dB in Table 4. For the error in on-axis gain of the sum patterns, Table 4 shows that this contribution of .1 dB is about as large as all the other errors combined. The same is true for the gain of the mainlobes of the difference pattern if the zposition part of the errors is ignored. Thus, for the situation described by Table 4, greater accuracy in the calibration of the probe and in the measuring of the input power to the test antenna could be a first step in significantly reducing the errors in the direction of maximum gain.

It is interesting to compare the maximum equivalent reflected signal [24] allowable in a conventional "far-field" range or anechoic chamber to get accuracies comparable to those shown in Table 4 for the near-field scanning technique. It is a simple matter to show that the maximum equivalent reflected signal (ERS) measured in dB down from the direct signal is related to the values of  $\eta_{dB}$  by

ERS = 20 log 
$$\frac{\eta_{dB}}{8.7}$$
 (assuming small  $\eta_{dB}$ ).

For example, near the boresight direction the ERS would have to be 33 dB down for the sum pattern and 15 dB down for the difference pattern to give the corresponding errors shown in Table 4. Of course, there would also be errors on conventional ranges due to proximity effects, uncertainties in the calibration of the standard antenna, and instrumentation errors.

In conclusion, it can be seen from Tables 1-4 that for a reasonably accurate scanning system no one source of error dominates over all the others in the boresight direction of both sum and difference patterns. However, in the far-field region away from the boresight direction, but well within the solid angle region formed by the edge of the aperture and boundary of the scan area, the deviation in zposition of the scanner can, in principle, cause far-field errors which are much larger than the combined errors of all other sources. In practice, however, these maximum possible errors seldom occur. Moreover, it will be shown in the subsequent report by Newell [21]

that the scanner can be designed and utilized to keep the off-axis, z-position errors far below the upper-bound values given by eqs. (114) and shown in Tables 2 and 4. Of course, beyond the solid angle region formed by the edge of the aperture and boundary of the scan area, it was shown in Section III.A that the far-field computed from the near-field data cannot be relied upon with any confidence.



Figure 1. Main beam of a hypothetical test antenna.



Figure 2. Schematic of scanning geometry.



Figure 3. Schematic of aperture antenna.





Figure 5. Schematic of aperture and scan areas. (Although A and A' are drawn parallel, it is not a necessary requirement of the theory.)



Figure 6. Circular reflector antenna.



Figure 7a. Near-field centerline data (constrained lens) (z = 25 cm).



Figure 7b. Near-field centerline data (reflector antenna) (z = 43.18 cm).



Figure 8a. Change in gain vs. decreasing scan length (constrained lens).



Figure 8b. Change in gain vs. decreasing scan length (reflector antenna).





Figure 9a.

Constrained lens sum port nearfield log amplitude, f=9.2 GHz, z=25.0 cm, no radome.

Near-field phase, constrained lens sum port, f = 9.2 GHz, z = 25 cm.



Figure 9c. Constrained lens antenna and probe.



Figure 9d. Near-Field Centerline Data, z = 25 cm.



Figure 10. Position errors in on-axis gain.



Figure 11. Comparison with Rodrigue et al. for random phase errors.



Figure 12. Comparison with Newell for quadratic phase errors.



Figure 13. Amplitude errors in on-axis gain.



Figure 14. On-axis error in far-field from multiple reflections.





Finite Scan Errors from Centerline Data of a Typical X-Band Antenna. Table 1.

	Far-Field Parameter	Finite Scan Error	
	On-Axis Gain	± .01 dB	
sum pattern	Sidelobe Level	± .16 dB	
4	Beamwidth $\phi_{O}$	$\pm$ .002 $\phi_0$	
	On-Axis Polarization Ratio	± .001	
difference	Null Depth	± .28 dB	
pattern	Null Shift	Negligible	
	Main Lobes	± .01 dB	

$$\alpha = 5$$

$$\lambda = 3.26 \text{ cm}$$

$$L^{\text{max}} = 160 \text{ cm}$$

$$A = 5000 \text{ cm}^2$$

$$\theta_{\text{max}} = 60^{\circ}$$

$$X = 45 \text{ dB}$$
Sidelobe Level = -25 \text{ dB}
Null Depth = -30 dB

θ<sup>max</sup> A L max

.

.2 mm 11  $\Delta Z_{max} = \Delta P_{max} = \chi^{max}$ Null Depth = -30 dB Sidelobe Level = -25 dB  $\Delta F = .01$ 3 ŧ ರ N ×ρμγ SCAN ANTENNA

		XY-Positic	on Error	Z-Position (or	r Phase) Error
	Far-Field Parameter	$\lambda = 3.26 \text{ cm}$	$\lambda = 1.63 \text{ cm}$	$\lambda = 3.26 \text{ cm}$	$\lambda = 1.63 \text{ cm}$
	On-axis gain (dB)	± .01	± .01	± .006	± .026
sum	Sidelobe level (dB)	+ .18	+ .18	± 2 <b>.</b> 5	± 4 . 5
pattern	Beamwidth $\phi_{0}$	± .002¢0	± .002¢0	$\pm .04\phi_{0}$	± .03φ
	On-axis polarization ratio	± .002	± .002	± .001	± .004
difference	Null depth (dB)	± .32	+ .32	± .42	+ .84
pattern	Null shift (degrees)	negligible	negligible	+ .06	+ .06
	Main lobes (dB)	+ .01	± .01	± .17	+ .33

XY- and Z-Position Errors for a Typical X- and K-Band Antenna. Table 2.



Instrumentation Errors in Measuring Amplitude. Table 3.

Negligible

.018 dB

+1

± .035 dB

.006

+1

On-Axis Polarization Ratio

Null Depth

difference

pattern

Null Shift

Main Lobes

Sidelobe Level = -25 dB Null Depth = -30 dB  $\eta_{\text{probe}}^{\text{dB}} + \eta_{\text{input}}^{\text{dB}} = .1 \text{ dB}$  $\varepsilon^{\text{mr}} = .001$  $\Delta F = .01$  $N_{dB}^{I}$  = .002 dB per dB  $\Delta Z_{max}^{S} = \Delta P_{max}^{S} = .2 \text{ mm}$  $\Delta z_{max}^{rn} = .1 mm$  $\Delta \phi_{max}^{I} = 1^{\circ}$ x = 45 dB $A = 5000 \text{ cm}^2$  $L^{\text{max}} = 160 \text{ cm}$  $\chi^{\text{max}} = 80 \text{ cm}$  $\theta_{max} = 60^{\circ}$ З П ರ

Error	$\lambda = 1.63 \text{ cm}$	± .20	$\pm$ ( .80+4.5)	$\pm$ (.01 +.077) $\phi_0$	± .032	± 1.74	$\pm$ (01+.06)	$\pm$ (.14+.33)
Total	$\lambda = 3.26 \text{ cm}$	± .18	$\pm$ ( .86+ <u>2.5</u> )	$\pm$ (.01 +.038) $\phi_0$	± .029	± 1.50	$\pm$ (02 + .06)	± (.14 + <u>.17</u> )
	Far-Field Parameter	On-axis gain (dB)	Sidelobe level (dB)	Beamwidth $\phi_0$	On-axis polarization ratio	Null depth (dB)	Null shift (degrees)	Mainlobes (dB)
		sum pattern			difference pattern			

Table 4. Total Far-Field Errors for a Typical X- and K-Band Antenna.

## Appendix A

## Near-Fields of a Circular Antenna with Uniform Aperture Distribution

The purpose of this Appendix is to derive expressions for the near-field of a circular antenna of uniform aperture distribution. Specifically, the amplitude and phase are constant within the aperture and zero outside. The antenna is electrically large in the sense that the diameter of the aperture is many wavelengths across.

The transverse electric field to the right of the aperture is given exactly by eq. (16). If we assume that the aperture fields are linearly polarized in the x-direction, eq. (16) becomes

$$E_{X}(\overline{r}) = \frac{-E_{O}}{2\pi} \frac{\partial}{\partial z} \int_{O}^{2\pi} \int_{O}^{a} \frac{e^{ik|\overline{r}-\overline{R}'|}}{|\overline{r}-\overline{R}'|} R'dR'd\phi'$$
(A1)

for the circular aperture of radius a and uniform amplitude  $E_0$ . The element of area has been written in terms of the polar coordinates  $(R', \phi')$  of the vector  $\overline{R'}$ . In addition it can be proven from eq. (15) that if the aperture fields have longitudinal components which are small compared to the transverse components, then the longitudinal components remain relatively small in the near-field ( $z << a^2/\lambda$ ), provided  $a/\lambda >> 1$ .

The change of variable  $\overline{t} = \overline{R}' - \overline{R}$ , where  $\overline{R}$  is the transverse part of  $\overline{r}$ , converts eq. (A1) to

$$E_{x}(\bar{r}) = -2iE_{o} \frac{\partial}{\partial z} \left[ e^{ikz} - \int_{0}^{\pi} e^{ik\sqrt{t_{o}^{2}(\alpha) + z^{2}}} d\alpha \right] R < a$$
(A2a)

$$E_{X}(\bar{r}) = -2iE_{0} \frac{\partial}{\partial z} \int_{0}^{\alpha_{1}} \left[ e^{ik\sqrt{t_{1}^{2}(\alpha) + z^{2}}} - e^{ik\sqrt{t_{2}^{2}(\alpha) + z^{2}}} \right] d\alpha R > a. \quad (A2b)$$

The variables  $t_0$ ,  $t_1$  and  $t_2$  and the limit of integration  $\alpha_1$  are defined in figures Ala and Alb. Apparently, eqs. (A2) were first derived by Schoch [19].

For large k, the integrals in eqs. (A2) can be evaluated by the method of stationary phase. The integrand of eq. (A2a) has two stationary points, one at  $\alpha = 0$  and one at  $\alpha = \pi$ . The two terms in

the integrand of eq. (A2b) each have a single stationary point at  $\alpha = 0$ . After carrying through the details of the method of stationary phase, eqs. (A2) become

$$E_{x}(\bar{r}) = E_{o}[e^{ikz} + \Delta I] R < a$$
 (A3a)

$$E_{\chi}(\bar{r}) = E_{0} \Delta I$$
 R>a, (A3b)

where  $\Delta I$  is given by

$$\Delta I = \frac{-z}{2\pi} \sqrt{\frac{\lambda a}{R}} \left\{ \frac{e^{i \left[ k\sqrt{z^2 + (R+a)^2} - \frac{\pi}{4} \right]}}{(R+a)\sqrt[4]{z^2 + (R+a)^2}} - \frac{e^{i \left[ k\sqrt{z^2 + (R-a)^2} + \frac{\pi}{4} \right]}}{(R-a)\sqrt[4]{z^2 + (R-a)^2}} \right\}.$$
 (A3c)

Equation (A3b) is identical to eq. (17) of the main text when the following substitutions are made:

$$D_{1} = \sqrt{z^{2} + (R+a)^{2}} \qquad D_{2} = \sqrt{z^{2} + (R-a)^{2}}$$

$$a_{1} = -a \qquad a_{2} = a$$

$$\cos\theta_{1} = z/(R+a) \qquad \cos\theta_{2} = z/(R-a)$$

Strictly speaking, eqs. (A3) are valid only as  $k = 2\pi/\lambda$  approaches infinity. For finite k they represent first term approximations to an infinite asymptotic series, and the first term approximations are valid only in certain regions of the near-field. These regions of validity can be estimated by returning to eqs. (A2). First concentrate on eq. (A2a). In eq. (A2a) t ranges from (a-R) to (a+R). Thus if the rate of change of t is somewhat uniform with  $\alpha$  on the interval  $\alpha = 0$  to  $\pi$ , the method of stationary phase will yield a good approximation when

$$\frac{1}{\lambda} \left( \sqrt{(R+a)^2 + z^2} - \sqrt{(a-R)^2 + z^2} \right) >> 1.$$
 (A4)

Unfortunately t<sub>o</sub> does not change uniformly with  $\alpha$  from  $\alpha = 0$  to  $\pi$ , but it does so in the separate intervals 0 to  $\frac{\pi}{2}$  and  $\frac{\pi}{2}$  to  $\pi$ . Since  $t^2 = a^2 - R^2$  at  $\alpha = \frac{\pi}{2}$ , the condition (A4) must be replaced by the two conditions,

$$\frac{1}{\lambda} \left( \sqrt{(R+a)^2 + z^2} - \sqrt{a^2 - R^2 + z^2} \right) > 3$$
 (A5a)

$$\frac{1}{\lambda} \left( \sqrt{a^2 - R^2 + z^2} - \sqrt{(a - R)^2 + z^2} \right) > 3.$$
 (A5b)

(Actually the right side of eqs. (A5) should be >> 1 but experience with the method of stationary phase indicates it remains a good approximation down to where the quantities in brackets in eqs. (A5) are just a few wavelengths--specifically  $3\lambda$  is chosen in eqs. (A5).)

Manipulation of eqs. (A5) shows that they are satisfied for large  $a/\lambda$  if

$$3\lambda < R < [a-(12\lambda/a)\lambda]$$
 (A6a)

$$z < \frac{a-R}{3\lambda} \sqrt{R^2 - (3\lambda)^2}.$$
 (A6b)

That is, eq. (A3a) approximates eq. (A2a) in the region defined by eqs. (A6). A similar analysis with eq. (A2b) shows that it is approximated by eq. (A3b) in the region defined by

$$R > [a+(12\lambda/a)\lambda]$$
(A7a)

$$z < (R-a) \frac{a}{3\lambda}$$
 (A7b)

The regions of validity defined by eqs. (A6) and (A7) are shown in figure A2 for an  $a/\lambda$  equal to 12. Each region is labeled by the equation which approximates the field in that region. In addition to the regions defined by eqs. (A6) and (A7) two other regions--one near the z-axis,

$$R < \frac{1}{2}a \tag{A8a}$$

R < the larger of 
$$\left(\frac{\lambda}{2a} \text{ z or } .3\left(\frac{a}{\lambda}\right)^{2/3}\lambda\right)$$
, (A8b)

and one near the edge of the aperture

$$z > \frac{1}{2} \left( \pi \frac{a}{\lambda} \right)^{\frac{1}{3}} a$$
 (A9a)

$$z > \frac{\pi a}{\lambda} |a-R|$$
 (A9b)

$$|R-a| < \frac{1}{4} a \tag{A9c}$$

are shown in figure A2.
In the axis region defined by eqs. (A8), the exponent in the integrand of eq. (A2a) can be approximated by the first two terms of its expansion in R/a, and integrated to give

$$E_{x}(\bar{r}) = E_{0}\left(e^{ikz} - \frac{ze^{ik\sqrt{z^{2}+a^{2}}}}{\sqrt{z^{2}+a^{2}}} J\left(\frac{ka}{\sqrt{z^{2}+a^{2}}} R\right)\right).$$
(A10)

Similarly, in the edge region defined by eqs. (A9), the eq. (A2b) can be integrated approximately to give

$$E_{x}(\bar{r}) = \frac{E_{o}}{2} \left[ e^{ikz} - \frac{ze^{ik\sqrt{z^{2}+2a^{2}}}}{\sqrt{z^{2}+2a^{2}}} J_{o}\left(\frac{ka^{2}}{\sqrt{z^{2}+2a^{2}}}\right) \right].$$
(A11)

In the near-field in front of the aperture (z less than about  $\frac{1}{12} a^2/\lambda$ ), eqs. (A3a) and (A10) reveal that the electric field can be approximated by a single equation,

$$E_{x}(\overline{r}) = E_{o}[e^{ikz} + \Delta I'], \qquad (A12a)$$

with

$$\Delta I' = -\frac{za}{\sqrt{2}} \left\{ \frac{e^{\frac{i[k\sqrt{z^{2}+(R+a)^{2}} - \frac{\pi}{4}]}{(R+a)\sqrt{z^{2}+(R+a)^{2}}}}{e^{\frac{i[k\sqrt{z^{2}+(R+a)^{2}} + \frac{\pi}{4}]}{(R-a)\sqrt{z^{2}+(R-a)^{2}}}} J_{0}^{e} \left\{ \frac{ka}{\sqrt{z^{2}+(R+a)^{2}}} R \right\}$$
(A12b)  
$$-\frac{e^{\frac{i[k\sqrt{z^{2}+(R-a)^{2}} + \frac{\pi}{4}]}}{(R-a)\sqrt{z^{2}+(R-a)^{2}}} J_{0}^{e} \left\{ \frac{ka}{\sqrt{z^{2}+(R-a)^{2}}} R \right\}$$

and  $J_0^e$  defined as

$$J_{0}^{e}(z) \equiv \begin{cases} (1 - \frac{1}{4} z^{2}) & z < 1.46 \\ \\ \sqrt{\frac{1}{\pi z}} & z > 1.46. \end{cases}$$
(A12c)

Essentially, eqs. (Al2) represent the total electric field for the linearly polarized circular aperture in the region

$$R < a - \lambda$$
 (A13a)

$$z < \frac{1}{12} \frac{a^2}{\lambda}.$$
 (A13b)

The amplitude  $|E_{x}|$  and phase  $\phi_{x}$  of  $E_{x}$  may be found from eqs. (A12),

$$|E_{x}| \simeq E_{0} \left[ 1 - \frac{za}{\sqrt{2}} \left[ Q_{1} \cos(k\sqrt{z^{2} + (R+a)^{2}} - kz - \frac{\pi}{4}) - Q_{2} \cos(k\sqrt{z^{2} + (R-a)^{2}} - kz + \frac{\pi}{4}) \right] \right]$$
(A14a)

$$\phi_{\rm X} \simeq kz - \frac{za}{\sqrt{2}} \left[ \cos kz \left[ Q_1 \sin \left( k\sqrt{z^2 + (R+a)^2} - \frac{\pi}{4} \right) - Q_2 \sin \left( k\sqrt{z^2 + (R-a)^2} - \frac{\pi}{4} \right) \right] - \sin kz \left[ Q_1 \cos \left( k\sqrt{z^2 + (R+a)^2} - \frac{\pi}{4} \right) - Q_2 \cos \left( k\sqrt{z^2 + (R-a)^2} + \frac{\pi}{4} \right) \right] \right],$$
(A14b)

with

$$Q_{1} = \frac{J_{0}^{e} \left(\frac{ka}{\sqrt{z^{2} + (R+a)^{2}}} R\right)}{(R+a)\sqrt{z^{2} + (R+a)^{2}}}$$
(A14c)  
$$Q_{2} = \frac{J_{0}^{e} \left(\frac{ka}{\sqrt{z^{2} + (R-a)^{2}}} R\right)}{(R-a)\sqrt{z^{2} + (R-a)^{2}}}$$
(A14d)

Equations (A14) hold (to a first order approximation) everywhere in the near-field region defined by eqs. (A13). Except within a wavelength or so of the z-axis, eqs. (A14) reveal that in this region the maximum amplitude fluctuations are about  $\pm \frac{1}{\pi} \sqrt{\frac{\lambda}{a}}$ , and the phase varies slightly from kz. The amplitude of the electric field given by eq. (A14a) is plotted in figure A3 for  $a/\lambda = 12$  and 15, and for increments of z/a from 0 to  $\frac{1}{12} a/\lambda$ . The amplitude curves show large fluctuations within a wavelength of the points of maxima and minima along the z-axis. These z-axis maxima and minima, which are a wellknown phenomenon for the circular aperture of uniform distribution, are less pronounced for noncircular apertures, or for apertures with a tapered distribution (see reference [13], Section 1-F).

Figure A3 also shows that the amplitude variations across the aperture repeat about every wavelength in the very near-field (z < a/4), but spread out as the distance from the aperture gets larger. This behavior has been observed for tapered distributions as well, by the many near-field measurements on microwave antennas performed at the National Bureau of Standards [17].

The phase in the near-field of a circular antenna with  $a/\lambda = 12$ is plotted in figure A4. Except near the zeros in on-axis amplitude, the phase across the beam is uniform to within a few degrees of oscillation which repeat about every wavelength in the very near-field.



Figure A1. Definition of  $\overline{t}$  and  $\alpha.$ 



Figure A2. Dotted line shows region in which eq. (Al2a) holds.





|E<sub>x</sub>|





Figure A4. Near-field phase of circular antenna  $(a/\lambda = 12)$ .

# <u>Appendix B</u> <u>Position and Instrumentation Errors for the</u> <u>Null Depth of Difference Patterns</u>

# 1. Position Errors

The errors in null depth of a difference pattern caused by transverse displacement errors  $(\Delta \overline{P})$  of the near-field scanner can be derived in the same way and are given by the same upper bound expression as that of the transverse errors for sum patterns (eq. (60a)). However, the sum pattern derivation of Section III.B.1 for longitudinal displacement errors cannot be applied to finding errors in the null depth of difference patterns. The main reasons for this are twofold. The first and most obvious is that the equation for difference patterns analogous to eq. (48) may not be satisfiable because the near-field of a difference pattern changes phase by 180° across the aperture. Secondly, as the analysis below shows, the greatest effect of a longitudinal displacement error is a slight shift in the position of the null rather than a change in the depth of the null.

If the longitudinal position errors were zero and the perpendicular  $(\hat{e}_z)$  to the scan plane were parallel to the null axis, the far-field in the direction of the "null" is given in terms of the near-field by eq. (10):

$$E_{X}^{null} = \frac{1}{\lambda r} e^{ik(r-d)} \int_{A_{O}} E_{X}(\overline{P}, d) d\overline{P}, \qquad (B1)$$

where, as usual, A<sub>o</sub> refers essentially to that part of the scan area that covers the antenna aperture, and just the x-component of electric-field will be considered first.

Now if the amplitude of  $E_{\chi}(\overline{P},d)$  on opposite halves of the aperture (and thus  $A_0$ ) were equal and the phase difference exactly 180°, the field in the direction of the null axis would actually be zero. In reality the amplitudes are not exactly equal and the phase difference, even on the average, is not exactly 180°. Specifically, we can write  $E_{\chi}(\overline{P},d)$  as

$$E_{x}(\overline{P},d) = \begin{cases} i(\phi_{ox}^{\dagger}+kd) \\ (A_{x}^{\dagger}+\Delta A_{x}) e^{i(\phi_{ox}^{\dagger}+kd)} \\ i(\phi_{ox}^{\dagger}+kd+\Delta\psi_{x}) \\ -A_{x} e^{i(\phi_{ox}^{\dagger}+kd+\Delta\psi_{x})} \\ (over second half, A_{o2}) \end{cases}$$
(B2)

with  $\Delta A_{\chi}/A_{\chi}$  and  $\Delta \psi_{\chi}$  both << 1. For simplicity  $\phi_{OX}$  has been chosen constant, although it can be shown that the results do not change significantly if  $\phi_{OX}$  is allowed to vary slightly across  $A_{O}$ . Substitution of eq. (B2) into (B1) and approximating e by  $(1+i\Delta\psi_{\chi})$  yields

$$E_{x}^{null} = \frac{e^{i(kr+\phi_{ox})}}{\lambda r} \left[ \int_{A_{ol}} \Delta A_{x} d\overline{P} - \int_{A_{o2}} iA_{x} \Delta \psi_{x} d\overline{P} \right]$$
(B3)

for the field in the null direction. Experimentally, it has been found at the NBS that for many if not all antennas operating in a difference mode the first integral in (B3) predominates [17], but for the sake of the error analysis we must retain both integrals.

When longitudinal displacement errors ( $\Delta z$ ) are introduced, eq. (10) shows that eq. (B1) must be replaced by

$$E_{x}^{null'} = \frac{1}{\lambda r} e^{i(kr+\phi_{ox})} \int_{A_{o}} E_{x}(\overline{P}, d) e^{ik(\Delta z - \sin\theta e_{R} \cdot \overline{P})} d\overline{P}, \quad (B4)$$

where  $E_x^{null'}$  represents the null field computed from the actual nearfield data containing errors in the z-position of the scanner.  $\theta$  can no longer be set equal to zero because the error  $\Delta z$  may shift the angular position of the null axis. After substituting eq. (B2) into (B4), expanding the exponential in a power series, and discarding error terms higher than second order, eq. (B4) becomes,

$$|\mathbf{E}_{\mathbf{X}}^{\mathrm{null'}}| = \frac{\mathrm{e}^{\mathrm{i}(\mathrm{kr}+\phi_{0\mathbf{X}})}}{\lambda \mathrm{r}} \left( \int_{A_{01}} \Delta A_{\mathbf{X}} d\overline{P} - \int_{A_{02}} \mathrm{i}A_{\mathbf{X}} \Delta \psi_{\mathbf{X}} d\overline{P} \right)$$

$$+ \int_{A_{0}} (\pm A_{\mathbf{X}} + \Delta A_{\mathbf{X}}^{+}) \left( \mathrm{i} \mathrm{k} (\Delta z - \theta \, \widehat{\mathbf{e}}_{\mathrm{R}} \cdot \overline{P}) + \mathrm{k}^{2} \Delta z \theta \, \widehat{\mathbf{e}}_{\mathrm{R}} \cdot \overline{P} \right)$$

$$- \frac{(\mathrm{k} \Delta z)^{2}}{2} - \frac{(\mathrm{k} \theta \, \widehat{\mathbf{e}}_{\mathrm{R}} \cdot \overline{P})^{2}}{2} d\overline{P}$$

$$+ \mathrm{k} \int_{A_{02}} A_{\mathbf{X}} \Delta \psi_{\mathbf{X}} (\Delta z - \theta \, \widehat{\mathbf{e}}_{\mathrm{R}} \cdot \overline{P}) d\overline{P} , \qquad (B5)$$

with

 $\Delta A_{x}^{+} \equiv \begin{pmatrix} \Delta A_{x} & \text{in } A_{o1} \\ 0 & \text{in } A_{o2} \end{pmatrix}$ 

and the + and - sign before  $A_{\chi}$  being used in the areas  $A_{o1}$  and  $A_{o2}$  respectively.

The first order error term in eq. (B5) can be made zero by choosing  $\theta = \theta_s$  such that

$$\int_{A_{O}} (\pm A_{X} + \Delta A_{X}^{+}) \Delta z \ d\overline{P} = \theta_{S} \int_{A_{O}} (\pm A_{X} + \Delta A_{X}^{+}) (\hat{e}_{R} \cdot \overline{P}) \ d\overline{P}.$$
(B6)

 $\theta_{s}$  corresponds essentially to the shift in the direction of the null caused by longitudinal position errors. If we take the weighted average value of  $|\hat{e}_{R} \cdot \overline{P}|$  at about  $\ell^{max}/4$ , eq. (B6) implies that for most antennas

$$\frac{\theta_{s} \ell^{\max}}{4} \leq \Delta z_{\max}, \qquad (B7)$$

where  $l^{\max}$  denotes the maximum width of the antenna aperture. By defining  $\delta_{\max} = 2\pi\Delta z_{\max}/\lambda$ , eq. (B7) becomes approximately,

$$\theta_{s} \leq \frac{2\delta_{\max}\lambda}{\pi \ell^{\max}} = \frac{4\Delta z_{\max}}{\ell^{\max}}$$
(B8)

With the choice of  $\theta$  given by eq. (B6) the amplitude,  $|E_x^{\text{null}'} - E_x^{\text{null}}|$ , of the error field in the null direction may be written by subtracting eq. (B3) from eq. (B5),

$$|\mathbf{E}_{\mathbf{x}}^{\mathrm{null}'} - \mathbf{E}_{\mathbf{x}}^{\mathrm{null}}| \leq \frac{1}{\lambda \mathbf{r}} \left| \mathbf{k}^{2} \int_{A_{0}} \pm A_{\mathbf{x}} \left( \Delta z \theta_{s} \hat{\mathbf{e}}_{R} \cdot \overline{\mathbf{P}} - \frac{(\Delta z)^{2}}{2} - \frac{(\theta_{s} \hat{\mathbf{e}}_{R} \cdot \overline{\mathbf{P}})^{2}}{2} \right) d\overline{\mathbf{P}} + k \int_{A_{02}} A_{\mathbf{x}} \Delta \psi_{\mathbf{x}} (\Delta z - \theta_{s} \hat{\mathbf{e}}_{R} \cdot \overline{\mathbf{P}}) d\overline{\mathbf{P}} \right|.$$
(B9)

The first term in the first integral of eq. (B9) can be made zero by merely shifting the reference plane from which  $\Delta z$  is measured. The third term in the first integral is identically zero because it is an odd function over the scan area  $A_0$ . Thus eq. (B9) reduces to

$$|\mathbf{E}_{\mathbf{X}}^{\mathrm{null}'} - \mathbf{E}_{\mathbf{X}}^{\mathrm{null}}| \leq \frac{\mathbf{k}}{\lambda \mathbf{r}} \left| \int_{A_{02}} A_{\mathbf{X}} \Delta \psi_{\mathbf{X}} (\Delta z - \theta_{\mathbf{S}} | \overline{\mathbf{P}} |) d\overline{\mathbf{P}} + \frac{\mathbf{k}}{2} \int_{A_{0}} \pm A_{\mathbf{X}} (\Delta z)^{2} d\overline{\mathbf{P}} \right|.$$
(B10)

The second integral in eq. (B10) is also negligible if we assume the rms value of ( $\Delta z$ ) is approximately equal on the "positive" and "negative" sides of A<sub>0</sub>. Finally, since the maximum value of  $\theta_s$  is  $2\delta_{max} \lambda/\pi \ell^{max}$  eq. (B10) becomes

$$|E_{x}^{null'} - E_{x}^{null}| \leq \frac{k \delta_{max} \lambda}{\lambda r \ell^{max}} \left| \int_{A_{o2}} A_{x} \Delta \psi_{x} |\overline{P}| d\overline{P} \right| \simeq \frac{\delta_{max} \Delta \psi_{x}^{ave}}{\lambda r} \int_{A_{o2}} A_{x} d\overline{P},$$
(B11)

with  $\Delta \psi_X^{\text{ave}}$  denoting the average phase difference from  $\pi$  radians of the probe output between the positive and negative sides of the partial scan area which is perpendicular to the null axis.

The factor  $\frac{1}{\lambda r} \int_{A_{02}} A_x d\overline{P}$  is approximately equal to the maximum field in the mainbeams of the difference pattern. And since an expression analagous to eq. (B11) holds for the y-component of the field, we can write the fractional error  $\eta(\overline{r})$  near the null of a difference pattern as

$$\eta(\bar{r}) \leq \delta_{\max} \Delta \psi_{ave} g(\bar{r}), \qquad (B12a)$$

where, as in the main text,  $g(\overline{r})$  is the ratio of the amplitude of the maximum far-electric-field to the far-electric-field at the given direction  $\overline{r}$ . Here  $\overline{r}$  is essentially the direction of the null axis and thus  $g(\overline{r})$  the ratio of maximum far-field to null axis far-field.

Now eq. (B12) is a very simple expression. However, the average phase difference  $\Delta \psi_{ave}$  of the probe output may be a difficult

quantity to estimate accurately from the near-field phase data. Fortunately, it can be shown that  $\Delta \psi_{ave}$  is related to the relative size of the two mainlobes in the far-field of the difference pattern. Specifically, a straightforward but rather lengthy manipulation (which will not be shown here) of the near-field of a difference pattern reveals that  $\Delta \psi_{ave}$  can be approximated by

$$\frac{\Delta \psi_{ave}}{ave} \simeq 4 \Delta F$$

where  $\Delta F$  is the fractional difference between the amplitude of the two main far-field lobes of the difference pattern. For example, if the amplitude of one mainlobe is 10 on some linear scale and the amplitude of the other mainlobe is 10.1 then  $\Delta F$  would equal (10.1-10)/10 or .01. Equation (B12a) can now be written in the alternative form

$$\eta(\overline{r}) \leq 4\delta_{\max} \Delta F g(\overline{r}).$$
 (B12b)

## 2. Instrumentation Errors

The inaccuracies in measuring near-field phase have the same effect on the null-depth as the longitudinal position errors. That is,  $\Delta \phi_{\text{max}}^{I}$ , the maximum instrumentation error in measuring phase, simply replaces  $\delta_{\text{max}}$  in eqs. (B8) and (B12).

The inaccuracies in measuring amplitude affect the null depth differently, however, than the transverse position errors because the nonlinearities in the instrumentation distort the amplitude on each side of the difference pattern in nearly the same way and thus their effect on the null depth is much smaller than might first be expected. Specifically, errors in measuring amplitude show up in the null depth through distortion of only the  $\Delta A$  part (see eq. (B2)) of the near field. Carrying through an analysis similar to that performed above for z-position errors yields the following expression for the maximum change  $\Delta E_A^{null}$  in null electric field caused by amplitude errors:

$$|\Delta E_{A}^{null}| \leq \frac{N_{dB}^{I}}{\lambda r} \int_{A_{ol}} (\Delta A_{max} - |\Delta A|) dP \leq \frac{N_{dB}^{I} \Delta A_{max} A_{ol}}{\lambda r}, \quad (B13)$$

where  $\Delta A_{max}$  is the maximum of  $\Delta A$  across  $A_{o1}$  and  $N_{dB}^{I}$  is the maximum instrumentation error in measuring the amplitude of the probe output (see Section III.B.2). If we approximate  $|E_A^{null}|$ , the x-component of which is given in eq. (B3), by  $\frac{\Delta A_{max}A_{o1}}{2\lambda r}$ , then the fractional error in null depth caused by instrumentation errors in measuring amplitude can be written

$$\eta = \frac{|\Delta E|}{|E^{null}|} \leq 2N_{dB}^{I}.$$
(B14)

Note that the instrumentation amplitude error in null depth does not depend on the null depth itself. In addition, it can be shown that, unlike phase errors, the instrumentation amplitude errors have negligible effect on the angular position of the null direction.

## References

- <u>IEEE Standard Definitions of Terms for Antennas</u>, IEEE Transactions on Antennas and Propagation, <u>AP-22</u>, 1 (January 1974).
- [2] DeSize, L.K. and J.F. Ramsay, in <u>Microwave Scanning Antennas</u>,
   Ed. R.C. Hansen, Academic Press--New York, London (1964), Vol. 1,
   Ch. 2-II.B.
- [3] Kerns, D.M., "Correction of Near-Field Antenna Measurements Made with an Arbitrary But Known Measuring Antenna," Electronics Letters, 6, 11, pp. 346-347 (28th May 1970).
- [4] See e.g. Jackson, J.D., <u>Classical Electrodynamics</u>, John Wiley & Sons Inc., New York, London (1962), Section 9.6.
- [5]a Braunbek, W., "Zur Beugung an der Kreisscheibe," Zeitschrift Für Physik, <u>127</u>, pp. 405-415 (1950).
  - b Ufimtsev, P.Ia., "Approximate Computation of the Diffraction of Plane Electromagnetic Waves at Certain Metal Bodies," Soviet Physics--Technical Physics, <u>2</u>, 8, pp. 1708-1718 (August 1957).
- [6]a Keller, J.B., "Diffraction by an Aperture," Journal of Applied Physics, 28, 4, pp. 426-444 (April 1957).
  - b Keller, J.B., "Geometrical Theory of Diffraction," Journal of the Optical Society of America, <u>52</u>, 2, pp. 116-130 (February 1962).
- [7] Van Kampen, N.G., "An Asymptotic Treatment of Diffraction Problems," Physica, 14, 9, pp. 575-589 (January 1949).
- [8] Keller, J.B., R.M. Lewis, and B.D. Seckler, "Diffraction by an Aperture II," Journal of Applied Physics, <u>28</u>, 5, pp. 570-579 (May 1957).
- [9]a Kouyoumjian, R.G., and P.H. Pathak, "A Uniform Geometrical Theory of Diffraction for an Edge in a Perfectly Conducting Surface," Proceedings of the IEEE, <u>62</u>, 11, pp. 1448-1461 (November 1974).
  - b Hwang, Y.M. and R. G. Kouyoumjian, "A Dyadic Coefficient for an Electromagnetic Wave Which is Rapidly-Varying at an Edge," URSI 1974 Annual Meeting, Boulder, Colorado.
- [10] See e.g., Born M., and E. Wolf, <u>Principles of Optics</u>, Pergamon Press, Oxford, New York (1970), 4th Ed., Appendix III.

- [11] Newell, A.C. and M.L. Crawford, "Planar Near-Field Measurements on High Performance Array Antennas," NBSIR 74-380, National Bureau of Standards, Boulder, Colorado (July 1974).
- [12] Kraus, J.D., <u>Antennas</u>, McGraw-Hill, Inc., New York, Toronto, London (1950), Chs. 3 and 12.
- [13] Hansen, R.C., (Ch. 1, Sect. 2-I in ref [2]): A<sub>e</sub>/A = G/G<sub>o</sub> in Table IX, p. 66.
- [14] Rusch, W.V.T. and P.D. Potter, <u>Analysis of Reflector Antennas</u>, Academic Press, New York - London (1970), Section 2.52.
- [15] Ruze, John, "Antenna Tolerance Theory -- A Review," Proceedings IEEE, 54, 4, pp. 633-640 (April 1966).
- [16] Rodrigue, G.P., E.B. Joy, and C.P. Burns, <u>An Investigation of the Accuracy of Far-Field Radiation Patterns Determined from Near-Field Measurements</u>, Report -- Georgia Institute of Technology, Atlanta, Georgia (August 1973).
- [17] Newell, A.C., private communication, National Bureau of Standards, Boulder, Colorado.
- [18] Kerns, D.M., "Scattering-Matrix Description and Near-Field Measurements of Electroacoustic Transducers," The Journal of the Acoustical Society of America, <u>57</u>, 2, pp. 497-507 (February 1975).
- [19] Schoch, V.A., "Betrachtungen über das Schallfeld einer Kolbenmembran," Akustische Zeitschrift, 6, pp. 318-326 (1941).
- [20] Crawford, M.L., A.C. Newell, J.W. Greene, and A.D. Yaghjian, "Experimental Design Study for a Near-Field Broadbeam Antenna Pattern Calibrator," AFAL-TR-75-179, Air Force Avionics Lab., Wright-Patterson Air Force Base, Ohio 45433 (to be published).
- [21] Newell, A.C., "Planar Near-Field Measurement Techniques on High Performance Arrays -- Part II," Air Force Technical Report, Air Force Avionics Laboratory -- Wright Patterson Air Force Base, Ohio (to be published).
- [22] Newell, A.C., R.C. Baird, and P.F. Wacker, "Accurate Measurement of Antenna Gain and Polarization at Reduced Distances by an Extrapolation Technique," IEEE Transactions on Antenna and Propagation, AP-21, 4, pp. 418-431 (July 1973).

- [23] Kanda, M., "Accuracy Considerations in the Measurement of the Power Gain of a Large Microwave Antenna," IEEE Transactions on Antennas and Propagation, AP-23, 3, pp. 407-411 (May 1975).
- [24] Appel-Hansen, J., "Reflectivity Level of Radio Anechoic Chambers," IEEE Transactions on Antennas and Propagation, <u>AP-21</u>, pp. 490-498 (July 1973).
- [25] Jensen, Frank, "Electromagnetic near-field-far-field correlations," Ph.D. Dissertation, Technical University of Denmark, Lyngby, Denmark (July 1970).

## ACKNOWLEDGMENT

The author is grateful to Allen C. Newell for his invaluable consultation throughout the preparation of this report. Much appreciation is extended to John W. Greene and Douglas P. Kremer for the information they provided about the NBS near-field scanning facilities. Mark T. Ma and Carl F. Stubenrauch of the Department of Commerce, and Kenneth Grimm of the Air Force Avionics Laboratory contributed many helpful suggestions in reviewing the report. Many thanks also go to Janet R. Jasa for carefully and patiently typing the manuscript.

U.S. DEPT. OF COMM. BIBLIOGRAPHIC DATA SHEET	1. PUBLICATION OR REPORT NO. NBS Tech Note 667	2. Gov't Accession No.	3. Recipient'	s Accession No.					
4. TITLE AND SUBTITLE			5. Publication	n Date					
Upper-Bound Errors in Far-Field Antenna Parameters			Octob	er 1975					
Determined from Planar Near-Field Measurements, Part I: Analysis			A Declarity						
			<b>o.</b> Performing	Organization Code					
			276.0	5					
7. AUTHOR(S) Arthur D. Yaghjian			8. Performing TN-66	Organ. Report No. 7					
9. PERFORMING ORGANIZATION NAME AND ADDRESS			10. Project/Task/Work Unit No. 2765276						
DEPARTMENT OF COMMERCE WASHINGTON, D.C. 20234				Grant No.					
12. Sponsoring Organization Name and Complete Address (Street, City, State, ZIP) Air Force Avionics Laboratory			13. Type of R Covered	eport & Period					
Air Force Wright Aeronautical Laboratories			7/73	- 7/74					
Air Force Systems Command			14. Sponsorin	g Agency Code					
Wright-Patterso	n Air Force Base, Ohio	45433							
15. SUPPLEMENTARY NOTES									
16. ABSTRACT (A 200-word or less factual summary of most significant information. If document includes a significant									
bibliography or literature survey, mention it here.)									
General expressions are derived for estimating the errors in the									
sum or difference far-field pattern of electrically large aperture									
antennas which are measured by the planar near-field scanning tech-									
nique. Upper bounds are determined for the far-field errors produced by 1) the nonzero fields outside the finite scan area, 2) the inac- curacies in the positioning of the probe, 3) the distortion and non-									
					linearities of the instrumentation which measures the amplitude and				
					phase of the probe output, and 4) the multiple reflections. Computa-				
tional errors, uncertainties in the receiving characteristics of the									
probe, and errors involved with measuring the input power to the test									
antenna are briefly discussed.									
17. KEY WORDS (six to twelve entries; alphabetical order; capitalize only the first letter of the first key word unless a proper									
name; separated by semicolons)									
Antennas; error analysis; far field pattern; near-field measurements; planar scanning; planewave spectrum.									
	X Unlimited	19. SECURIT	Y CLASS	21. NO. OF PAGES					
IO, AVAILADILITT	A Omminded	(THIS RE	PORT)						
For Official Distributio	on. Do Not Release to NTIS			100					
	in 50 not nelease to n no	UNCL ASS	IFIED	120					
X Order From Sup. of Doc	., U.S. Government Printing Office	20. SECURIT	Y CLASS	22. Price					
Washington, D.C. 2040	2, SD Cat. No. C13. 66:66/	(THIS PA	GE)	¢7 05					
Order From National T Springfield, Virginia 23	echnical Information Service (NTIS) 2151	UNCLASS	IFIED	\$1.85					

☆ U.S. GOVERNMENT PRINTING OFFICE: 1975 - 677-347 / 1226 REGION NO. 8

#### PERIODICALS

JOURNAL OF RESEARCH reports National Bureau of Standards research and development in physics, mathematics, and chemistry. It is published in two sections, available separately:

#### • Physics and Chemistry (Section A)

Papers of interest primarily to scientists working in these fields. This section covers a broad range of physical and chemical research, with major emphasis on standards of physical measurement, fundamental constants, and properties of matter. Issued six times a year. Annual subscription: Domestic, \$17.00; Foreign, \$21.25.

#### • Mathematical Sciences (Section B)

Studies and compilations designed mainly for the mathematician and theoretical physicist. Topics in mathematical statistics, theory of experiment design, numerical analysis, theoretical physics and chemistry, logical design and programming of computers and computer systems. Short numerical tables. Issued quarterly. Annual subscription: Domestic, \$9.00; Foreign, \$11.25.

DIMENSIONS/NBS (formerly Technical News Bulletin)—This monthly magazine is published to inform scientists, engineers, businessmen, industry, teachers, students, and consumers of the latest advances in science and technology, with primary emphasis on the work at NBS. The magazine highlights and reviews such issues as energy research, fire protection, building technology, metric conversion, pollution abatement, health and safety, and consumer product performance. In addition, it reports the results of Bureau programs in measurement standards and techniques, properties of matter and materials, engineering standards and services, instrumentation, and automatic data processing.

Annual subscription: Domestic, \$9.45; Foreign, \$11.85.

#### NONPERIODICALS

Monographs—Major contributions to the technical literature on various subjects related to the Bureau's scientific and technical activities.

Handbooks—Recommended codes of engineering and industrial practice (including safety codes) developed in cooperation with interested industries, professional organizations, and regulatory bodies.

Special Publications—Include proceedings of conferences sponsored by NBS, NBS annual reports, and other special publications appropriate to this grouping such as wall charts, pocket cards, and bibliographies.

Applied Mathematics Series—Mathematical tables, manuals, and studies of special interest to physicists, engineers, chemists, biologists, mathematicians, computer programmers, and others engaged in scientific and technical work.

National Standard Reference Data Series—Provides quantitative data on the physical and chemical properties of materials, compiled from the world's literature and critically evaluated. Developed under a world-wide program coordinated by NBS. Program under authority of National Standard Data Act (Public Law 90-396).

NOTE: At present the principal publication outlet for these data is the Journal of Physical and Chemical Reference Data (JPCRD) published quarterly for NBS by the American Chemical Society (ACS) and the American Institute of Physics (AIP). Subscriptions, reprints, and supplements available from ACS, 1155 Sixteenth St. N. W., Wash. D. C. 20056.

Building Science Series—Disseminates technical information developed at the Bureau on building materials, components, systems, and whole structures. The series presents research results, test methods, and performance criteria related to the structural and environmental functions and the durability and safety characteristics of building elements and systems.

Technical Notes—Studies or reports which are complete in themselves but restrictive in their treatment of a subject. Analogous to monographs but not so comprehensive in scope or definitive in treatment of the subject area. Often serve as a vehicle for final reports of work performed at NBS under the sponsorship of other government agencies.

Voluntary Product Standards—Developed under procedures published by the Department of Commerce in Part 10, Title 15, of the Code of Federal Regulations. The purpose of the standards is to establish nationally recognized requirements for products, and to provide all concerned interests with a basis for common understanding of the characteristics of the products. NBS administers this program as a supplement to the activities of the private sector standardizing organizations.

Federal Information Processing Standards Publications (FIPS PUBS)—Publications in this series collectively constitute the Federal Information Processing Standards Register. Register serves as the official source of information in the Federal Government regarding standards issued by NBS pursuant to the Federal Property and Administrative Services Act of 1949 as amended, Public Law 89-306 (79 Stat. 1127), and as implemented by Executive Order 11717 (38 FR 12315, dated May 11, 1973) and Part 6 of Title 15 CFR (Code of Federal Regulations).

Consumer Information Series—Practical information, based on NBS research and experience, covering areas of interest to the consumer. Easily understandable language and illustrations provide useful background knowledge for shopping in today's technological marketplace.

NBS Interagency Reports (NBSIR)—A special series of interim or final reports on work performed by NBS for outside sponsors (both government and non-government). In general, initial distribution is handled by the sponsor; public distribution is by the National Technical Information Service (Springfield, Va. 22161) in paper copy or microfiche form.

Order NBS publications (except NBSIR's and Bibliographic Subscription Services) from: Superintendent of Documents, Government Printing Office, Washington, D.C. 20402.

#### **BIBLIOGRAPHIC SUBSCRIPTION SERVICES**

The following current-awareness and literature-survey bibliographies are issued periodically by the Bureau: Cryogenic Data Center Current Awareness Service

A literature survey issued biweekly. Annual subscription: Domestic, \$20.00; foreign, \$25.00.

Liquefied Natural Gas. A literature survey issued quarterly. Annual subscription: \$20.00.

Superconducting Devices and Materials. A literature

survey issued quarterly. Annual subscription: \$20.00. Send subscription orders and remittances for the preceding bibliographic services to National Technical Information Service, Springfield, Va. 22161.

Electromagnetic Metrology Current Awareness Service Issued monthly. Annual subscription: \$100.00 (Special rates for multi-subscriptions). Send subscription order and remittance to Electromagnetics Division, National Bureau of Standards, Boulder, Colo. 80302.

# U.S. OEPARTMENT OF COMMERCE National Bureau of Standards Washington, D.C. 20234

OFFICIAL BUSINESS

Penalty for Private Use, \$300

POSTAGE AND FEES PAID U.S. DEPARTMENT OF COMMERCE COM-215



FOURTH CLASS MAIL

